

Structural characterization of epitaxial graphene

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Resumen

El estudio de grafeno crecido epitaxialmente sobre substratos monocristalinos tiene una doble relevancia: por un lado desde un punto de vista puramente técnico e industrial y por el otro desde el meramente científico. Existen diferentes substratos adecuados para el crecimiento de láminas de grafeno de alta pureza con vistas a futuras aplicaciones prácticas. Estas aplicaciones abarcan desde membranas para desalinizar el agua hasta electrodos transparentes para pantallas táctiles o transistores de alta frecuencia.

Entre los substratos propuestos, podríamos diferenciar dos subclases: los substratos metálicos y el carburo de silicio. En la presente tesis hemos estudiado ambos casos mediante técnicas avanzadas de caracterización superficial. Para ello ha sido necesario el uso de campanas de ultra alto vacio (UHV, por sus siglas en inglés) donde las muestras monocristalinas una vez preparadas pueden mantener su superficie libre de contaminantes durante un tiempo suficiente como para realizar los experimentos y así poder crecer las capas de grafeno sin injerencias de contaminación involuntarias. El UHV también es un requisito necesario para la mayoría de las técnicas de caracterización utilizadas, tanto técnicas de microscopía de efecto túnel de alta resolución (STM, del inglés) como de espectroscopía de fotoemisión. Los resultados experimentales han sido confrontados con simulaciones de primeros principios mediante el uso del funcional de la densidad electrónica (DFT de las siglas en inglés).

Grafeno sobre Pt(111). En esta tesis hemos elegido como representante de los substratos metálicos la superficie hexagonal (111) de platino. Sobre ella hemos depositado diferentes precursores moleculares (moléculas ricas en carbón cuya descomposición resulta en grafeno) para el crecimiento epitaxial de las capas grafénicas. Como precursores hemos usado tanto pequeños hidrocarburos como grandes moléculas policíclicas aromáticas. Su deposición y posterior calentamiento a altas temperaturas (típicamente >1100K) da lugar al crecimiento capas de grafeno policristalino donde coexisten diferentes ángulos entre el grafeno y el substrato. Estos dominios rotacionales forman interferencias electrónicas con el substrato, los llamados, patrones de Moiré. Se ha abordado el estudio de qué rotaciones permitidas sobre el Pt(111) mediante una combinación de medidas de STM y el desarrollo de un modelo fenomenológico que se basa en la búsqueda

de las mejores coincidencias entre posiciones atómicas de substrato y grafeno para todos los ángulos.

El modelo predice que existen 22 ángulos preferentes que forman 15 Moirés distintos y distinguibles, asimismo el modelo obtiene para cada ángulo de rotación el ángulo aparente del Moiré resultante – esto es la orientación relativa de la superestructura respecto al substrato- así como su periodicidad. Estos resultados coinciden con las medidas realizadas mediante STM y con las estructuras reportadas en la literatura. De entre todos los posible Moirés hemos estudiado mediante una combinación de imágenes de resolución atómica y simulaciones de DFT las dos estructuras que involucran un menor número de átomos, llamadas (v3Xv3)R30° y (v7Xv7)R19° debido a su conmensuración con el substrato.

Para investigar los mecanismos fundamentales que inducen la aparición de un numero finito de posibles Moirés hemos realizado un estudio extensivo de las regiones de enlace entre las islas de grafeno y los escalones de Pt(111). Estas intercaras forman estructuras 1-dimensionales donde los últimos átomos de carbono pertenecientes al grafeno se enlazan químicamente con los átomos de Pt mas exteriores de los escalones monoatómicos del Pt(111). Nuestro análisis sugiere que estas regiones de enlace son uno de los factores que determinan la orientación de las islas de grafeno.

Hemos realizado un estudio detallado de una de estas intercaras, más concretamente la heteroestructura formada entre grafeno con Moiré (V7XV7)R19° y escalón monoatómico de Pt(111), para entender en profundidad los mecanismos que aparecen en este tipo de bordes. La comparación entre resultados experimentales y teóricos perfila para esta precisa estructura un escenario donde el grueso del estrés es absorbido en la mitad del Pt mediante la inducción de una compleja reconstrucción cristalina que sitúa algunos de los átomos de Pt muy lejos de sus posiciones "originales". Sorprendentemente en conjunción con esta reconstrucción también aparecen unos estados electrónicos en el lado del grafeno que se ven constreñidos a una, y solo una, de las dos subredes del grafeno.

Por último, y para finalizar con el estudio de las estructuras de grafeno que aparecen en la superficie de Pt(111) hemos realizado un inventario de todos los defectos que hemos ido encontrando en nuestras sesiones de STM. Este estudio no entra en detalle y pretende servir de "bestiario"

descriptivo desde un punto de vista experimental para futuras investigaciones.

Grafeno sobre SiC(0001). Independientemente de todos estos trabajos, hemos estudiado las propiedades estructurales de las posibles reconstrucciones que aparecen en SiC(0001). Diferentes estructuras superficiales aparecen cuando calentamos este material a altas temperaturas. Una vez las muestras son calentadas a >1500K obtenemos una superficie rica en carbono organizado en hibridación sp². Calentamientos a temperaturas más altas inducen la aparición de multicapas (bicapa, tricapa...). En la presente tesis se ha realizado una caracterización exhaustiva del grafeno epitaxialmente crecido sobre SiC(0001).

El grafeno crecido de esta manera presenta propiedades muy similares de aquellas que presentan las muestras exfoliadas de grafito. Esto es una indicación directa de que la interacción del grafeno con el substrato es muy baja. Por este motivo G/SiC(0001) supone un excelente banco de pruebas para racionalizar las interacciones a escala atómica de distintos adsorbatos depositados sobre grafeno y entender las contribuciones debidas a la interacción entre moléculas discriminándolas de la interacción entre adsorbato y substrato. Normalmente la competición entre las interacciones intermoleculares y la interacción van der Waals substrato-adsorbato dirige la dinámica molecular, pero a veces la interacción con el substrato es más fuerte llegando a darse el caso de quimisorción de adsorbatos simples. En estos casos la hibridación de los átomos de carbono del substrato pasa de ser sp² a sp³.

En la presente tesis hemos estudiado mediante técnicas de caracterización superficial y cálculos de primeros principios la adsorción e interacción de adsorbatos modelo con diferente fuerza de interacción adsorbato-substrato. Para ello hemos utilizado sistemas sencillos que expresan independientemente la naturaleza de su interacción. Por un lado hemos estudiado las débilmente unidas moléculas de C₆₀ y por el otro los covalentemente unidos átomos de hidrógeno.

Nuestros resultados demuestran que C₆₀/G/SiC(0001) forma islas ordenadas exclusivamente unidas por interacciones van der Waals donde la interacción entre moléculas juega un rol primordial, mientras que el H/G/SiC(0001) quimisorbe encima de los átomos de carbono formando dímeros, trímeros y pequeños clústeres bidimensionales cuya configuración

geométrica está determinada por la red de panal de abejas del substrato. La comparación entre estos dos sistemas ideales revela que la interacción de los adsorbatos sobre grafeno puede ser tuneada en un amplio rango de intensidades desde una atracción mínima hasta un enlace sólido.

SiC en astroquímica. Por último, cabe señalar la motivación original de la presente tesis. Esta tesis surgió como una idea interdisciplinar del Centro de Astrobiología para emplear métodos y técnicas de física de superficies para entender problemas de astroquímica. Así, se trata de de combinar los conocimientos del grupo de investigación ESISNA con los del grupo del Prof. J. Cernicharo para estudiar la formación de moléculas policíclicas aromáticas (PAHs por sus siglas en inglés) en el espacio, más concretamente en el medio circumestelar e interestelar. Las regiones circumestelares de estrellas rojas masivas ricas en carbono son abundantes en granos de polvo de carburo de silicio (SiC). Esto se ha podido detallar mediante espectroscopía rotacional y vibracional usando telescopios terrestres y espaciales. Por otra parte, estas observaciones han revelado un medio interestelar rico en química en fase gas de atmósferas enrarecidas donde moléculas sencillas, tales como el H₂, CO, C₂H₂, HCN... y moléculas sorprendentemente complejas como la glicina (CH₂NH₂COOH), uno de los aminoácidos presentes en nuestros organismos, pueden ser detectadas mediantes este tipo de técnicas observacionales.

Uno de los grandes problemas abiertos en la astroquímica moderna es la extraordinariamente alta abundancia de PAHs. Este tipo de moléculas es considerado responsable de la aparición en los espectros infrarrojos de unas bandas difíciles de identificar de longitudes de onda entre 3 y 25 μ m. La abundancia relativa de PAHs no puede ser explicada mediante las teorías actuales (tales como la polimerización acetilénica) debido a la baja frecuencia de colisión en las atmósferas interestelares entre las partículas constituyentes. Nuevos mecanismos de formación de PAHs interestelares son, por lo tanto, necesarios para poder explicar su relativamente alta tasa de presencia.

En la presente tesis proponemos una nueva vía de formación de PAHs basada en la descomposición de las capas de grafeno epitaxial sobre los granos de polvo interestelar de SiC. Los granos de SiC se forman cerca de la fotosfera de las estrellas y se grafitizan debido a las altas temperaturas ocurrentes en estas regiones del espacio. La presencia de hidrógeno atómico -disociado del molecular mediante procesos térmicos y de fotodisociación ultravioleta- en esas regiones induce una corrosión superficial en las superficies de SiC que produce PAHs de distintos tamaños que posteriormente son eyectados a la fase gas. Todos los pasos de este proceso pueden ser reproducidos en ambientes controlados en tierra mediante campanas de UHV y pueden ser caracterizados mediante técnicas provenientes de la rama de física del estado sólido. Estos resultados abren nuevas líneas de investigación en la síntesis de PAHs y demuestran que determinados problemas de la astroquímica pueden ser abordados desde una metodología de ciencia de superficies.

Abstract

The studies of epitaxially grown graphene on monocrystalline substrates possess a double relevance: first from a purely technical and industrial point of view and second from a merely scientific one. There are several substrates suitable to grow high purity graphene sheets for future practical applications. These applications range from membranes to desalinate water, transparent electrodes for touchscreens or high-frequency transistors.

The mostly used substrates can be divided in two main subclasses: metal surfaces and silicon carbide. In this thesis we have studied both systems using advanced surface characterization techniques. This is why the use of ultra high vacuum chambers (UHV) has been necessary, once single crystal samples are prepared, UHV keeps its surface free of contaminants during a time large enough to grow the graphene layers without interference from unintentional contamination. The UHV is also required for most characterization techniques used in this thesis, such as high resolution scanning tunneling microscopy (STM) and photoemission spectroscopy. These experimental results have been confronted with first-principles simulations using the density functional theory (DFT).

Graphene on Pt(111). In this thesis we have chosen as representative of the metal substrates the hexagonal surface (111) of Pt, on which different precursors (i.e. carbon rich molecules whose decomposition results in graphene) have been deposited in order to grow epitaxial layers. We have used both, small hydrocarbons and large polycyclic aromatic molecules for this purpose. Deposition and subsequent heating at elevated temperatures (>1100K) of these precursors typically produces polycrystalline graphene where different angles between the substrate and graphene coexist. These rotational domains produce electronic interferences with the substrate and form the, so-called Moiré patterns. The problem of which rotations are permitted in the G/Pt(111) system has been addressed in this thesis by a combination of STM images and the use of an original phenomenological model based on the search of the best coincident atomic positions between substrate and graphene for every angle.

The model predicts the existence of 22 preferred angles but only 15 distinguishable Moirés. The model also obtains for every rotation angle the

resulting Moiré apparent angle - this is the relative orientation between the superstructure and the substrate- and the periodicity. These results are consistent with the STM measurements and with the structures reported in the literature. Among all the possible Moirés, we have characterized through a combination of atomic-resolution images and DFT simulations the two structures involving fewer number of atoms , namely ($\sqrt{3}\times\sqrt{3}$)R30° and ($\sqrt{7}\times\sqrt{7}$) R19° (according to their commensuration with the substrate).

To investigate the fundamental mechanisms leading to a finite number of stable Moirés we have made an extensive study of the binding regions between graphene islands and the Pt(111) steps. These interfaces consist of one-dimensional structures where the last carbon atoms belonging to graphene chemically bond with the outermost Pt atoms in the monatomic steps of Pt(111). Our analysis suggests that these binding regions are one of the driving factors determining the orientation of the graphene islands.

We conducted a detailed study of these interfaces, and among them, specifically the heterostructure formed between (V7XV7)R19° Moiré and a monatomic Pt (111) step, so we can understand in depth the driving mechanisms appearing in these edges. The comparison between experimental and theoretical results for this precise structure depicts a scenario where most stress is relaxed at the Pt side by inducing a complex crystalline 1D reconstruction that moves some of the Pt atoms far from their "original" positions. Surprisingly, in conjunction with this reconstruction exotic electronic states also appear on the graphene side. These states are constrained to only one of the two sublattices of graphene.

Finally, we finish the study of graphene structures on Pt(111) with an inventory of all the defective structures found during our STM sessions. This study is not as detailed as the previous ones and is intended to serve as a descriptive "bestiary" from an experimental point of view.

Graphene on SiC(0001). We studied the structural properties of all the possible reconstructions appearing on the SiC(0001) surface. Different surface structures appear when heating this material at high temperatures. Once the samples are heated to >1500K we obtain a carbon-rich surface organized in sp² hybridization. Annealing at higher temperatures induces the appearance of multilayer (bilayer, trilayer...). In this thesis we have performed a comprehensive characterization of epitaxial graphene grown on SiC(0001).

Graphene grown with this methodology exhibits properties very similar to those of exfoliated samples. This is a direct indication that graphene-SiC interaction is very faint. For this reason G/SiC(0001) seems an excellent testbed where to rationalize the atomic-scale interactions of adsorbates deposited on graphene and for understanding the different contributions arising from the intermolecular and the adsorbate-substrate interactions.

Typically, competition between intermolecular and van der Waals substrate-adsorbate interactions drives the molecular surface structures. However sometimes the interaction with the substrate can be much stronger and some simple adsorbates chemisorb on top of carbon atoms in the graphene lattice. In these cases, hybridization of the carbon atoms within graphene changes from sp^2 to sp^3 .

In this thesis we have studied the interaction of adsorbates with graphene by means of surface characterization techniques combined with firstprinciples calculations. We have used simple model systems that represent different strength in its interaction with the substrate. On one side we have studied the weakly interacting C_{60} molecules and on the other covalently bonded hydrogen atoms.

Our results show that $C_{60}/G/SiC$ forms ordered layers exclusively bound by van der Waals interactions and where intermolecular interactions play an important role. Differently, H/G/SiC chemisorbs on top of the C atoms of graphene forming dimers, trimers and small clusters with geometrical configurations confined by the honeycomb lattice of the substrate. The comparison between these two ideal systems reveals that the adsorbate-graphene interaction can be tuned over a wide range of intensities from a weak physisorption to a strong chemisorption.

Astrochemistry and SiC. Finally, it should be noted that the original motivation of this thesis was a surface description of the processes occurring in some regions of the interstellar and circumstellar space. This thesis emerges as an interdisciplinary collaboration in the *Centro de Astrobiología* that uses the techniques and methodologies of surface science for understanding of astrochemical problems. In this direction we have put together the efforts of the ESISNA and Prof. J. Cernicharo research groups to investigate the synthesis of polycyclic aromatic hydrocarbons (PAHs) in the space, more precisely in the circumstellar and interstellar regions. Circumstellar regions near carbon-rich red stars contain silicon carbide (SiC) dust grains. This has been observed by rotational and

vibrational infrared spectroscopy using ground and space-based telescopes. On the other side, these observations revealed an interstellar medium rich in gas phase chemistry where simple molecules such as H_2 , CO, C_2H_2 , and HCN ... are found together with amazingly complex molecules such as glycine (CH₂NH₂COOH), one of the amino acids present in our bodies.

One of the major problems in modern astrochemistry is the unusually high abundance of PAHs. These molecules are considered responsible for the appearance in the infrared spectra of bands with wavelengths between 3 and 25 microns. PAHs relative abundance cannot be explained by current theories (such as acetylene polymerization) owing to the low collision frequency in interstellar atmospheres. Finding new mechanisms of interstellar PAHs formation is necessary in order to explain the relatively high abundance.

In this thesis we propose a new PAHs formation mechanism from our experimental observations on epitaxial graphene hydrogen etching. SiC grains form near the photosphere of the star and graphitize due to the high temperatures occurring in these regions of space. The presence of atomic hydrogen – dissociated through thermal and ultraviolet photodissociation-in those regions induces corrosion on the SiC surfaces and produces PAHs of different sizes which are subsequently ejected into the gas phase. All the steps of this process can be reproduced in controlled environments with UHV chambers and can be characterized using solid state physics techniques. These results open new research lines in the PAHs synthesis and show that certain astrochemistry problems can be addressed from a surface science methodology.

Introduction and motivation

Nanotechnology, towards a controlled synthesis of new carbon structures

"There's plenty of room at the bottom"

R. Feynman. December 29, 1959.

In 1959 Prof. Feynman used this sentence during a famous lecture in California to describe the real possibility of reducing the size of the computer circuitry down to its atomic limits. In his talk he speculated with performing atomic scale designed structures. He foresaw the possibility of using advanced methodologies for manipulating individual atoms as a source of performing synthetic chemistry. He even imagined the possible clinical applications of tiny functionalized nanoparticles inside the body for health treatments. This talk is considered to be one of the earliest discussions about modern nanotechnology concepts. For the first time, the human beings considered the idea of manipulating the matter that surrounds us with atomic precision. These concepts were first pronounced as a dream. Nowadays, although still limited, they have become a real possibility opening an immense field of atomically controlled designs with new and stunning properties. Today Si-based transistors are reaching its fundamental limitations as lithography techniques improve and single atoms (and molecules) are routinely controlled on top of particular atomically precise surfaces in laboratories around the world. The simplest approach for producing these new nanostructures would be to fabricate them in a top-down approach, as we produce most of the goods that we use in our everyday life (for example, computers). We can think of starting with a macroscopic piece and *sculpting* it down, ideally down to the atomic scale, and later *mount* them together with others on a *nano-assembly-line*.

However, the most fascinating nanostructures that have ever been considered are not designed on purpose by humans but they appeared spontaneously on Earth. Living beings are the result of the sum of atomically precise nanometer scale structures (from DNA to peptides and proteins) that are almost exclusively formed by only four elements –carbon, hydrogen, oxygen, nitrogen: CHON. Human beings, for example, are mainly made of carbon (18%), hydrogen (10%), oxygen (65 %) and nitrogen (3%). These structures are the result of a bottom-up process of self assembly that

naturally appeared on the surface of the Earth around 4 billion years ago. This strategy has proven to be very versatile for creating a vast inventory of macromolecules with different complex functionalities. If nature itself is capable of creating life out from "mud" just by a trial and error methodology, let us imagine what could be done by taking advantage of the knowledge of the bottom-up processes of biology but using all the elements and strategies that nature did not have at hand.

Nowadays technologies are far from the fabrication of any on-demand biofunctional architectures that R. Feynman envisioned 50 years ago. However some important achievements in the field of the nanotechnology have been developed. The invention of Scanning Tunneling Microscopy (STM)¹ resulted in the first controlled manipulation of single atoms² and the first self-assembled structures were successfully produced through smart molecular designs³. In order to advance in the interdisciplinary field of nanotechnology simple model systems are needed to rationalize the different mechanisms and processes involved in the atomic scale. Several different interactions -such as electrostatic, magnetic, van der Waals or chemical bonding- normally appear together and compete on the atomic scale. The studies of model systems take apart the different contributions of the complex behavior of the quantum nature and unveil common patterns across different processes. For this purpose carbon nanostructures are ideal systems of study.

Carbon nanostructures are atomically precise carbon-pure composites with reduced size -one of its dimensions is in the range of the nm. Carbon nanostructures with different dimensionalities have attracted the attention of the scientific community because their simplicity and exotic properties. We will focus on the carbon structures with sp² hybridization. These structures comprise the 0D family of fullerene molecules ⁴, the 1D family of carbon nanotubes (CNTs) ⁵, and the 2D graphenic materials ⁶. These atomic configurations have been proven to be stable and experimentally observed and have fostered significant scientific efforts from many branches of the science, such as chemistry, physics, or material science. Some of these studies have been recognized with some important scientific prizes; the discovery of fullerenes in 1988 earned to H. Kroto, R. Curl and R. Smalley the Nobel Prize (NP) in Chemistry of the year 1996 and the discovery of graphene in 2004 earned to A. Geim and K. Novoselov the NP in Physics of the year 2010. The present thesis studies from a surface science approach epitaxial graphene grown on single crystal surfaces.

Graphene: Introduction.

Graphene is a carbon allotrope consisting of an atom-thick single layer ordered in a honeycomb lattice ⁷. Its unit cell contains two nonequivalent carbon atoms and therefore in order to be fully described we need to account for two hexagonal lattices. This particular atomic structure yields graphene extraordinary electronic properties. In **Figure 0 1** we present a ball and stick drawing of the real space of the atomic structure of graphene. In this figure we have marked the two lattice vectors and the sublattice "number" (sublattice A and B respectively) of every atom. As one can notice, every carbon atom has three first neighbors corresponding to the opposite sublattice.



Figure 0 1: Schematic ball-and-stick representation of the honeycomb lattice of graphene. The structure consists of two interpenetrating hexagonal lattices.

The structure of graphene is not a Bravais lattice; it needs to be expressed as an hexagonal lattice with a basis. Choosing the appropriate axis of reference one can express the lattice vectors by the following form.

$$a_1 = \frac{a}{2}(3,\sqrt{3}), \qquad a_2 = \frac{a}{2}(3,-\sqrt{3})$$

Where a = 1.42 Å is the carbon-carbon distance. The reciprocal lattice vectors are then

$$\boldsymbol{b_1} = \frac{2\pi}{3a} (1, \sqrt{3}), \qquad \boldsymbol{b_2} = \frac{2\pi}{3a} (1, -\sqrt{3})$$

This system's electronic structure is so simple that it can be correctly described under the tight-binding approach. This calculation was first performed back in 1947 by P. R. Wallace. The Hamiltonian for electrons considering that electrons can hop to nearest and 2^{nd} nearest neighbor atoms can be written under this theoretical treatment as follows (assuming for convenience $\hbar = 1$)⁷.

$$H = -t \sum_{\langle i,j \rangle,\sigma} \left(a^{\dagger}_{\sigma,i} b_{\sigma,j} + h.c \right) - t \sum_{\langle \langle i,j \rangle \rangle,\sigma} \left(a^{\dagger}_{\sigma,i} a_{\sigma,j} + b^{\dagger}_{\sigma,i} b_{\sigma,j} + h.c \right)$$

Where $a_{\sigma,i}$, $a_{\sigma,i}^{\dagger}$ are respectively the annihilation and creation operators with spin σ in the A sublattice, and equivalent definitions for the B sublattice. The hopping parameters for the nearest neighbor electronic jump (hopping between different sublattices) are t = 2.8eV and the one for next nearest neighbors is t' = 0.6 eV. The energy bands can be easily derived from this Hamiltonian and result.

$$E_{\pm}(\mathbf{k}) = \pm t\sqrt{3 + f(\mathbf{k})} - t'f(\mathbf{k})$$
$$f(\mathbf{k}) = 2\cos(\sqrt{3}k_ya) + 4\cos\left(\frac{\sqrt{3}}{2}k_ya\right)\cos\left(\frac{3}{2}k_{xy}a\right)$$

The energy landscape and electron behavior that these equations depict are very interesting. Near the so-called Dirac points the energy dispersion can be considered linear and therefore the effective mass of the electrons (proportional to the derivate of the band dispersion) is zero. These electrons behave as massless Dirac fermions ⁷. In **Figure 0 2** we present the graphical representation of $E_{\pm}(\mathbf{k})$, and the magnified region of a single Dirac cone.



Figure 0 2: Calculated energy band dispersion for the graphene electronic structure. (Right) Closer look to the energy band near the k point in the reciprocal space known as Dirac point, and the so-called Dirac cones.

This electronic structure is unique of 2D honeycomb materials and the resulting massless charge carriers are very interesting from a theoretical point of view as they behave like electrons accelerated to velocities near the light speed. The graphene discoverer A. K. Geim already noticed this behavior and remarked it in its famous sentence: graphene... allows the investigation of relativistic quantum phenomena in a bench-top experiment ⁸.

Graphene first isolation

Graphene was first isolated in 2004 by the group of K. Novoselov and A. K. Geim in Manchester from mechanical exfoliation of highly oriented pyrolytic graphite (HOPG) using a simple scotch tape for removing the topmost layers of a commercial HOPG sample⁶. This technique is normally used for cleaning the HOPG samples prior to its use as a super-flat substrate and leaves clean fresh surfaces free of involuntary contaminants. Mechanical cleavage of HOPG can also be performed in UHV conditions in

order to use the sample for advanced surface characterization. The brilliant idea here was to look at the remnants attached to the scotch tape and study its electronic properties, showing the existence of the first purely 2D system. However, as A. K. Geim itself recognized it was first isolated long before by means of graphite oxidation ⁹. The work of G. Ruess and F. Vogt ad later U. Hofmann and H.-P. Boehm on transmission electron microscopy (TEM) analysis of dried graphite oxide droplets in the 1950-1960s was probably the first time that single layer of this material was successfully isolated and studied. Actually, the graphene name itself was first introduced by H.-P. Boehm et al. in 1986 deriving it from the word "graphite" and the suffix referring to polycyclic aromatic hydrocarbons "- ene" ⁹. Every time we use a pencil it is very likely that we are creating micron-sized graphene crystals.

Single layer graphite was long known in the surface science community as an undesired contaminant appearing on many materials such as some metallic surfaces ¹⁰. However it was needed that graphene electronic properties were first experimentally described for all these studies to become relevant. Since graphene was discovered, thousands of scientific papers have been devoted to the topic. This new material combined many interesting aspects. The previously discussed massless Dirac fermions, the first pure 2D material ever isolated, the strongest material and one of the best thermal and electrical conductors ever described. Graphene is a superlative material and it has attracted the attention of many researchers around the globe.

Graphene production methods

There are several production methodologies of graphene. Every of them have its advantages and drawbacks. The most important ones are:

Mechanical exfoliation from highly ordered pyrolytic graphite (HOPG) ⁶, also known as the scotch-tape technique. This is the method that obtains best quality freestanding graphene, however the size and morphology of the samples is not well controlled and the production price is relatively high, as an experimented researcher has to look one by one with an optical microscope the by-products of HOPG exfoliation searching flakes with a precise optical absorbance.

- Epitaxial growth on silicon carbide by thermal annealing ¹¹. When heating SiC to high temperatures (>1500K) graphitic layers grow on the surface of the samples. This process is induced by Si depletion and C reorganization into the stable sp² adlayers. This method produces high purity areas of graphene on top of a wide gap semiconductor and it is the most promising for being used in future graphene based nanoelectronics.
- Epitaxial growth on metals by carbon decomposition by assisted surface catalysis ¹². Graphene can be successfully grown on the hexagonal surface of most transition metals. The interaction between the metallic substrate and the graphene layer ranges from weak adsorption to strong chemisorption. This method has the advantage that is highly scalable in roll-to-roll mass production and the drawback that the resulting product consists normally of highly defective polycrystalline films.
- Graphite oxide reduction through chemical methods ¹³. Graphite oxide is a well known composite produced after HOPG sonication in an acid solution. The resulting product is highly dispersed carbon powder with a few percent of single layer planes. These sheets are, however, highly functionalized through –OH, -COOH,-O- and other oxygen-rich groups. Reduction of this material yields highly defective and always oxidized graphene layers that result very cheap to produce.

In the present work we focused on the two methods more suitable for surface science studies. These are the epitaxial growth, on SiC(0001) and on metals, and more precisely on Pt(111), a weakly interacting metal.

Graphene on weakly interacting metals: Moirés

Metal surfaces normally react with carbon by forming surface carbides. However some surfaces, normally the less reactive ones, develop graphene upon carbon exposition. The less interacting metals are, in progressive order, Au, Ag, and Cu. However they are so little interacting that only very recently, and through smart growth techniques, graphene has successfully been grown on them ¹⁴ ¹⁵ (no graphene on Ag has been reported as far as we know). The next metals in low reactivity would be, Ir, Pt and Pd. Graphene can be successfully grown on the highly-packed hexagonal surfaces of these metals either by annealing the carbon rich samples (carbon segregation) or through annealing the samples in the presence of an external carbon-rich molecular precursor. Early studies in the 1970s of "single layer graphite" ^{16 10} on transition metal surfaces depicted a very rich landscape of graphitic structures on weakly interacting metal surfaces. Several orientations of the graphene overlayers with respect to the substrate are permitted and the electronic interference between substrate and graphene produces Moiré patterns with different angles and superperiodicities. The formation of these coincidence superstructures is described by STM images. The exact determination of these structures is difficult to find from a theoretical point of view as the number of atoms involved is very high. In the present work we have carefully analyzed STM images and combined them with some theoretical models in order to draw a full picture of the growth of graphene on weakly interacting metal surfaces.

Graphene on SiC: electronic effects

Silicon carbide is a wide bandgap semiconductor that is well suitable for high temperature, high frequency transistors ¹⁷. Again, it was known the presence of "single layer graphite" on top of the hexagonal surfaces of this material long before isolation of mechanical exfoliated samples was achieved ¹¹. The surface of SiC passes through several surface reconstructions when annealed in vacuum before it develops graphene. Moreover annealing at higher temperatures (typically >1500K) initiates multilayer growth on the SiC(0001) Si-terminated face. Graphene grow on SiC(0001) expresses very interesting electronic properties. The electronic band structure is analogous to freestanding graphene and when inspected with local microscopy techniques, such as STM, it appears transparent or opaque depending on the used bias voltage: the honeycomb structure is "visible" only within a small range of scanning conditions. G/SiC(0001) presents guantum interferences between electrons of different sublattices and it exists the valley degree of freedom (similar to the sublattice degree of freedom but in the reciprocal space). All these characteristics makes G/SiC(0001) an ideal system to test the fundamental properties of this pure sp² compound. On the other hand the C-terminated SiC face develops multilayer graphene at lower temperatures (around 1400K). These layers are very weakly bound and stacked in different orientations forming graphene-graphene Moirés with different orientations and periodicities.

Study of molecules on graphene

Graphene is supposed to be relatively inert to most atmospheric airborne contaminants, this is, low sticking coefficients towards O₂, N₂, and more importantly, H₂O molecular exposition. This is the result of a highly saturated electronic structure and a high crystallinity with low amount of defects. The basal plane of graphene flakes normally interacts with condensed adsorbates through weak interactions, but some species can chemisorb on top of in-lattice C atoms. Highly reactive atomic adsorbates, such as O or H, tend to covalent bond the substrate while organic molecules and, more precisely, aromatic molecules tend to present a dominant intermolecular contribution into the force balance. We took advantage of this quasi-free behavior of G/SiC(0001) to test the reactivity of graphene upon molecular deposition of selected adsorbates. To prove the extremes of the possible range of interactions we have studied the atomic scale structure of graphene functionalized with two simple species: atomic hydrogen and C₆₀. The behavior comparison between both systems will give insight into the adsorption mechanisms on graphene.

Thesis outline

After introducing the experimental techniques used in this work we will present the results. The thesis is presented in two independent blocks, and the blocks are divided into chapters.

Graphene on Pt(111):

1 We have grown epitaxial overlayers by means of molecular decomposition of carbon rich molecules. The precise role of molecular precursor- and its dissociation temperature- to form polycrystalline surfaces consisting of graphene patches with different orientations will be discussed.

- 2 In our search for understanding the stability of the different rotational domains we have developed a simple model that finds the best coincident lattice positions between the Pt(111) substrate and graphene overlayer, for every graphene twist angle. We will compare the predictions of the model with the experimentally observed Moirés to test model validity and to reveal some critical aspects in the Moiré stability of G/Pt(111).
- 3 The atomic structure of the smallest observed –and predicted- Moiré, namely (V3xV3)R30°, is studied in detail through the comparison between STM images and advanced DFT calculations.
- 4 (\v7x\v7)R19° is the most commonly observed Moiré superstructure of G/Pt(111) for a wide range of growth conditions. In the present section we will present a detailed analysis of STM images together with calculations to fully determine the atomic configuration of this structure.
- 5 The relation between stable rotational domains and the bonding region between the metal substrate and graphene is discussed in this section. Nucleation and subsequent growth from the Pt(111) atomic steps is discussed and compared with our phenomenological model.
- 6 Among all the crystalline edges found in the experiments we have studied in detail the contact region between (v7xv7)R19°-graphene and Pt(111) step edge. Theory predicts the appearance of exotic 1D states in the vicinities of the contact region and experiments show the existence of electronic states localized in this region.
- 7 Defective structures with different dimensionalities of G/Pt(111) will be introduced as strain relief mechanisms. The accumulated mismatch between substrate and overlayer produces high stress amounts that relax through the formation of atomic scale defects. A *bestiary* of these defects is presented and described in this section.
8 At last we will extract some conclusions out of our analysis of the G/Pt(111) system.

Graphene on SiC(0001):

- 1 Once we anneal the samples at 1450K the Si loss is so important that a carbon-rich atomic reconstruction appears. We normally obtain a surface where different reconstructions coexist. The dominating reconstruction is known as (6v3x6v3)R30°/SiC(0001). The periodicity of this structure under diffraction measurements differs with the periodicity measured with local techniques –quasi-(6x6). We will also present the less abundant quasi-(5x5). Single layer graphene is characterized by a combination of experiments and calculations. The exotic electronic properties that this system expresses are discussed. Higher order graphene stacking, such as bilayer graphene, are briefly presented.
- 2 Hydrogen adsorbates deposited on graphene at 300K are a model system of chemisorbed structures on graphene basal plane. The interaction strength will be analyzed and the adsorption configuration of the hydrogen clusters appearing on the surface will be studied in detail by a combination of high resolution STM images and advanced DFT calculations.
- 3 We will compare the behavior of hydrogen adsorbates with that of C_{60} molecules deposited both at 300K and at 40K on the same single-layer graphene surface. We will study the strength of the dominating intermolecular interaction through STM sequences of the dynamics of the C_{60} molecular adsorbates and after comparison with vdW-DFT calculations.
- 4 Finally we will point out the conclusions of our study on simple adsorbates on G/SiC(0001).

After all this considerations, general conclusions will be extracted out of the comparison of both graphene systems. Both are considered to be weakly interacting systems whose graphene epitaxial structures retain near-free behavior. However, we can notice that graphene grown on metals presents structural properties much more affected by the underlying substrate than those of G/SiC(0001).

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Chapter 1. Theoretical and experimental methods

Nanotechnology has become a new important discipline in science. This multidisciplinary branch of knowledge combines results obtained within "classical sciences", such as physics, chemistry or biology, during the last 30 years, in order to study the behavior of the nature when nanometric scales come into play. A nanometer is a billionth of a meter (10⁻⁹ m), or 10 Angstrom (Å) and is approximately the size of a tetracene molecule (see **Figure 1 1**) i.e. four benzene rings merged together. Within these length scales physical objects must be studied under a quantum perspective; nature no longer behaves under the classical Newtonian laws but new intriguing and rather counterintuitive rules control the stability, kinematics and dynamics of a particle.



9.84 Å ≈ 1 nanometer

Figure 1 1: Ball and stick model o a tetracene molecule whose lateral side measures approximately 1nm.

The quantum theory –developed during the beginning of the centuryformulates the atomic particles (in our case, mostly electrons) in terms of wavefunctions. Within this mathematical approach particles are no longer described in a deterministic frame, but they are characterized in terms of probabilities. The probability of, for example, an electron to be in a determined position is proportional to the modulus of the wavefunction in that precise position and deterministic particles become clouds of probabilities. Therefore measurements in the nanoscale need to take into account these "quantum world" effects and average the result of multiple single measurements.

A typical "quantum measurement" could be the determination of the lattice parameter of a crystal. This distance usually ranges in the order of a few Ås and to analyze it we study the pattern formed by diffracted X-Rays scattered out from the crystal. The X-rays interfere constructively or destructively depending on the crystallography of the sample. The quantum paradox arises when we compare the measurements of a single X-ray

photon (i.e one by one) with the overall landscape after billions of single photon measurements. Single photons appear randomly distributed (appearing scattered even in regions forbidden by quantum mechanics) but when billions are measured a clear diffraction pattern arises revealing the preferential and forbidden scattering directions. From this pattern the lattice parameter of the crystal can easily be extracted. Nanotechnology, and more precisely surface science, necessarily must take into account these quantum properties and limitations.

Modern surface science takes advantage of the technical advances in Physics in order to study the solid surfaces. The structural and electronic properties of the outermost region on the material normally behave differently to the bulk because they are affected by the proximity of the vacuum interface. Surface science methodologies provide the control to study and model complex 2D systems and for understanding the chemicalphysical properties of a surface on the atomic scale.

Several experimental techniques were used during the work performed in this thesis. Modern surface science supplies a handful of different techniques providing important parameters of the surface under study. Most of them can be subdivided in two main groups: experimental techniques using a "wave-like" probe (photons, electrons...), and experimental techniques using a sharp tip placed very close -almost in contact- with the sample as a probe. Among the first ones we find the non-local techniques, LEED, LEEM, UPS, XPS, AES... and among the tip-based we find the local techniques, AFM and STM, which where the main ones employed in this work.

In the following chapter, these experimental techniques and their theoretical fundamentals are briefly described. The structure of this chapter will be as it follows: First, I will shortly introduce the theoretical frame for every different technique. Second, I will describe the particular implementation of every technique that has been used during these works. Third and last, I will shortly introduce typical results and the information that can be extracted out of them.

1.1. Scanning Tunneling Microscopy (STM)

In 1981 Gerd Binnig and Heinrich Rohrer invented the Scanning Tunneling Microscopy (STM) in their laboratory of IBM in Zurich. This new technique brought, for the first time, the possibility of observe atomic scale objects on atomically flat surfaces ^{1 2}. This invention was awarded with the Nobel Prize in physics only 5 years later, in 1986 "for their design of the scanning tunneling microscope". It permitted to study in real space the interactions occurring between atoms and molecules, while resolving them individually. STM also provided for the first time the possibility of moving single atoms in a controlled manner, placing them at will, and study the structures that have been formed ³. It can be said that STM is the key discovery fostering modern nanotechnology; after its invention, for the first time the mankind was provided with a tool that could "touch" atoms one by one.

The STM is based in quantum tunneling of electrons through an energy barrier between a metallic tip and a conducting or semiconducting surface (and some selected insulators, such as TiO_2). In classical mechanics a particle with a certain energy ($E_{Particle}$) cannot surpass an energy barrier ($E_{Barrier}$) when $E_{Particle} < E_{Barrier}$. In quantum mechanics a particle has a non zero probability to go through a potential barrier higher than the energy of the considered particle. The quantum tunneling effect is this non negligible probability of the quantum wave-functions to surpass the energy barrier ⁴. In **Figure 1 2** we see a schematic representation of the 1D tunneling effect.

The tunneling barrier between tip and sample is modeled by a potential with energy equal to the vacuum level (E_{VL}). An electron in the sample (or tip) with an energy, E, smaller than the barrier (E< E_{VL}), will satisfy the Schrödinger's equation. Neglecting thermal excitation the Fermi level is equal to the work E_{f} =-Ø. Applying a voltage bias, V, we can obtain a tunneling current I. Assuming the work functions of tip and sample to be equal and eV<< Ø we obtain a current value satisfying:

$$I \propto V \rho_S(E_F) e^{-2\hbar \frac{\sqrt{2m\emptyset}}{\hbar}}$$

This means the value of the current is proportional to the: applied bias (V) and the local density of states (LDOS) of the sample's surface at the Fermi level ($\rho_S(E_F)$); and exponentially dependent on the distance between sample and tip (h).



Figure 1 2: Quantum mechanical energy scheme of tunneling between two ideal metals.[Adapted from J.Chen²]

Due to the exponential behavior of the tunneling current with respect to the distance between tip and sample we can assume the main contribution to the current (up to 90%) coming from the tunneling through the last atom in the tip, and the vast majority (up to 99%) coming from the apex atom and its first neighbors atoms in the tip pyramid. Therefore by scanning a sharp tip over an atomically flat surface we can map de density of states of a sample's surface. The spatial resolution can be estimated in terms of the radius of the apex (R) and the distance between tip and sample (*d*) to be $1.4\sqrt{d+R}$ [Å]. When using a sharp tip, a STM can achieve atomic resolution of metals and graphene ⁵.

ESISNA group hold three UHV operating STMs in their facilities. The ICMM laboratory has a variable temperature (40-300 K)STM (VT-STM) and a room temperature STM (RT-STM). The CAB laboratory has a RT-STM in its Spectroscopy and Microscopy on Surfaces (SMS) UHV chamber. They are all commercial instrumentation provided by Omicron GmbH and operated with Nanotec electronics. The **Figure 1 3** shows a model of the microscopes of our group. Sample and tip are respectively colored in red and blue, the tip is mounted on the piezoelectric tripod stage which is used to move it over the surface and scan. The whole STM is mounted on an eddy-current vibration dumping stage in order to minimize mechanical vibrations. In

Figure 1 4 we present a picture of a real nc-AFM/STM instrument out from vacuum for maintenance and repair.



Figure 1 3: Schematic representation of a UHV STM. The red colored platelet corresponds to the sample holder where the sample is mounted. The blue colored part corresponds to the scanning tip, mounted onto a piezoelectric tripod.

The tip is controlled by a scanning feedback system. There are two major operation regimes: constant current and constant height. In the constant current mode the loop circuits measures the value of the tunneling current and readjusts the voltage towards the piezos in order to keep the current constant. Therefore if the sample morphology makes the tunneling current decrease, the feedback loop is going to push the tip closer to the sample in order to obtain the desired scanning current. This constant current regime is also known as topographic mode, as somehow it is related to the surface topographic landscape (assuming the changes in the LDOS are small). On the other hand we have the constant height mode, where the tip is kept at fixed distance on the sample and changes in the tunneling current are mapped. In the present work both regimes were used.



Figure 1 4: *Picture of a nc-AFM-STM instrument similar to the one depicted schematically in* **Figure 1 3** *but adapted to low temperature measurements.*



Figure 1 5: SEM (scanning electron microscope) images of tungsten STM tips. **a.** Two tips, the scale bar represents 1mm. **b.** Apex of a single tip. The scale bar represents 200 μm.



Figure 1 6: STM tips under optical microscope. **a**. A commercial tip mounted onto a gold-coated tip-holder. **b**. A tip during scanning into the microscope. The reflecting surface corresponds to a SiC sample.

In **Figure 1 5** we present scanning electron microscope SEM images of tungsten tips. These tips were made in-house by etching them in a NaOH solution through electrochemical methods. These tips are then mounted and approached using piezoelectric motors towards the surface. A picture of a STM during measurements can be seen in **Figure 16**.

Figure 1 7 shows typical images of an STM. In these images there are fullerenes and graphene coexisting on the same region. When using a small bias (100mV) fullerenes look distorted because they have not a significant density of states (DOS) around the Fermi level and tip crashes with the molecule while trying to readjust the current to its nominal value. This is so, because they are molecules and therefore they have gaps in its energy spectrum. On the other hand when imaging graphene at 100mV the contrast is mainly coming from the sp² overlayer, while, when imaging it at higher bias (200mV) the main characteristic are the subsurface features. This seems to indicate that graphene LDOS is mainly localized around the Fermi level while the subsurface states appear at higher energies. In our STM design the bias voltage is applied to the tip.

Apart from imaging, STM can be used in spectroscopic modes. In these working modes the feedback system is usually turned off and the tip is placed on top of a particular surface structure. There are several spectroscopies: I(z), z(V), I(V)... among them I(V) and its derivative study dI/dV are the most normally used. In this technique we measure the current (I) for a given voltage (V) and we measure it for a wide range of voltages. Assuming the DOS of the tip is constant, it can be shown ⁶ that dI/dV provides direct information about the LDOS of the sample. It can probe the occupied and unoccupied states of the material with atomic

resolution. Curiously, the tips that are good for imaging normally have a sharp atomic orbital on the apex, which makes them very poor for STS. On the other hand tips that have a blunt DOS on the apex might be good for spectroscopy, but they are normally useless for imaging.



Figure 1 7: upper part, 20x20 nm² STM images at two different bias of C_{60} molecules (upper right corner) and graphene showing differences with voltage. At 100mV the fullerenes do not have significant DOS and thus electrons from the tip cannot tunnel to them, while at 200 mV the fullerenes have more states but graphene instead does not and looks transparent (detail presented in the lower insets). Lower part, dI/dV spectrum of C_{60} molecules on SiC. The molecular orbitals in the unoccupied energy region are revealed at around 1V (LUMO) and 1.7V (LUMO+1).

1.2. Atomic Force Microscopy (AFM)

The main disadvantage of STM is that the sample under study must be conducting (or semiconducting) and as a consequence insulating materials cannot be analyzed. There are important systems, such as oxides (TiO₂, CeO₂...) and ionic solids (NaCl...), which are insulating. Moreover, the large organic molecular complexes, such as the ones relevant in biology (DNA, proteins, lipid membranes...) are not conductive. The AFM was invented by G. Binnig in 1986 in order to overcome this limitation. Shortly after Calvin Quate and Christoph Gerber developed the first instrument ⁷.

The AFM is similar to STM but the conductive tip is changed by a force sensor measuring the force between tip and sample (F_{T-S}). The tunneling current exponentially decays with increasing distance and has a very short range. Opposed to that, the F_{T-S} has long-range and short-range additive contributions. Among the short range contributions the chemical forces are the most important; the main contribution arises from the formation of chemical bonds between atoms in the sample and the apex atom in the tip while scanning. Long-range forces can be attributed to a broader variety of effects such as: van der Waals contributions, electrostatic, magnetic forces and, when scanning in ambient conditions to the force of the meniscus of water formed between the sample and the tip ^{8 9}.

The force sensors are the central elements of the AFM ¹⁰; they are the major difference with STM and they are the "spring" that measures the F_{T-S} . Nowadays there are two basic families of AFMs based in two different kinds of force sensors. The first family of AFMs is based in silicon microfabricated cantilevers; most of them have "diving-board" geometry with a small protruding pyramid on the opposite end. When using silicon cantilevers we exploit the reflectivity of the polished silicon to aim a focused laser beam just on the end of the cantilever that is reflected under a certain angle. This laser will carry the signal of the deflection of the cantilever, which is proportional to the force. The laser beam needs to be properly focused in order to reduce its diameter to few μ m and carefully directed to the cantilever. The reflected laser signal is directed to a photodiode (see **Figure 1 8**) normally divided into quadrants. Depending on which quadrant the laser illuminates we can extract the deflection of the AFM and readjust the tip with feedback loops to either go closer or farther from the sample.



Figure 1 8: Schematic representation of the working conditions of a regular laser-based AFM. The tip is placed near the surface scanning it. The reflected laser signal spots into a photodiode that traduces the light intensity variations to forces between tip and sample.



Figure 1 9: AFM images of reduced graphene oxide on a polished SiO₂
surface of native oxide on a Si wafer. a & b. Laser-based tapping mode AFM
images of graphene oxide flakes. c. Height profile extracted from the b
image, where it is marked with a light blue line.

The second design of AFM was developed by Franz Giessibl around 1998 ¹¹ ¹². The force sensor used in this implementation (see **Figure 1 10**) is a tungsten tip attached to the apex of a quartz tuning fork. Tuning forks are used as frequency standards in clocks because they have very high stiffness, low amplitude and high energy of oscillation. In this configuration the F_{T-S} is

measured by the frequency shift needed to maintain the tuning fork in its resonance mode.



Figure 1 10: Optical microscope image of a force sensor based on the measurement of the dissipation energy of a conducting tip placed on top of a quartz tuning fork.

AFM can be operated in different modes. The static mode of AFM is very similar to the functioning of a regular STM. But most times AFM is operated in dynamic modes; within this mode, we force the tip to oscillate on the sample's surface. By measuring the decrease in the amplitude of the oscillation we can extract the force between the sample and the tip. This so called tapping mode is less intrusive to the sample and is normally used for measuring nanostructures deposited on flat surfaces as they can be easily moved with other imaging modes.

1.3. Low energy electron diffraction (LEED)

The low energy electron diffraction (LEED) was first discovered in 1927 at Bell Labs ¹³. Electron diffraction was predicted by L. de Broglie after his famous hypothesis in 1924¹⁴ and only 3 years later got its experimental confirmation, however its use in surface science for characterization had to wait more than 30 years to dispose of vacuum techniques permitting to keep a surface atomically clean for a sufficiently long period of time. LEED exploits the quantum nature of electrons that may behave as a particle and/or as a wave depending on how we observe them. The usual LEED apparatus (see Figure 1 11) consists of an electron gun emitting collimated electrons onto a crystalline sample. The arriving electrons interact with the surface reflecting and diffracting. The interference between the diffracted electrons forms an intensity pattern characteristic for the topmost surface crystallography. This intensity pattern can normally be observed on a fluorescent screen and is very useful for identifying surface structures and reconstructions as it is directly related to the 2D reciprocal lattice of the surface crystal symmetry. Because the electrons have very low energy they

are very weakly accelerated onto the sample; this creates a situation where these electrons mainly interact with the few topmost atomic layers of the sample. This extreme selectivity to the surface terminations together with its simplicity makes LEED an ideal technique for surface characterization prior to measurements through more complex methods, such as surface X rays diffraction or SPM's.



Figure 1 11: Sketch of the basic components of a LEED device. The electrons from the electron gun are accelerated towards the surface and the reflected ones retarded and finally accelerated towards a fluorescent screen showing the interference LEED pattern.

Depending on the nature of the sample different patterns can be observed. Simple metals normally relax its metal-vacuum interface by out-of-plane relaxations and therefore they rarely show surface reconstructions. Thus (1x1) patterns of the different surface terminations (normally (111), (110), and (100)) are normally seen in the fluorescent screen after surface preparation; an exception from this rule could be the so called "herringbone reconstruction" of the Au(111) surface whose unit cell corresponds to 22xV3¹⁵. On the other hand, semiconductors usually reconstruct in complex surface unit cells, consisting in several nonequivalent atoms per unit cell. For instance, clean Si(111) reconstructs in a 7x7 supercell involving dimers, adatoms and stacking faults¹⁶.

Another interesting case is SiC(0001). This surface presents several surface reconstructions after being annealed to different temperatures. The as-

received sample is normally covered by a SiO₂ native oxide layer, but still presents a (1x1) LEED pattern. After annealing the samples at 1100K in the presence of a Si flux (normally a Si evaporator) it develops a sharp (3x3) pattern. Si depletion occurs if we anneal the sample to temperatures above 1150K; the surface and the surface stoichiometry varies progressively. The pattern passes from a ($\sqrt{3}x\sqrt{3}$)R30°, ($6\sqrt{3}x6\sqrt{3}$)R30° to a graphene LEED patterns (see **Figure 1 12**).



Figure 1 12:a. *LEED pattern of the clean (1x1) surface of Pt(111) at 130eV.***b.** *LEED pattern of the (6V3x6V3)R30^o and graphene structure at 120 eV.*

LEED can also be used in a quantitative manner. The different nonequivalent points occurring in the pattern normally reflect with different intensity upon irradiation of electrons with different energies. Thus intensity versus voltage of the incident electrons curves can be plotted for every diffracted spot of the pattern. These curves can be also calculated numerically for different theoretically proposed surface atomic configurations permitting the use of LEED I(V) curves as a tool for unveil the average position of the atoms within the surface unit cell.

1.4. Low energy electron microscopy (LEEM) and X-ray photoemission electron microscopy (XPEEM)

This new kind of microscopy was developed during the 1960s by Ernst Bauer and collaborators but it was not completely developed until 1984 ¹⁷ ¹⁸. It is based in the previously described physical phenomena of electron diffraction and thus only crystalline surfaces can be imaged. The usual

geometry of these instruments is the threefold symmetry depicted in **Figure 1 13**, the three columns are respectively called illumination column, imaging column and sample chamber ¹⁹.



Figure 1 13: Schematic representation of the usual geometry of a LEEM – PEEM apparatus. The tree-fold geometry allows to use the three different sides for illumination column, sample, chamber and imaging column respectively.

Upon illumination of the sample with either electrons, UV photons from an Hg lamp or synchrotron radiation ²⁰ the reflected or photoexcited electrons form on the objective a magnified image of the sample surface. Depending on the lens configuration we change from real (surface imaging) to reciprocal (LEED pattern) spaces. The electrons are later filtered by energy through a hemispherical electron analyzer and projected into a multichannel plate where the signal is collected. There are also filtering slits that can be placed in one of the reciprocal space planes in order to permit only one of the diffracted LEED spots to continue the optical path. When this slit is placed in, in the real space plane (imaging mode) we will only see contrast arising from the surface regions (normally atomic terraces) that contribute to that particular crystallographic phase/diffraction spot. If we place the slit allowing only the (0,0) diffraction spot to pass the slit we

enhance the contrast of the LEEM image; this imaging mode is normally called bright field mode, as all the crystalline phases contributing to the (0,0) diffraction spot are imaged. On the other hand, if we place the slit allowing only one diffracted beam (other than (0,0) spot) pass the filter we obtain in the imaging planes micrographs of the surface where the only intensity comes from the terraces that express that particular crystallographic reconstruction. This imaging mode is called dark field imaging.

1.5. Photoemission spectroscopy (PES): XPS, UPS

The photoemission spectroscopy is based on the photoelectric effect in which a free electron is ejected from an atom after absorbing a photon. This effect was first observed by Heinrich Hertz in 1887²¹ and fully understood after Albert Einstein famous paper in 1905 which earned him the Nobel Prize in Physics.

The effect can be described as follows; one bound electron absorbs a high energy photon, normally X-ray or ultraviolet, turning it into a free electron of kinetic energy (E_K) (see Figure 1 14). The binding energy (E_B), the photon energy (hv) and the work function (\emptyset) fulfill the relation:

$$E_K = hv - E_B - \phi$$

Knowing the energy of the impinging photon and measuring the kinetic energy of the resulting free electron we can extract the energy of the former bound electron. For measuring the kinetic energy of the free electrons we normally use an experimental set up consisting of a cylindrical electron analyzer for energy filtering and an electron multiplier like a channeltron or a channelplate as a collector. The laboratory standard X-Ray guns normally have a double anode of Mg (K_{α} , hv = 1253.6 eV) and Al (K_{α} , hv = 1486.6 eV) and the usual UV illumination consist of an He lamp whose principal lines are He I hv = 21.2 eV and He II hv = 40.8 eV. Synchrotron radiation can also be used as an illumination source; its main advantages are higher photon flux and better monochromacy, which combined increases the energy resolution up to a tenths of meV for XPS and few meV for UPS. Another big advantage is that we can tune the energy of the arriving photons in a continuous range and thus set a photon energy that maximizes the photoexcited electrons of the element under analysis.

Depending on the energy of the illuminating photon we will excite different bound electrons giving rise to different photoemission spectroscopies. Thus if we use X-rays, the electrons that are mainly excited are the core level electrons (XPS) while if we use ultraviolet electrons we will excite the valence band electrons (UPS)²².



Figure 1 14: Schematic representation of the photoelectric effect. The Sketch shows the working principles of XPS. A photon excites a core-level electron above the vacuum level. The kinetic energy of the outgoing electron is recorded and the binding energy can be calculated.

XPS is a powerful technique for the characterization of the chemical species present on a surface. The characteristic energy values of the levels in every chemical element has been tabulated since the technique was developed, and complete inventories of the resonances appearing under standard X-Ray illumination are present in many handbooks ²² or web applications. XPS is not only sensitive to the chemical element but it is also sensitive to the electronic and chemical environment of the particular element. Small energy shifts (surface core level shifts or SCLS) from the nominal value of a particular state are normally attributed to different chemical bonding configurations, and thus to the electronic environments of this element (see **Figure 1 15**). If we have, for example, a carbon (C) atom bonded in sp²

configuration with three other C atoms the C1s peak will have its maximum at energy around 284.8 eV ²³, while if we have C bonded to Si in the form of carbide (SiC) the C1s peak will appear shifted to lower energies around 283 eV. The XPS spectra were analyzed using the FITT program developed by Hyun-Jo Kim (Seoul National University). This program allows a fit of the peaks by convoluting Lorentzian and Gaussian contribution to the width of a specific core level.

The UPS spectrum is a measurement of the valence band of a particular material. If this substance is conductive we will find electron populating levels around the Fermi level. On the other hand if the material is insulating we will find that no electrons are populating the Fermi level and we can very easily calculate the band gap as the energy difference between the last occupied electronic band and the Fermi level. However one must take care of charge effects that might be occurring and making the band gap appear distorted.



Figure 1 15: XPS deconvolution of graphene oxide. The blue component, centered at 284.8eV corresponds to C in sp^2 configuration; the other components are assigned to different carbon oxidized species. Spectrum acquired under illumination with an $AI_{k\alpha}$ X-ray source (1486.6 eV).

1.6. Density functional theory (DFT)

In order to complement the experimental observations with a theoretical framework, density functional theory (DFT) calculations have been performed of most of the systems studied in the present thesis. DFT was developed during the 1960s by P. Hohenberg, L. Sham and W. Kohn ²⁴, among others, and brought the last one the Nobel Prize in chemistry of 1998.

From a theoretical point of view we need to solve the Schrödinger equation of the many body system, finding its eigenvalues (energies) and its eigenfunctions (wavefunctions). In order to solve such a complex equation several approximations and strategies have to be taken. DFT proposes a new approach; instead of searching the wavefunctions we will search for the electronic density. The Hohenberg-Kohn theorem establishes that it exists a one-to-one relationship between the fundamental state and a particular electron density which calculates the energy functional ²⁵. This makes the system easier to calculate, as we change from a problem were we have 3N variables (being N the number of electrons in the system under study) to a problem where we have a quantity, the electronic density, which depends on only 3 variables.

many available calculation packages including There are DFT approximations, however from a practical point of view there are two main "schools". The difference between them comes from the choice of the mathematical basis used for describing the electronic density. On one side we have the description of the electronic states in terms of a plane wave basis; this set permits more precise calculations but it is more time computing consuming. Usual plane wave codes -as VASP or CASTEPnormally include the option of performing spin-resolved calculations. On the other side we can use a linear combination of atomic orbitals (LCAO) as a basis set. These calculations are normally less time consuming allowing exploring larger unit cells. The LCAO calculation does not normally include spin variables. In Figure 1 16 we see the relaxation of the $(\sqrt{7}x\sqrt{7})R19^{\circ}$ -G/Pt(111) unit cell with the FIREBALL code, this code is based on the LCAO approach.



Figure 1 16: Ball-and-stick model of the optimized relaxed structure of the ($\sqrt{7}x\sqrt{7}$)R19°-G/Pt(111) Moiré, where the grey spheres correspond to carbon atoms and the blue spheres to Pt atoms. The unit cell has been repeated four times to allow for a better visualization. The structure has been relaxed using the FIREBALL code.

One of the most important outcomes that DFT brings for an STM experimentalist is the STM image simulation of the relaxed surface structures. For this purpose a metallic pyramid (normally W or another metal) is relaxed independently to be used as an STM tip. The FIREBALL package used in this work for this purpose uses the local-density approximation (LDA) and the Keldysh-Green function formalism to calculate the tunneling current (J). The equation that describes J has the form:

$$J = \frac{4\pi e}{\hbar} \int_{E_F}^{E_F + eV} T_r [T_{TS} \rho_{SS}(E) D_{SS}^R T_{ST} \rho_{TT}(E - eV) D_{TT}^A] dE$$

Where T refers to the hopping matrix, ρ to the electronic density, and D to the probability of multiple scattering; and the suffixes S and T to sample and tip respectively.

The calculations shown in this thesis have been performed by the group of Dr. P. Jelinek, the group of Prof. R. Pérez – Dr. P. Pou and L. Rodriguez –, by the theoretical part of the ESISNA group – Dr. P. de Andrés, Dr. I. Martínez, Dr. C. González – and by Dr. Y. J. Dappe and Dr. E. Abad.

1.7. Vacuum instrumentation

a. Ultra high vacuum systems

Surface science did not develop until ultra high vacuum (UHV) pressure was accessible in the mid 1950s. UHV chambers are necessary in order to prevent the sample from getting contaminated from the residual gases present in the atmosphere within seconds; in order to ensure the cleanliness of the sample for periods exceeding 1 hour, a typical minimum duration of a single experiment, we will need to lower down the pressure to the range of 10^{-10} mbar. In fact, according to the kinetic gas theory, the number of particles striking a surface per square cm per second is ²⁶:

$$\dot{n}_S = N_g \sqrt{\frac{RT}{2\pi M}} \approx 2.7 \times 10^{22} \frac{p}{\sqrt{MT}} (cm^{-2}s^{-1})$$

Where p is the pressure in mbar, M the molecular weight of the dominant species of the residual gas, and T the temperature in K. Assuming M=28 and T=300 we have $\dot{n}_S \approx 10^6 p$ so we need a pressure lower than 10^{-6} mbar in order to keep the surface clean for a second. However, another important factor that needs to be taken into account when calculating the deposition rates is the sticking factor of the adsorbate. This is the probability of an impinging molecule to remain fixed to the surface and ranges between 0 and 1. Depending on relative reactivity of surface and adsorbate an the substrate temperature we will have systems where very little of arriving molecules stick to the surface (S≈0), for example noble gases on metals, or where most of them get "glued" to the surface(S≈1), for example oxygen on semiconductors.

b. Silicon evaporator

There is not a unique way to build a Si evaporator. Here I will present the model that we constructed, adapted from the work of Johansson *et al.* on SiC ²⁷. This particular design is intended for SiC cleaning procedure. This needs high quantity deposition –around 1ML/s- of Silicon in order to keep the Si/C stoichiometry on the Si depleted SiC surfaces. Si depletion naturally occurs when heating SiC above 800C and these temperatures are needed for removing the native oxide layer that all commercial wafers come with.



Figure 1 17: Picture of a double Si evaporator. The copper wires are supporting Ta clamps for a Si wafer piece. The two upper copper wires and the two lower ones form independent evaporators. Passing current though the Si piece causes the semiconductor to heat up to temperatures around 1500K and it evaporates material in the form of atomic Si.

A picture of the design can be seen in **Figure 1 17**. It is very simple; it consists of a Si platelet of typically $1.5 \times 0.5 \times 0.1$ cm³, cut away from a Si wafer with a diamond tip, attached to a commercial UHV feedthrough with home-made Ta clamps for electrical contact. The operation mode follows: first, we normally apply \approx 70V volts to the Si plate to surpass the dielectric barrier. Once Si is warm, it starts conducting, and thus the circuit is governed by current. Typical parameters for getting Si evaporation (reaching 1550 °C on the platelet) normally are 10A, 4V with a partial pressure in the order of 5×10^{-10} mbar. Due to the need of such high temperatures for Si evaporation it is important to very carefully degas the device prior to exposure to the sample. The model presented in **Figure 1 17** has two independent evaporators one in the upper part and the other in the lower part of the image.

c. Molecular beam evaporator

The deposition of organic molecules needs a different strategy other than simple direct current annealing of the substance that we want to evaporate. For evaporating such molecules we introduce them into a homemade Ta crucible welded to two stainless steel or copper bars. Passing current through these bars we increase the temperature of the crucible. The temperature of the molecules is controlled by a thermocouple welded to the Ta envelope (see **Figure 1 18**).



Figure 1 18: Picture of the "head" of a home-made molecular evaporator. It consists in a Ta envelope, where the molecules are deposited, which is contacted by two cupper wires in order to close the circuit. Passing current trough the system makes the Ta to warm up and the molecules to evaporate. A thermocouple is spot-welded to the envelope in order to monitor the temperature.

This approach is very clean and allows evaporation of a wide range of complex adsorbates. However, normally prior to its use the crucible is degassed into UHV above in order to desorb water and other contaminants that may alter the purity of the molecules. Then the Ta envelope is filled with the desired molecule and degassed again up to temperatures slightly above the evaporation temperature in order to get rid of any possible impurity or chemical remnants that may be mixed with the molecules. We also used commercial quart crucible evaporators obtaining similar results. In this thesis C_{60} has been used. It was a commercial item bought to Sigma Aldrich with 99.9% purity. The typical evaporation temperature is 700-780K to obtain a rate of evaporation of around 0.1ML/min. During the deposition the pressure was always below 5×10^{-10} mbar.

d. <u>H-cracker</u>

Two independent designs of hydrogen crackers were used in the experiments to dissociate ultra pure molecular hydrogen. The H-flux atomic hydrogen source manufactured by TECTRA GmBH and a custom made H-cracker. The first design is based on the thermal molecular dissociation occurring when hydrogen passes through a tungsten capillary heated up to 2500K by electron bombardment. Its working characteristics are almost 100% cracking efficiency and zero residual ion current (no protons are created). Normal operating conditions, consisting typically of hydrogen partial pressure of 1×10^{-9} mbar, yields under typical pumping systems an atomic flux of 5×10^{13} atoms/cm² on a sample located typically at 10 cm.

The second hydrogen cracker used in the experiments is a homemade design. The cracking mechanism is analogous to that used in the quadrupole mass spectrometer (QMS). The gas enters the UHV chamber

through a capillary whose end is placed in the proximity of a Faraday cell and a tungsten filament. The filament is used as an electron emitter and the Faraday cell is positively charged (70V) in order to accelerate the electrons. The H_2 molecules are hit by the electrons in a process that cracks them down into atomic hydrogen.



Figure 1 19: *Picture of our home-made H-cracker. The hydrogen is introduced through the serpentine and the rest of Cu contacts serve to pass the high voltage as well as for passing current through the filament.*

1.8. Surface preparation

a. <u>Pt(111)</u>

Pt(111) single crystals were acquired from commercial firms. They present different geometries depending on the main technique that is going to be used. Thus, for diffraction cylinders with relatively large (1 cm diameter) surfaces are normally used while for STM the geometry used in ESISNA laboratory is the "hat-like" where the surface, typically 5mm diameter, is smaller than the base and the sample can be held with wires at the sample holder. The experiments were carried out in UHV environments with normal pressures in the low 10^{-10} mbar. The cleaning procedure of the Pt(111) substrate is a well established protocol consisting of three or more cycles of annealing the sample at 1200-1300 K in an oxygen atmosphere (typically 1-5 x 10^{-6} mbar) in order to remove all possible carbon contaminants from the surface, such as surface carbides and molecular adsorbates, forming CO and CO₂ which leaves the surface and is pumped away from the chamber.

After this procedure several cycles of argon ion sputtering and annealing are needed in order to obtain a clean surface suitable for STM experiments. Normal sputtering parameters for Pt(111) are $P_{Ar}= 1 \times 10^{-5}$ mbar accelerated with 1.5kV, impinging the substrate and generating typical currents of 8-12 μ A during periods of 10-15 min. After this procedure the sample surface strongly roughens, in order to "reorder" again the Pt(111) steps a strong-1200K- annealing in an extremely low – <5 x 10¹⁰ mbar- base pressure needs

to be performed. The annealing step of the cleaning procedure is shown as a picture taken through an UHV window in **Figure 1 20**.



Figure 1 20: Picture of the annealing of the Pt(111) sample. The red-glowing platelet is the sample holder irradiating visible light. The darker orange circle inside the glowing square is the Pt(111) sample at an approximated temperature of 1100K.

After this cleaning procedure we obtain a sample exhibiting well developed (1x1) LEED pattern, and a surface morphology consisting of clean Pt(111) terraces of 10-100 nm width, separated by monoatomic steps that typically run parallel to the Pt[110] direction. The Pt crystallizes in a face centered cubic (FCC) structure with a lattice parameter of 3.92Å. This yields a Pt(111) morphology of Pt atoms organized in a hexagonal configuration with a first-neighbor distance between atoms of 2.77 Å. The single step height is 2.26 Å; however as the sample ages it is more and more easy to observe multiple steps originated from processes of step bunching. In **Figure 1 21** we present STM images of the clean Pt(111) surface both at the atomic scale, as well as the parallel single-atom step terraces.



Figure 1 21: STM images of clean Pt(111) surface.**a**. 5x5 nm²Atomically resolved high resolution image where every of the protrusions corresponds to a single Pt atom. **b**. 50x50nm² image showing straight atomic steps, the small black sqare corresponds to the area marked in the **a** image.

b. <u>6H-SiC(0001)</u>

SiC is a wide gap semiconductor that can be purchased from commercial firms in the form of wafers with different doping grades. Small stripes can later be cut apart from the wafer with the help of a diamond tip. These ready-to-mount samples have later been put on two different sampleholders: the usual Omicron standard which consist of a small Ta platelet with an adequate geometry for the vacuum tweezers, or the usual omicron sample holders for semiconductors, in which the sample is mounted between two electrical contacts, in order to pass a direct current through it so it can be annealed by direct heating. The preparation of the SiC(0001) was performed in ultrahigh vacuum, although it can be done in an inert atmosphere- such as Ar- with similar results. The first step of the preparation of SiC consists in removing the native oxide layer that is formed when the sample is exposed to the air and that protects the surface. For this process we developed a recipe consisting of a slow degas of the whole annealing stage keeping the pressure below 1×10^{-9} mbar up to a sample temperature of 1000-1100 K. The sample temperature is normally monitored using an infrared pyrometer with an emissivity set to 0.53²⁸. Once the sample is properly degassed we deposit Si at a rate of 1ML/s with the help of the Si evaporator that has already been introduced in this section. We can either maintain the surface at RT or at high temperature, but it seems more effective to do cycles of Si evaporation while annealing the sample at 1100K during 10-15 min (a picture of this process is shown in

Figure 1 22). After doing a cycle we normally check the sample with the LEED. The SiC(0001) sample just after being introduced in UHV exhibits a faint (1x1) pattern, after 5-10 cycles of Si evaporation while annealing the pattern changes to a sharp (3x3) one. It is important to note that the appearance of the (3x3) pattern does not assure that the sample is well prepared for STM inspection, as the LEED pattern can appear even when the terraces are very small, or only a part of the surface is covered with the (3x3) reconstruction.



Figure 1 22: Picture of the interior of the UHV chamber during the Si evaporation and SiC treatment. The Si evaporator is placed at the left of the image whereas the sample is on the right part of the image.

Once we have the surface with a developed (3x3) surface periodicity we consider the sample well suited for preparing other surface reconstructions. This is performed by simple annealing to different temperatures. If we anneal the sample at 1200K we observe that the LEED pattern suddenly changes to a $(V3xV3)R30^{\circ}$ structure; when inspected with STM we observe that the surface morphology has been strongly altered and a $(V3xV3)R30^{\circ}$ periodicity appears. In case we increase the temperature to 1350K, Si depletion induces a stoichiometry where the most favored structure is the $(6V3x6V3)R30^{\circ}$ surface reconstruction. Annealing beyond this temperature induced a Si loss so severe that graphitic phases are predominant.

Depending on the temperature we can control the number of graphene layers. This process is shown through a combination of the atomically resolved STM images of the same size in **Figure 1 23** and described in detail in the last part of this thesis.



Figure 1 23: Atomically resolved STM images of the SiC surface annealed at increasing temperatures. From left to right we pass ffrom the Si-Rich (3x3), $(\sqrt{3}x\sqrt{3})R30^{\circ}, (6\sqrt{3}x6\sqrt{3})R30^{\circ}$ and finally graphene.

1.9. Description of the experimental systems used in this thesis

During the realization of this thesis we have used up to 10 different experimental UHV chambers. However the most of this thesis have been performed in three of them, the chamber in *Centro de Astrobiología* (CAB), the chamber in ICMM and the chamber in FZU (Institute of Physics of the Academy of Sciences of the Czech Republic). The chamber at CAB (see Figure 1 24), consists of an UHV vessel equipped with a hemispherical electron analyzer, a LEED apparatus and a room temperature STM. The illumination sources are a double anode (Mg-Al) soft X-rays gun -for XPS studies-, a He UV lamp - for UPS - and a electron gun- for Auger spectroscopy. The chamber in ICMM consists of a room temperature STM and a LEED instrument. The chamber in FZU consists of a UHV vessel with a LEED instrumentation with a channel-plate for LEED I(V) characterization and a variable temperature STM head modified to combine, STM measurements with Q-Plus nc-AFM measurements. All of them were equipped with quadrupole mass spectrometry, LEED, heating system, gas inlet lines and free CF-ports for attaching the molecular evaporators.



Figure 1 24: Picture of the combined microscopy and photoemission chamber held by the Centro de Astrobiologia.

The rest of the chambers used during this thesis were placed in synchrotrons radiation facilities and were designed for surface diffraction (ESRF ID03 and ESRF Spline), PEEM (ALBA-CIRCE) or high resolution XPS (Elettra-SuperESCA).

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Chapter 2. Epitaxial growth of graphene on Pt(111)

Several productions methods –apart from the originally proposed mechanical exfoliation of highly oriented pyrolytic graphite (HOPG) ¹- have been proposed and achieved ² ³. Among the most important ones are the epitaxial growth techniques of graphene on single crystal surfaces; the result of these production methods are very promising for future applications as the quality of the resulting sheets is much better than the quality of the –normally used method in massive production - reduced graphene oxide layers, which usually exhibit a large amount of oxygen related defects limiting the exceptional mechanical and electronic properties. ⁴

Most metals develop graphene layers on its surface when annealed to high temperatures, typically 1000-1500 K, in the presence of an external source of carbon or by segregation of C dissolved in the bulk 5 ⁶. The formation of graphene has been mostly studied on hexagonal metal surfaces, like the (0001) for the HCP crystallographic structures $-Ru^{7 8}$, Co $^{9 10}$, Re 11 - and the (111) for the FCC metals $-Ni^{12}$, Cu 13 , Rh 14 , Pd 15 , Ir 16 , Pt 17 and Au 18 - but it has also been observed to grow on non-hexagonal crystallographic surfaces such as Pt(100)^{19 20}. The interference between the hexagonal substrate and the honeycomb lattice of graphene give rise to Moiré superstructures of different periodicities for every transition metal. Depending on the reactivity of the substrate, the interaction strength can range from van der Waals physisorption to strong bonded chemisorption. Moreover, the interaction between the substrate and the graphene overlayer drives the corrugation of graphene and the mean distance from the substrate ²¹. Normally, when the interaction is not very strong different rotational domains appear ^{22 17 15} each of them with a different apparent angle and periodicity.

Ti	V	Cr	Mn	Fe	Со	Ni	Cu
Zr	Nb	Mo	Тс	Ru	Rh	Pd	Ag
Hf	Та	W	Re	Os	Ir	Pt	Au

Figure 2 1: Table of the carbon stability on transition metal surfaces adapted from Ref. 6. The color scale is as follows: Grey means the most favored C phase is a carbide, red means that carbon reactivity remains unknown, yellow and green means that C may grow as graphene layers on these surfaces; yellow means that only one orientation is normally obtained whereas different rotational domains (or Moirés) are found for the metals with a green color.

Among the weakly interactive transition metal hexagonal surfaces, Pt(111) is a model substrate. Epitaxial graphitic layers on Pt(111) were discovered already in 1975 by B. Lang in its pioneering LEED study ²³. The first STM study of this system also precedes the discovery of graphene: T. A. Land *et al.* reported in 1992 the presence of at least three different rotational domains, or Moirés, of "single layer graphite" on Pt(111) formed by hydrocarbon decomposition ²⁴. Later works have found a big amount of Moiré structures of graphene on Pt(111) with LEEM ²⁵ or STM ²⁶. However the agreement between the different experimental observations is not good and different research groups have described different orientations between graphene and Pt(111). To clarify this complex system, G/Pt(111), we have performed a combined theoretical-experimental approach. Our results are described in the sections below.

2.1. Growth of G/Pt(111) in UHV

The graphene growth process we have used is schematically reproduced in **Figure 2 2**. This process is based on the deposition at room temperature (300K) of large aromatic molecules, such as fullerene $(C_{60})^{27}$ or $C_{60}H_{30}^{28}$, following by an annealing at typical temperatures of 1100-1200K that induce a thermal decomposition of the precursors. We have also used other growth methodologies such as the use of small hydrocarbons precursors (in our case propane, C_3H_8) or the deposition of the carbon rich molecules on the hot surface of the samples. All these variants appear to be successful to form graphene. The fact that most recipes succeed in the formation of graphene on Pt(111) indicates that this is a thermodynamically favored process and that Pt(111) is a good catalyst for this reaction.



Figure 2 2: Schematic representation of the process of graphene formation on Pt(111). The C-rich molecular precursors, such as C₆₀H₃₀ or C₆₀, are deposited on clean Pt(111) and annealed. Different intermediate states appear upon annealing, but annealing at a sufficient high temperature always yields to graphene formation. The different stages are represented by STM images.

The standard experiments were carried out in an UHV chamber provided with a commercial room temperature Omicron scanning tunneling microscope and a low-energy electron diffraction system. The base pressure was 1×10^{-10} mbar and Pt was cleaned by the conventional

procedure of repeated cycles of argon sputtering and annealing. As usual the first annealing cycles were done in an oxygen atmosphere of 1×10^{-5} mbar in order to remove carbon impurities. Commercial C₆₀ (provided by Sigma Aldrich, 98 % of purity) were used for the sample preparation. The fullerenes were degassed during several hours at 715 K and the sublimation temperature was 725 K. Fullerene deposition rate was calibrated according to previous STM experience and it was estimated to be around 0.4 ML/h. After sample cleaning, C₆₀ was evaporated for 30 min. keeping the sample at room temperature. Sample was later annealed by electron bombardment up to 1200 K in order to decompose the C₆₀ molecules. Temperatures were measured using a commercial IR pyrometer. The use of large poly-aromatic hydrocarbons as carbon precursors for graphene growth permits better control of the coverage fraction and induces the appearance of islands with several different orientations.

After this treatment the sample is transferred to the instrumentation for investigation. The LEED pattern is normally checked prior to STM measurements. The diffraction pattern characteristic of G/Pt(111) consist in the one of clean Pt(111) summed with a ring-shaped circle located out of the (1x1) pattern indicating the presence of multiple orientations of a superficial structure with a lattice parameter of \approx 2.4 Å (See **Figure 2 3**).The ring indicates rotational disorder of the graphene layers.



Figure 2 3: Typical G/Pt(111) LEED pattern with an energy of the incident electrons of 130 eV. Dots correspond to Pt(111) (1x1) pattern and the ring-shaped structure results from diffraction of graphene domains with different orientations.

After checking the graphene growth with LEED, the sample is transferred to STM, where flat, homogeneous flakes of graphene layers are found

together with clean Pt regions. Images were recorded using topographic and current modes with typical bias of -2000...2000 mV and currents of 0.1..2 nA although some images were taken with currents up to 4 nA. WSxM software was used for data acquisition and image analysis²⁹. We also used homemade drift correction software for hexagonal lattices in order to avoid possible errors introduced by sample movement during scan. This software corrects the images for a given unit cell keeping the fast scan axis distances as the reference one.

One of the main advantages of growing graphene by aromatic molecules decomposition, instead of using acetylene or other small hydrocarbons, is that one can easily control the coverage. The use of these molecules and low temperature annealing -but above dissociation temperature- induces the growth of a richer amount of different Moiré superstructures; this is a richer polycrystalline epitaxial graphene sample. Higher temperatures lead to surfaces with a lower number of graphene phases.

Graphene on Pt(111) forms pseudoperiodic structures, Moiré superstructures. A Moiré is the secondary pattern created by the interference of two superimposed lattices (see **Figure 2 4**). This phenomenon is not only characteristic for graphene overlayer, but it also appears in a wide range of physical phenomena. However, it is very important for graphene grown on transition metal surfaces as it is the main structural motif normally observed in STM investigations.



Figure 2 4: Schematic explanation of a hexagonal Moiré. The blue honeycomb lattice represents Pt(111) ($a_{Pt}=2.77$ Å) with one of its main crystallographic directions aligned with the horizontal. The black honeycomb lattice represents graphene ($a_G=2.46$ Å) rotated Φ (crystallographic angle) respect the Pt directions. When both lattices are overlaid the resulting diagram presents a superperiodicity (Moiré pattern) due to the coincidences (two of them are marked as red dots). An example of a hexagonal Moiré appearing on the G/Pt(111) system is illustrated in **Figure 2 4**. The black lattice correspond to a rotated graphene sheet lying on a single Pt layer (blue lattice) oriented with the Pt[110]surface direction along the horizontal axis. The relative angle between both lattices (Φ) will called from here in crystallographic angle. It is the angle formed between the black arrow and the horizontal (i.e. Pt[110]direction). We observe a superperiodicity arising from coincident regions, i.e. a hexagon of graphene appearing on top of a hexagon of Pt. We have marked two of these coincidences with red dots. The Moiré is defined by these coincidence regions; the Moiré forms another angle with the Pt[110] crystallographic direction that we will call Ω , the apparent angle of the Moiré.

A good example of these systems could be the Moiré appearing on $G/Ru(0001)^{8}$. Normally, only one Moiré superstructure is observed in the G/Ru(0001) system with a periodicity of C(11x11)/Ru(10x10) extracted from local experiments. The characteristic angles for this Moiré are $\Phi=0^{\circ}$, $\Omega=0^{\circ}$ The determination of the origin of the topological corrugation appearing in the STM images of this superstructure fostered deep investigations in order to discriminate the electronic and topographic contributions. Nowadays it is well accepted that graphene interacts strongly with the Ru(0001) surface in some parts of the superstructure unit cell inducing high structural buckling. On the other hand several graphene Moirés are spotted on the surface of Pt(111) and the interaction between the metal and over layer is considered to be very weak.

The following STM images of the G/Pt(111) system present graphene islands with several Moiré configurations. Moiré presets two different corrugations, big scale (Moiré) and small scale (graphene). High resolution STM images resolve Moiré superperiodicity (big scale protrusions with typical buckling about 0.2Å and a Ω angle respect the substrate) together with graphene periodicity (small scale protrusions with a periodicity of 2.4Å and rotated Φ respect Pt[110]direction). However, images scanning over large regions normally only resolve the Moiré superperiodicity, while the small corrugation due to the graphene lattice remains unresolved until high magnification images (smaller scanning areas) are used



Figure 2 5: STM images of the G/Pt(111) systems formed using C₆₀ as precursors at 1150K. a.100x100 nm² topographic image, V=400mV, I=0.2nA. The flat regions correspond to clean Pt(111) surface whilst the hexagonal corrugated regions correspond to the Moiré superstructures with different apparent angles. b. 50x25 nm² current signal error image, V=300mV, I=0.1nA. The smooth regions correspond to graphene with different rotational domains, whereas the clean Pt(111) regions look spiky in these imaging mode. c. 50x25 nm² signal error image, V=-100mV, I=2 nA.

Figure 2 5 shows STM images for submonolayer coverage where several domains are imaged on clean Pt(111) regions. Graphene forms different regions with superstructures characterized by the angle between the graphene rows and the Pt $[1\overline{1}0]$ surface direction. On the surface we found graphene regions with small periodicities ratio (i.e. (V3xV3)R30° and (V7xV7)R19°) coexisting with larger Moiré superstructures. The study of hundreds of atomically resolved STM images of G/Pt(111) prepared following the abovementioned recipe before revealed a system surprisingly rich in graphene superstructures, in contrast, for example, with the G/Ru(0001) system where mainly a single domain is developed. In Figure 2 **5** we see images where neither the Pt(111), neither the graphene are atomically resolved. Instead, we are able to resolve the periodicity and apparent angle -this is the angle formed between the $Pt[1\overline{1}0]$ and the Moiré superstructure- of the resulting Moiré superstructures. This is so, because we can estimate the directions of the Pt rows, i.e. $Pt[1\overline{1}0]$, using the directions of the atomic Pt steps that normally run parallel to these highly packed directions. It is important to remember that the images shown in this chapter are all obtained at room temperature.

However occasionally we obtain atomic resolution of graphene in addition to resolving the Moiré superstructure and, in exceptional cases - normally when using small tip-sample distances- we obtain atomic resolution of the clean Pt(111) surface. In **Figure 2 6** we show high resolution images of G/Pt(111); in **Figure 2 6 a** we see three different graphene domains coexisting with unresolved clean Pt whereas in **Figure 2 6 b** we see three different Moirés and atomically resolved Pt(111).

Although the coverage can be controlled by the deposition time of carboncontaining precursors and full monolayer growth can be achieved, we focused our work in the submonolayer coverage regime, as it seems to develop larger amount of superstructures. The large quantity of graphene Moirés developed on Pt(111) makes this system an ideal testbed for further molecular deposition. 1-3-5 Triazine deposition on G/Pt(111) showed that the (mostly electronic) Moiré corrugation does not takes an important role in the formation of ordered self assembled monolayers or in the molecular diffusion ³⁰. Further studies can use G/Pt(111) as a *graphene laboratory* and a source of surface templates of different sizes.



Figure 2 6: Constant current STM images of submonolayer graphene domains on Pt(111). Different graphene superstructures coexist together with clean Pt regions. **a**.14x14 nm², V=100 mV, I= 2 nA. **b**. 20x20 nm², V=10 mV, I=3.9 nA

2.2. Strain-driven Moirés of G/Pt(111): Phenomenological model

To describe these coincident structures we developed a phenomenological model based on geometrical considerations. The model that we propose is illustrated in Figure 2 7, where the black spheres correspond to a graphene lattice lying on a single Pt layer (blue spheres) oriented with the $Pt[1\overline{1}0]$ surface direction along the horizontal axis. After superimposing both atomic networks, with a relative angle between them denoted as Φ (the crystallographic angle, which in the figure is the one formed between black-dotted line and crystallographic $Pt[1\overline{1}0]$ direction), we observe a nearcoincident pair of atoms, i.e. a minimum distance between the carbon and the Pt spheres right below (enlarged in the inset at the top right of the image). The Moiré unit cell is then defined by these two orange points together with the atom at the origin (black lines); the Moiré forms another angle with the Pt[110] crystallographic direction: Ω , the apparent angle of the Moiré. The distance between these nearly coincident points, namely the mismatch between the graphene and the substrate, is never zero, but in some cases it is very small. Thus, each Moiré superstructure can be defined by the two angles described above, Φ and Ω , and by the size of the superperiodicity, L, associated with it. It is worth noting that the analysis of an atomically resolved STM image on a Moiré provides with the periodicity, L, but Ω and Φ values can only be precisely determined in small graphene islands (images as the ones shown in Figure 2 6 b) where atomic resolution on the substrate and layer is obtained simultaneously. Moreover, L and Ω may be coincident for some superstructures, only differing in the Φ , and therefore usually undetectable in the STM images.



Figure 2 7: Diagram of the model represented for the $\zeta G/Pt(111)$ superstructure. Pt atoms are represented by blue spheres whereas one hexagonal sublattice of graphene is represented by black spheres. The angle between the black dotted line and the Pt[**110**] surface direction (x axis) represents the crystallographic angle, Φ , which is equal to 25.1° for this particular case. The orange spheres are the carbon atoms with the lowest mismatch, which define the Moiré unit cell for a given Φ indicated by the black rhombus. The angle between the orange dashed line and the Pt [**110**] direction is the Moiré apparent angle (Ω). The white arrow in the inset represents the mismatch.

We describe the system by two overlaid hexagonal lattices corresponding to Pt (with lattice parameter a_{Pt} = 2.775 Å) and graphene (a_G = 2.46 Å). These are built from the same origin and the conclusions are independent of the considered origin. To represent graphene we used a simple hexagonal lattice instead of the honeycomb, as we are only interested in crystallographic coincidences. This counterintuitive result arises from the fact that the honeycomb lattice can also be described as two hexagonal networks shifted one from each other. As we only study crystallographic coincidences we restrain the possibility that the atom of the origin and the coincident position belong to the different hexagonal lattices of the honeycomb one. However, if we allow them, these extra coincidences gives rise to semi-periodicities, which offer no information about the real crystallography of the system and it can be seen as another proof of the non-equivalence between the two atoms of the graphene unit cell.

Thus, we define the position of any atom in the Pt(111) surface using a single vector defined for each lattice point by two integers n and m: $\mathbf{a}^{\text{Pt}}_{n,m}$. Similarly, we define the vector for the graphene lattice: $\mathbf{a}^{\text{gr}}_{i,j}$ (Φ). Where i and j are integer numbers and Φ is the crystallographic angle. This vector is the result of the product of a rotation matrix and the lattice vector. Now we compare both lattices by defining the mismatch, Δ :

$$\left|\Delta_{i,j}^{n,m}\right| = \left|\mathbf{a}_{n,m}^{Pt} - \mathbf{a}_{i,j}^{gr}(\phi)\right|$$

So for every Φ and any given graphene and platinum positions the mismatch defines the difference vector between them. The aim of the model is to find for every Φ the i,j,n,m values that minimize the modulus of Δ (see **Figure 2 7**) among all possible pairs. Usually, a particular pair of lattice positions (ij; nm) exists, that presents an extremely good coincidence

where atomic positions almost overlap, giving a $\left| \Delta_{i,j}^{n,m} \right|$ value close to zero and consequently they are good candidates to determine the Moiré parameters for that particular crystallographic angle. Therefore the strain (mismatch divided by the superperiodicity) of the superstructure comes, in our model, only from the strain of a single pair at the coincidence position. We applied the rotation transformation ranging from 0° to 30° with intervals of 0.05° on the graphene grid and we numerically analyzed the distances between any point in the Pt(111) lattice and any other in the graphene lattice (i.e. the mismatch) searching for the smallest possible mismatch for each angle Φ . Because of the symmetry of the system, this angular range covers the entire range of possible situations. We selected for every Pt lattice point the corresponding closest graphene lattice position. Among these values, we searched the pairs of points with a minimum mismatch for a particular Φ angle. We found that within this angular range there is usually an angle, Φ_m where $\left|\Delta_{i,j}^{n,m}\right|$ is at its absolute minimum and therefore at Φ_m the mismatch is the lowest

These curves follow a parabolic-shaped behaviour, as indicated in Figure 2 8, and can be regarded as existence or stability curves. Following the upward dispersion of one of those curves, there is a point where two adjacent curves cross. On the boundaries of this angular interval the solution 'jumps' to another pair of i'j',n'm' lattice points with a different minimum $\Phi_{m'}$ (corresponding to another parabolic curve). Figure 2 8 top represents those stability curves, *i.e* the relative mismatch as a function of Φ (we define relative mismatch as the strain per one graphene unit cell: Δ $/a_{gr}$). As the minima of the curves correspond to the angle Φ_m where the mismatch between the coincident points is minimized, the minimum of each parabola should correspond to a superstructure, being the modulus of the associated graphene vector the periodicity of the resulting Moiré (L), showed in **Figure 2 8** bottom as a function of Φ . We assume that the real system tries to accommodate the graphene overlayer with an angular orientation that accumulate the smallest strain, which depends on the mismatch of the best coincident position, as a consequence only the structures at the minimum of the stability curves will be found at the surface. Because our model only takes into account the coincident positions neglecting the rest of atoms, it suggests that the main interaction between the graphene and the substrate comes from the matching points. As we will see in the section 2.5 these results are in good agreement with the nucleation theory of graphene on Pt steps and subsequent growth where the crystallographic angle is determined by this strong bonding region.



Figure 2 8: (top and middle diagrams) Relative mismatch vs. crystallographic angle (Φ). The solid line indicates the minimum mismatch for the given angle. The dashed lines correspond to coincidence pairs with the lowest mismatch. The blue crosses indicate the stable structures of the model with positive mismatch (tensile strain), while the red ones represent the negative mismatch (compressive strain) phases. These phases are labelled with an associated Greek letter underneath. (bottom) Periodicity, L vs. crystallographic angle Φ .

We have denoted the calculated strain-mediated Moiré superstructure with Greek letters from the smallest periodicity - α G/Pt(111) to the biggest - oG/Pt(111). This model predicts the existence of 22 stable superstructures. However, only 15 of them are discernable with non-atomic resolution STM images, because for some of them, both their periodicity (L) and the apparent angle (Ω) are the same. All the structural parameters of the phases for the case of Pt are listed in **Table 2 1**. For a particular lattice

position defining a Moiré, we can have two types of mismatch. Δ can be either positive or negative. In the first case, the C-C distance might try to expand in order to commensurate the surface and therefore the layer will be under tensile strain, whereas in the second case the graphene layer may tend to decrease their size leading the layer to compressive strain and introducing in the system either a reduction of the C-C bond or the emergence of out of plane configurations. We have denoted in **Figure 2 8** the domains under tensile or compressive strain using labels in blue and red colour respectively.

We have presented in **Figure 2 8** the result of this calculation with a cutoff of the periodicity set to 23 Å since it is the largest periodicity we have found in the STM experiments. The cutoff is an important parameter in our model because it limits the maximum radius from the origin of the model where lattice positions are taken into account, constraining the L of the resulting solutions. In **Figure 2 9** we show a schematic representation of all the Moirés that come out from our model organized from left to right and updown by the crystallographic angle.

Figure 2 10 shows the result of classifying all the theoretically found structures in a periodicity vs. apparent angle plot. Every one of the 15 different superstructures of **Figure 2 9** has been represented in the **Figure 2 10** by a rhomboidal symbol. On the same plot we have marked the different experimental Moirés found after analyzing about hundred different graphene domains. The total normalized area for every domain is represented by a 2-D Gaussian. **Figure 2 10** shows that all the experimental determined structures can be associated with the 15 predicted ones. Interestingly, the more intense experimental points (the intensity is proportional to their frequency of appearance) are related to the lowest values of the relative mismatch in the stability curves and also to the lowest strains (see **Table 2 1**).

G/Pt(111)	Periodicity (Å	$\Phi_{m}(deg)$	Ω (deg)	Mismatch/a _{gr} (%)	Strain of the supercell (%)
α	4.9	30	30	4.7	2.36
β	7.4	19.1	19.1	1.7	0.57
γ	9.8	13.9	13.9	-6.6	-1.66
δ	11.3	10.9	0	7.2	1.57
з	13.7	9	0	-7	-1.26
ζ	15.4	25.1	8.9	-3.3	-0.53
ζ	15.4	7.2	8.9	-3.3	-0.53
η	17	4.7	25.3	6.9	1
θ	17.2	16.1	16.1	-4.2	-0.6
θ	17.2	22.1	16.1	-4.2	-0.6
θ	17.2	5.7	16.1	-4.2	-0.6
l	19.2	3.7	30	-0.4	-0.05
к	19.5	2.7	21.8	4.4	0.56
λ	20.1	26.1	13.9	5.4	0.66
λ	20.1	1.7	13.9	5.4	0.66
μ	21	0.8	6.6	3.1	0.36
μ	21	12.4	6.6	3.1	0.36
ν	21.9	2.1	19.1	-6.2	-0.7
ν	21.9	23.9	19.1	-6.2	-0.7
Ę	22.1	0	0	-2.1	-0.23
0	22.5	1.3	12.2	-6.5	-0.71
0	22.5	23.1	12.2	-6.5	-0.71

Table 2 1: Stable superstructures of G/Pt(111) extracted from the modeltogether with their important structural parameters, ordered withincreasing periodicity, L. The strain is defined as mismatch* a_G/L .



Figure 2 9: Schematic representation of all the stable Moirés coming out from our model. The crystallographic angle, apparent angle and periodicity appear above every scheme. The order of appearance corresponds to increasing crystallographic angle.



Figure 2 10: Periodicity vs. apparent angle for measured STM images of graphene islands (crosses) together with the predicted Moirés (rhomboidal ticks and Greek letters). The vertical and horizontal grey lines are the error bars of the experimental determination of periodicities and Moiré angles in STM images, respectively. 2D Gaussian shapes with intensity proportional to the experimental count of finding a Moiré with a given angle and periodicity are superimposed. The interpretation of the figure can be seen as a histogram where the colour intensity of a point is proportional to the occurrence of a structure.

The agreement between the experimental domains found with STM images and the theoretical phases predicted with our model is very good. In fact, all the experimental phases can be related to a theoretical minimum. **Figure 2 10** shows that there only exist three exceptions that we have not found in the experimental STM sessions. The ι G/Pt(111) is in our model the structure holding the lowest mismatch (see **Figure 2 8** top). Thus, following our previous discussion it should be the most stable phase, and consequently, also the most commonly observed one. However, we have never identified it. This does not mean that it does not exist, but that its stability (evaluated by its probability of appearance) is not connected to the relative mismatch. Nevertheless this structure was atomically imaged by Sasaki *et al.*³¹ Moreover, we have never observed the superstructures labelled as δ and η . This can be related to their high value of the mismatch (see **Figure 2 8** top), which would lead to less stable structures and therefore less frequently observed. It is remarkable that both structures hold values of the relative mismatch around +7%, and therefore this could be taken as an approximate upper limit of the compressive strain that can be accommodated in the layer.

This model also predicts the formation of Moirés on other hexagonal surfaces different than Pt. We have calculated the stability curves for the hexagonal faces of Ir, Ni, Co, Cu, Pd, Rh and Ru finding the most stable phases after our model correspond to the ones reported in literature. Thus, in Ir(111) 4 Moirés have been reported ²² and 6 superstructures were recently observed on Pd(111) ¹⁵. We have reproduced the four reported periodicities, their crystallographic and apparent angles for Ir(111) and five out of six for Pd(111). Moreover the stability curves (as the one shown in **Figure 2 8**) calculated for Ir and Pd predict superstructures holding minimum mismatch for various angles that have not been reported. We suggest that the use of polycyclic aromatic hydrocarbons as graphene precursors and low temperature annealing may lead to the formation of other unreported phases, as in the case of Pt(111). (See Appendix I)

At a first glance, the domains exhibiting compressive strain shall stretch or experience out-of-plane configurations, whereas the ones submitted to tensile strain might try to enlarge the C-C bond distance. Thus, the measured corrugation for the Moirés with negative mismatch (blue labels in **Figure 2 8**) shall be exclusively correlated to electronic effects. However the relation between the sign of the mismatch and the nature of the experimentally determined corrugation (electronic or topographic) should be treated carefully since other processes can eventually favour the emergence of topographic corrugations in the tensile-strained Moirés. Full DFT calculations for these particular structures combined with good-quality STM and AFM measurements could confirm this point.

The good agreement of our model with the experimental data for all transition metals suggests that the weak interaction between the Pt(111)

surface and graphene is sufficient enough to force the system to accommodate into some fixed number of orientations, which minimizes the relative mismatch. The existence of phases with large mismatches leads to the question of how the stress is released throughout the superstructure unit cell. It seems obvious that mismatch accumulation will lead, sooner or later, to interrupt the order of the Moiré unit cell, and therefore they would not be stable. Phases as y would never be observed because, after a few unit cells, the coincidence structure would disrupt. However, this is not the case and for instance this particular structure is found in extended domain sizes, indicating a full release of the stress within the periodicity of the Moiré. Therefore our model confirms that the stability of the Moiré structures on TM surfaces emerges by the interplay of the local interaction between single C and TM lattice positions, likely due to a favourable adsorption structure, as it has been proposed for Ru by DFT calculations ³² ³³. This is the reason why our model fits better to the relative mismatch than to the total strain of the superstructure (Δ /L) and therefore, some high strained phases in the superstructure present relatively high occurrence, like γ or ε phases.

We would like to remark that although most of the strain seems to be relaxed within the Moiré unit cell, this has not a clear relation with the crystallographic unit cell, and some of them could correspond to incommensurate superstructures. The analysis of the commensurability of a superstructure cannot be performed with our geometrical model. Nevertheless, the simplest explanation can be that it exists a second order (or higher) Moiré unit cell with a lower mismatch, longer periodicity and possibly a different apparent angle. The real system would tend to relax completely inside this crystallographic supercell. Atomically resolved images of large regions or X-ray diffraction could confirm this point.

2.3. Structure of (V3XV3)R30°, αG/Pt(111), or (2x2)_G

A different way to release stress is to induce a reconstruction on the Pt(111) surface. We have found that the formation of an ordered network of Pt vacancies at the outermost layer leads to an energetically stable structure compatible with the STM images for the (V3XV3)R30°, or α G/Pt(111) structure ²⁷.

We find that the $(\sqrt{3}x\sqrt{3})R30^{\circ}$ structure appears in large areas sometimes covering the whole terrace length (up to 100 nm). The $(\sqrt{3}x\sqrt{3})R30^{\circ}$ phase coexists with Moiré regions of different periodicities in the form of crystalline islands (see Figure 2 11 a), and it has never been found isolated ²⁴. Figure 2 11 c shows a detailed STM image where the atomic features forming the (V3xV3)R30° reconstruction are clearly identified. These images are characterized by bright points and depressions aligned along the [112]surface crystallographic direction. This structure exhibits in the STM images a large atomic corrugation, ranging from 0.60 to 0.15 Å, about 5 times higher than those we obtained for the corresponding Moiré regions at the same conditions (< 0.1 Å). Since electronic effects are important in the image appearance, the atomic assignment of the STM features shown in Figure 2 11 c is not trivial and requires the use of first-principles calculations. After trying many different structures (including lateral shifts in the graphene layer, extra carbon atoms, and vacancies in both layer and surface) our best-fit model is depicted in Figure 2 11 b and c. In this model one surface Pt atom is missing per (V3XV3)R30° unit cell, and the rest of the Pt atoms are alternatively in top or hollow positions with respect to the graphene layer.

Our DFT calculations show that graphene binds more strongly to the platinum surface in the presence of vacancies. The interaction becomes three times larger (-0.60 eV/per unit cell), and the bond length between the C near a top Pt shortens to 2.28 Å (see **Figure 2 11**, side view). The remaining seven C atoms in the unit cell relax outwards, producing a maximum buckling in the C layer of $\Delta z = 0.2$ Å. The outermost Pt layer goes from expansion to -8.1% contraction, while deeper layers stay around ±1.0% their bulk-like distances. For the simulated STM images we needed to include multiple scattering terms in order to obtain a good agreement with the experimental observations.



Figure 2 11: a. 12.4x12.4 nm² STM image showing an island of atomically resolved (V3xV3)R30° or αG/Pt(111) inside a bigger domain of µG/Pt(111) Moiré. **b.** Top view (left) and side view (right) of the structural model derived from DFT calculations for the (V3xV3)R30° reconstruction. Smaller sizes on the orange spheres represent deeper atoms. **c.** STM images (V=0.1 V) for the (V3xV3)R30° experimental (left) and DFT best fit simulation (right). A schematic atomic model of where the Pt vacancy network is placed has been overlaid.

From an experimental point of view this graphene orientation is one of the most commonly observed superstructures occupying an area of around 10-15% of the graphene area while it has a relative large strain as deduced from our phenomenological model (see **Table 1**). The strain of the supercell, defined as the mismatch divided by the periodicity of the supercell is 2.36%, making this structure the most unlikely to be stable of all the superstructure that came out from our model. We believe that the surface reconstruction through an ordered vacancy network is an atomic mechanism that stabilizes the system in an energetically more favored atomic configuration.

The formation of vacancies on metallic surfaces upon C_{60} deposition normally followed by a soft annealing- is a well known process in a wide range of transition metals. It was first discovered after investigations by means of surface X-ray diffraction on the (V13xV13)R13.9° reconstruction of C_{60} /Pt(111) ³⁴, but the mechanism was previously proposed for the (6x6)- C_{60} /Al(111) ³⁵ reconstruction. Since that discovery, many experimental and theoretical efforts have successfully been performed in the search of atomic vacancies on metallic surfaces. Nowadays it is believed that the formation of vacancies on close-packed metal surfaces upon C_{60} deposition is the rule rather than the exception ³⁶. The formation of vacancies structures might also be a mechanism of stress relaxation in some graphene superstructures and determined rotational domains, as in the case of $(\sqrt{3}x\sqrt{3})R30^{\circ}-G/Pt(111)$ and the reason why some Moiré structures are more common than others.

2.4. <u>Structure of (V7XV7)R19^o, βG/Pt(111), or (3x3)_G</u>

The most commonly observed graphene superstructure on Pt(111) is the (V7XV7)R19° Moiré. This Moiré is very characteristic as it is one with the smallest periodicity (7.4 Å) and it corresponds to a graphene $(3x3)_{G}$ commensuration. Again, this is only the average distance and because it is a pseudo-periodic structure, these numbers must be taken with caution (for example in DFT calculations). In Figure 2 12 we present four STM images of this Moiré obtained under different tunneling conditions (more precisely, different bias voltages). It becomes clear that this structure shows a bias dependence under STM imaging. The closer we are to the Fermi level, the narrower the bright features. This behavior might be an indication of the graphene-metal interaction as a similar behavior has been observed for the highly interacting system G/Ru(0001)⁸. It is important to recall that the interaction between G and Pt has been described to be much smaller than for Ru²¹. Nevertheless freestanding graphene would never present a hexagonal symmetry disruption in its density of states that could lead to the observed bias dependence behavior, and therefore we can conclude that in this rotational domain, G-Pt interactions are taking a role.



Figure 2 12: Series of 2x2nm² STM images of the (V7XV7)R19^o Moiré taken at different bias voltages. The bias is written in the upper part of the image. The bias dependence is clearly seen as the bright pockets get narrower near the Fermi level.

We have also performed DFT calculations of this system. These calculations involve a large number of atoms and thus they are very demanding on computer power. The theoretical framework used for this system is as follows: First the graphene unit cell of periodicity (V7XV7)R19° on Pt (111) is set free to relax with regular DFT under the FIREBALL package. Once the system's energy minimum is found (i.e. the calculation converges) we use the relaxed structure as the departure point for calculating the van der Waals corrections using plane waves. When these two steps are performed we consider that the system correctly includes all the physical interactions.

Van der Waals corrections leads to a decoupling of the graphene layer from the substrate and an increase in the G-Pt distance up to the final value of 3.1Å (distance between the lowest C atom un the upper Pt atom) where the layer stabilizes with a geometrical buckling of the graphene layer of 0.23 Å. The lowest part in the Moiré, darker regions in the STM images, is placed on top of the underlying Pt atoms. In **Figure 2 13 a** we present an extended representation (four times repeated the unit cell) of the resulting structure together with its simulated STM image. We can observe that the simulated STM image reproduces the $(3x3)_G$ periodicity perfectly and that the agreement with the experimental images is fairly good. The high regions are triangularly shaped features. These high parts are separated by darker regions.



Figure 2 13: Extended structure of the $(\sqrt{7}X\sqrt{7})R19^\circ$ Moiré. **a**. Ball and stick model of four contiguous unit cells .**b**. Simulated STM image at 0.1V bias for the extended structure where the $(3x3)_G$ periodicity is clearly resolved together with an experimental image taken at 0.1V.

2.5. Edges between graphene and Pt(111) steps and its relation with <u>Moirés</u>

The following STM images are represented in false color to allow for an easier interpretation. In this color scheme, blue regions stand for clean Pt(111) regions while grey regions stand for graphene.

Graphene theoretically is an infinite 2D material. However in real systems this is not feasible. The terminations of the flakes or terraces – the graphene edges- rarely are amorphous and normally present large straight regions following some crystallographic directions. The most common ending of graphene edges are the so called zig-zag and armchair endings, this is true for graphene from HOPG ³⁷ and also for epitaxial graphene on metals ²⁵. In **Figure 2 14** we present an example of these terminations. Moreover, when growing epitaxial graphene on metal substrates we have the possibility to study not only the edges "flying freely" on the lower substrate terrace (*step-like* edges) but also those bound to the upper terrace of the substrate (*border-like* edges).



Figure 2 14: Schematic representation of the different graphene edges. **a**. zig-zag and armchair .**b**. border-like, bounded to the uppermost terrace and step like, lying on top of the bottom terrace.

The -rather good- agreement between our phenomenological model presented previously, and the experimentally found Moiré superstructures

needs a deep discussion in order to find out the physical processes that are involved in the stability of the Moirés. In principle the validity of the model might suggest that the whole pseudo-unit cell of the Moiré is an energetically favored entity over any form of incomplete supercell. We can establish this from the fact that epitaxial graphene islands are normally holding full unit Moiré unit cells on their boundaries, rather than amorphous termination. Although we can also find islands terminations finishing in incomplete unit cells (see for example the upper domain of Figure 2 6 a) the rule is that islands are hexagonally shaped. This might indicate than there are pinning points in the unit cell where some atoms of graphene interact strongly with the substrate. Recent high temperatures STM investigations during graphene growth on Rh(111) show that a growth mechanism exists where the graphene layer increases its area by discrete adding of single Moiré unit cells. Another way to see it is that they grow following the crystallographic directions of the Moiré³⁸, thus opposed to the dendritic growth of, for example surface carbides 39 .

Although the stability of the Moiré pseudo-unit cell might be favored over other possible configurations, it remains the question of why, and how, does the graphene form rotational domains on Pt(111) and other metals. On most hexagonal transition metal surfaces graphene grows with a crystallographic angle of 0°, this means that the graphene and the substrate crvstallographic directions are aligned and the resulting superstructure has to accommodate the strain coming from the difference between the lattice parameters of G (2.46 Å) and the surface Moiré lattice constant in a configuration typically of the form $(n \times n)_{Pt} - (n+1 \times n+1)_{G}$. This, so called aligned Moiré, also exists on the Pt(111) surface as the {G/Pt(111) phase or $(8\times8)_{Pt}$ – $(9\times9)_{G}$ structure, but it is not as common as, for example, on Ir(111) or Ru(0001), where most of the experimental results refer to this aligned Moiré superstructure. The question of why the graphene layer acquires a non-zero angle is not trivial. In principle, it might be possible that the rotation arises from kinetics effects during annealing. Then when the annealing is turned off the layer evolves to the crystallographic angle corresponding to the local minimum closest to its angle.

A second possible explanation of why our simple model works is not related to kinetic effects but rather to energy considerations of the atomic bonding configurations during the nucleation of the graphene islands. It is not clear whether or not graphene nucleates following the same time sequence on different metal surfaces and several mechanisms have been theoretically and experimentally proposed ^{39 40}. Nucleation on step edges is one of these

possible mechanisms. Thus, the bonding between the island and the graphene edge seems to determine the periodicity of graphene on $Ir(111)^{41}$. In the present section we demonstrate that this is also occurring for the case of G/Pt(111) and that our phenomenological model can be seen as a procedure for determining the possible stable edge structures and thus the most likely Moirés to be formed.

STM analysis of several G-Pt(111) edges reveals that the –rather largeamount of stable Moiré superstructures on Pt(111) can be correlated to the crystallographic border edges of the graphene islands. Rotational domains seem to nucleate on Pt steps through chemical bonding of the outlying atoms of the graphene islands with the Pt atoms on the substrate step. This strong binding fixes the particular orientation which determines the crystallographic angle. The sheet thus continues its growth in this direction.

Analogous to the standard notation used for nanotubes, we can denote the crystallographic interfaces with a couple of chiral vectors (defining a chiral vector as for nanotubes: two integers n and m denote the number of unit vectors along the two crystallographic directions of the surface crystal lattice) one for Pt and other for the graphene (edge). With this notation, the edge shown in Figure 2 15 between Pt and G, can be denoted as $(1,2)_{Pt}(3,0)_G$ (see the eye guide in the inset); this is the interface between the $(\sqrt{7}x\sqrt{7})R19^{\circ}$ -G/Pt(111) Moiré (also called $(3x3)_{G}$, or β G/Pt(111)) and a Pt step. Other Moirés-Pt interfaces have different pairs of vectors in the form $(n,m)_{Pt}(i,j)_G$. We believe that any stable Moiré must possess a combination of vectors satisfying our phenomenological model ¹⁷. Thus our model is in a first approximation of the possible pairs of existing chiral vectors which minimize the strain and thus the most likely to be stable. However we have noted that some defective zones in the G-Pt interface might appear obscuring the crystallography of both, the edge and the Moiré of the island that is attached to it.



Figure 2 15: High resolution, atomically resolved, STM images of the *BG/Pt(111)-Pt(111)* interface. These crystalline edges are energetically favored and might be determinant in the orientation of the possible Moiré superstructures. 12.6 x 6.8 nm², V=40.2mV, I=5.2 nA. The inset shows the chiral vectors of this particular edge.

The study of the crystallographic parameters of the Moiré superstructures by STM images is a difficult task, because simultaneous atomic resolution in both graphene and metal surface is required. It is important to notice that normally STM images lack the information about the commensurability of the Moiré superstructures. Even though we could say that near the graphene-Pt interface the structure is commensurate, nothing could be said about zones far apart from the edges, as the accumulation of mismatch will either disrupt the long range order of the Moiré superstructure or induce defects – such as, for example, ripples, vacancies, or domes. In **Figure 2 16 a** we see a small epitaxial graphene island grown attached to a Pt step; as usual, it is hexagonally shaped and it appears with part of its area inside the upper Pt step, indicating some form of mass transport during graphene growth. Looking carefully to the upper left part of the image we see what does look like a graphene nanobubble. The mismatch accumulated in such a small island promotes the formation of a $6x3nm^2$ nanobubble.



Figure 2 16: a.*STM image showing a graphene island, a nanobubble can be seen in the upper part of the flake.* 34x34nm², 1.9nA, 100mV. **b.** Detail of a crystalline edge with a graphene zig-zag termination, 10x10 nm², 3.94nA, 10mV. **c**. Detail of a crystalline edge with a graphene zig-zag termination, 10x10 nm², 3.94nA, 10mV.

Figure 2 16 shows STM images of 3 border-like resolved crystalline edges giving rise to other Moiré superstructures. **Figure 2 16 b** and **c** correspond to Moiré patches of $\{G/Pt(111) \text{ and } \mu G/Pt(111) \text{ respectively}$. Using the chiral vector notation introduced before, these edges correspond to these pairs of vectors: $(8,0)_{Pt}$ $(9,0)_G$ for **b** and $(7,1)_{Pt}$ $(8,1)_G$ for **c**. These edges involve large number of atoms, and they exceed the capabilities of regular DFT calculations (contrary to the edge in **Figure 2 15** that will be discussed in detail later). However, optical inspection gives some interesting information about morphology and stability aspects of these bigger G-Pt edges. At the first glance it seems graphene ends preferentially on a zig-zag configuration. Hence the Pt atoms adopt the configuration maximizing the graphene ending in zig-zag configuration, the last carbon atoms in the graphene flake structured in a zigzag edge; this leads to a situation where the graphene crystallographic directions are parallel to the Pt outer atoms.

Figure 2 17 illustrates this point. In this figure we have schematically reproduced edges similar to ZZ3 and ZZ4 of **Figure 2 16**, another hypothetical ZZ edge (called ZZX) and an amorphous edge (A). Graphene prefers to stabilize its edges by maximizing the number of the -energetically favored- zigzag edges. The amount of the armchair regions needed in the interface (marked in the figure by a red oval) depends on the angle between G and Pt (and therefore the angle between the Moiré and the Pt). We observe that the more often found graphene edges are those which have maximized the number of zigzag units versus the armchair, thus, in **Figure 2 17**, ZZ4 will be preferred over the A edge (although both are rotated of 6^o). Termination A is exclusively observed in defective regions of the G-Pt edge.

The fact that the system tends to maximize the number of C atoms ending in zig-zag configuration for a given edge has an interesting secondary effect. This tendency in the edge stability induces, in the overall distribution, Pt edges ending parallel to the apparent angle of the Moiré. This means that if we ignore the local relaxation of individual Pt atoms, the overall imaginary line between graphene and Pt is parallel to the Moiré high symmetry axes. This might look simple, but involves that –normally, and in absence of defects- the Pt-Graphene edge is not parallel to the graphene crystallographic directions or to the Pt ones. This can be very useful for determination of the structure of unknown rotational domains with large scale STM or AFM images, even when the periodicity of the Moiré is not resolved. One has to measure the angle between the G-Pt edge and the clean Pt steps, then go to the list of Moirés and find which of them possess that particular apparent angle. However, one has to be very careful if using this method for Moiré determination, as –according to our model- there are normally more than one Moiré with a similar apparent angle, i.e. there are more than one rotational domains with different crystallographic angles yielding Moirés with different atomic structure but the same apparent angle ¹⁷.



Figure 2 17: Schematic model of the preferred graphene termination of border-like at the G-metal interface. The blue side corresponds to the Pt region, with crystallographic direction, indicated by a blue arrow, along the horizontal (except for ZZ3, where it is along the vertical). The graphene tends to adopt zigzag configurations by minimizing the number of armchair unit cells for a given crystallographic angle with respect to the Pt surface. Armchair configurations are marked with red ovals.
In the case of the edges between $(\sqrt{7}x\sqrt{7})R19^{\circ}$ graphene and Pt described in the next section curiously the apparent angle and the crystallographic angle are both the same, i.e. 19°, and thus it wrongly seems that the edges are parallel to the crystallographic directions of graphene. The cases of **Figure** 2 16 a and c or the cases of the islands shown in Figure 2 18 are the rule. The edges run parallel to the Moiré crystallographic directions – if one can talk of crystallography of a Moiré. One can notice that the edge shown in Figure 2 16 b is an exception. In this interface the Moiré runs parallel to the edges of the small triangular protrusions appearing at the interface but seems perpendicular to the overall landscape of the edge. We believe this because the Moiré is the so called (G/Pt(111)) or $(8x8)_{Pt}$ – $(9x9)_G$, and is the exceptional case of the aligned Moiré (where the crystallographic angle is 0). According to the rules that we observe for the rest of Moirés the normal edge would be a structure running parallel to both Pt[110] and the graphene high symmetry direction in straight line. This structure would be straight both in Pt and G and might accumulate high amounts of strain leading to a highly unstable structure. The edge then might relax in the peak protrusion that can be seen in **Figure 2 16** to minimize its energy.



Figure 2 18: STM images showing graphene edges running parallel to their Moiré apparent angles. Nanobubble or graphene folds can be seen in the islands. **a**.30x30nm², 2nA,-100mV. **b**.30x25nm², 1nA, 50mV.

The apparent angle of the Moiré is the same as the angle of its edge in most cases, a relationship between the growth of a determined Moiré and the crystallographic border-like edges exists and they may be an important

factor in the determination of the permitted orientations of graphene epitaxially grown on Pt(111). However it is important to notice that other kinetic effects, such as the formation of defects or folds due to the shrinking occurring during the cool-down after the growth annealing (arising because the differences in thermal expansion coefficients between graphene and the substrate) may take also a role in the determination of the atomic configuration of the final shape of the edges.

2.6. <u>1D sublattice electronic states in (V7xV7)R19° G-Pt(111)</u> <u>boundaries.</u>

Among all the crystallographic edges that we have experimentally determined, we have analyzed in detail one of them. This is the case of the lateral interface between (V7xV7)R19° G/Pt(111) and Pt(111). This Moiré reconstruction is the second smallest of all the possible on Pt(111) and thus it is affordable for first principles calculations. Understanding the connection of graphene with metal surfaces is a necessary step for developing atomically-precise graphene-based technology. Combining high resolution RT-STM experiments and DFT calculations we have unambiguously unveiled the atomic structure of the boundary between a graphene zigzag edge with $(\sqrt{7}x\sqrt{7})R19^\circ$, or $\beta G/Pt(111)$ and a Pt(111) step. This graphene edges minimize their strain by inducing a 3-fold edgereconstruction on the metal side. Moreover we have determined the theoretical electronic structure and we have found the existence of an unoccupied electronic state localized in the edge C atoms of one of the two graphene sublattices. This state extends few angstroms, thus few unit cells, inside the graphene layer.

The exceptional electronic properties of exotic graphene structures with a low dimensionality has recently attracted the attention of the scientific and technological community as possible basic components in future atomically-controlled graphene-based nanoelectronics ¹² ⁴². The breaking of the 2D periodicity in the presence of topological defects or in strain relief structures modifies significantly its electronic properties ⁴³ ⁴⁴ ⁴ ⁶. In particular, graphene nanobubbles have been suggested to present pseudo-magnetic associated landau-levels ⁴², electronic one-dimensional edge states have been revealed to be localized in graphene nanoribbons ⁴⁵ and missing atoms have been proposed as a source of carbon magnetism ⁴⁶. Thus, these recently developed nanoarchitectures could open the door to tune the electronic transport properties of graphene-based electronic devices by ribbon, boundary or defect engineering.

Graphene edges, rich in exotic properties, are a central in this effort. Electronic transport through grain boundaries of polycrystalline graphene ⁴⁷ or graphene nanoribbons (GNRs) have been extensively studied ^{48 49}. Theory predicts that the electronic properties of the edges can be tuned by the orientation of its ending (zig-zag, armchair, mixed), possible reconstructions (pentagonal, heptagonal and higher order rings), and their chemical functionalization (normally H passivation) ^{50 51}. Electron microscopy

experiments were the first to provide a structural characterization of graphene edges with atomic resolution using either aberration-corrected TEM images ⁵² or scanning transmission electron microscope (STEM) ⁵³. STM measurements based on graphene patches deposited on different substrates ^{45 54 55 56} added the possibility to correlate the structure with the local electronic properties. Even though atomic resolution was achieved in those experiments, STM was unable to reveal the details of the edge termination due to the interaction with the substrate. Only recently, Zhang et al ⁵⁷ have shown that hydrogen plasma etching of the nanoribbons induces hydrogen-terminated rough edges that lie flat on the substrate and where different endings (zigzag, armchair, chiral) can be resolved. STM experiments based on graphene islands grown directly on a metallic substrate ⁴¹ offer the possibility to study not only the edges "flying freely" on the lower substrate terrace (step-like edges) but also those bound to the upper terrace of the substrate (border-like edges). Although this study was able to show a correlation between the atomic corrugation at the graphene edges with the Moire pattern of Gr/Ir, an atomically precise description of graphene contacts with metallic substrates was still missing.

In this section we provide a combined experimental-theoretical atomistic description of the contact region formed along the interface in a graphenemetal heterostructure and we unveil its electronic properties. We have been able to obtain high-resolution STM images of atomically resolved *border-like* edges of ($\sqrt{7}x\sqrt{7}$)R19° graphene on a Pt(111) step. We have combined these detailed experimental results with DFT simulations to fully characterize the atomic structure of the Pt-graphene edges and to understand their electronic properties. This approach reveals the presence of 1D electronic highly localized state in one of the graphene sublattices. Theory predicts, and constant height STM images confirm, that this state is mainly confined on the first carbon atomic lines of the edge.

The topographic STM image on **Figure 2 19 a** shows a graphene island which grows attached to the upper part of a Pt(111) step. The usually straight Pt step-edge has been altered from its original shape during the graphene growth. In this image, half of the graphene island is embedded in the upper terrace, adjusting itself to the crystallographic directions of the substrate. This morphology indicates significant mass transport of Pt atoms during graphene growth and differs from the structures reported for graphitization on other metal surfaces, such as $Ir(111)^{16}$ or $Ru(0001)^7$, where graphene grows over the metal steps without altering the metal substrate.





Focusing now on the structure of the island, three different rotational domains of graphene separated by non-periodic grain boundaries can be clearly identified. The upper domain in **Figure 2 19 a** corresponds to $(\sqrt{7}x\sqrt{7})R19^{\circ}$, $(3x3)_{G}$, or $\beta G/Pt(111)$. Its crystallographic angle is 19.1° with respect to the surface $[1\overline{10}]$ crystallographic direction, which in the image runs parallel to the vertical direction, and it exhibits a superstructure periodicity of 7.38 Å ¹⁷. The middle domain is rotated 8° and presents a periodicity of 12.6 Å; it most likely corresponds to $\epsilon G/Pt(111)$. Finally, the lowest domain is small in size and unfortunately, we were not able to attain Moiré resolution to deduce the graphene orientation.

The upper (V7xV7)R19° domain exhibits a polygonal shape with four *border*-*like* and four *step-like* edges ⁴¹. In order to enhance the resolution on the graphene boundaries we have recorded current-error STM images. Both, STM topographic and current-error images show the same atomic features on the same positions, but the latter mode allows an enhanced resolution.

In **Figure 2 19 b** we see the high resolution current-error STM image of the region marked with the black square in **Figure 2 19 a** (drift corrected for avoiding thermal distortions of the image), we achieved atomic resolution not only on the Pt(111) terrace and the island but also on the interface. In this particular region, we find three different *border-like* edges where graphene binds to platinum atoms of the step edge.



Figure 2 20: Atomically resolved current (signal-error) STM images of: ZZ1) the zigzag edge number 1; $I_t = 5.2nA$, $V_s = 38mV$; A 1) the amorphous edge number 1; $I_t = 2.4nA$, $V_s = 42mV$, the arrow indicates the Pt[$\overline{110}$]direction; ZZ 2) the zigzag edge number 2; $I_t = 3.8nA$, $V_s = 47mV$; and A 2) the amorphous edge number 2; $I_t = 5.2nA$, $V_s = 38mV$. Blue/grey regions are identified by the lattice symmetry to be Pt/G respectively. A boundary region of 3-4 atomic rows is also clearly observed with atomic resolution. These images have been drift corrected and FFT filtered.

High-resolution current signal-error STM images allow a systematic characterization of all of the different border-like edges on the $(\sqrt{7}x\sqrt{7})R19^{\circ}$ graphene Moiré shown in **Figure 2 19 a**. These results are shown in **Figure 2 20**, where edges have been labeled as ZZ (for a zig-zag graphene ending) and A (for an amorphous or armchair configuration). Border A1 is parallel to the $[1\overline{10}]$ Pt crystallographic direction while borders ZZ1 and ZZ2 run along the $[3\overline{21}]$ and $[1\overline{32}]$ directions respectively, forming 19° and 41° degrees with the $[1\overline{10}]$ direction. A1 and A2 edges present a disordered structure whereas the other two, ZZ1 and ZZ2, are crystalline at both sides. A2 border presents a mixture of armchair and zig-zag termination.

Edges ZZ1 and ZZ2 show regions that can be unambiguously assigned to Pt and G (blue and gray colored areas on Figure 2 20, respectively) and a boundary area, of 3-4 atomic rows, where the atoms although clearly visible cannot be directly ascribed to Pt or C (gradient colored area). Only Ab-initio simulations based on DFT for a similar graphene flake attached to a Pt step allow a full understanding of these edges. Figure 2 22 shows the main results of these calculations performed by the Scanning Probe Microscopy Theory & Nanomechanics Group of the UAM. Starting from different initial structures for the G-Pt interface, we have obtained a stable configuration where the stress induced in the graphene-Pt junction has been relaxed with a rearrangement of the outermost Pt atoms of the singleatom step (see Figure 2 22 a and b). The unit cell of our system involves three non-equivalent Pt atoms directly bonded to graphene. To allow for a better visualization we have marked them with blue, red and green colors. These Pt atoms undergo both out-of and in-plane displacements. The red Pt atom on Figure 2 22 protrudes 0.65 Å out of the Pt terrace plane and it moves laterally from its original position ~1 Å towards the graphene forming a bond with an unsaturated C edge atom. As a result a hole is created on the Pt side. This can be visualized in Figure 2 22 a as the vacant region beneath the red Pt atom. The blue and green Pt atoms also passivate one outermost C atom each but they show lower strains and displacements, the more significant being the -0.15 Å out-of-plane displacement (inwards relaxation) of the blue atom on Figure 2 22.



Figure 2 21: Ball and stick model of the DFT relaxed structure compared with the false colored STM image. The atomic positions of the calculations reproduce with great accuracy the protrusions in the STM images .

This atomic structure mimics with great accuracy the atomically resolved experimental STM images (see **Figure 2 21** and **Figure 2 22c**). The strain induced on the Pt side is localized mainly on the outermost Pt atoms and only slightly propagate to the 2^{nd} Pt row. While free-standing zigzag edges should undergo reconstruction, no relevant rearrangement is observed on the graphene side in the theoretical results. The three external C atoms of the zigzag edge are covalently bonded to the metal step, keeping their graphene-like positions. This covalent interaction between graphene and Pt, already theoretically proposed for Cu, Co and Ni(111) surfaces ^{40 58 59} and observed with STM on G/Ir ⁴¹, passivates the graphene dangling bonds and stabilizes the zigzag structure ⁵⁸. Our calculations have found another stable configuration where the stress is relaxed on the graphene edge instead of on the Pt side, although with worse matching with the experimental images.



Figure 2 22: a and b. Ball-and-stick model of the atomic configuration of graphene on the Pt(111) step edge calculated with DFT. Bond distance, a, and out of plane displacement, b, of the Pt edge atoms are indicated. c.
Overlay of the relaxed structure with the STM image for edge ZZ1. d. Local density of states (LDOS) for the 1st (red), 2nd (blue), 3rd (green) and 4th (pink) rows of carbon atoms belonging to the same sublattice and for the 1st (orange) one of the other sublattice. An electronic state at +0.8 eV above E_F is clearly observed only in one sublattice and is mainly localized on the edge row. e. Local density of states (LDOS) for the C atoms (solid red) versus the same atoms in a step without a graphene flake attached (dashed red). The same localized electronic state shown in c can be observed in the Pt atoms of our Pt-C system but is absent in the bare Pt step

The good match between the calculated atomic structure and the experimental STM images motivate us to characterize the electronic structure at the edges by calculating the local density of states (LDOS) associated to this nanostructure. Figure 2 22 d shows the calculated LDOS for the first carbon rows. A localized state ≈0.8 eV above the Fermi level, with a FWHM of 0.2 eV, is found at the carbon atoms bonded to Pt. This state decays strongly in intensity when moving away from the edge. Furthermore, it is exclusively localized in one sublattice: the LDOS of the neighboring C atoms (orange curve in Figure 2 22 d), belonging to the other sublattice, does not show any trace of this state. The position of the peak with respect to the Fermi level and the decay length are similar to the ones

associated with a single atom vacancy on graphene on Pt ⁶⁰. Looking at the Pt side of the edge, we have found that the LDOS projected on the Pt row closer to the interface shows a peak at the same E_F +0.8 eV energy. This peak is not present in the LDOS of the pristine Pt step, indicating that the G-edge state spreads out inside the Pt (see **Figure 2 22 e**). Our calculations do not show any magnetism associated with the G-Pt edge. Free-standing graphene edges are characterized by the presence of a localized state at the Fermi level, which is responsible for the magnetic moment predicted for this system. In our case, both the charge transfer and the strong G-Pt interaction broaden this peak and shift it towards positive energies. As a consequence, the magnetic moments are quenched, similarly to the case of point defects on G/Pt ⁶⁰.

This electronic state has to be reflected in the empty-states STM images, and this is indeed experimentally observed. In **Figure 2 23 a**, we show a topographic STM image where a modulation of the intensity parallel to the border-like edge is clearly visualized. The distance between the lines corresponding to the maxima is 2.4 Å (see the height profile in **Figure 2 23 b**), as corresponds to the fact that the edge state is exclusively confined in one of the two sublattices. Experiments show that after 4 lines the state fully disappears. This state, decaying away from the interface and localized in one of the sublattices, is also visible in the STM image of the ZZ2 edge in **Figure 2 22**.



Figure 2 23: a. 13.4x6.9 nm² Topographic STM image of a border-like edge where an excess of charge is visualized parallel to the interface in the first three rows of graphene $V_s = 51mV$, $I_t = 4nA$. **b**. Detail of such 1D states and height profile.

Interestingly this state is localized both in energy and real-space. It vanishes as we move out of the interface. Therefore it can be considered as 1D electronic states associated to each of the graphene sublattices. These electronic states confined to specific sublattices of the graphene structure open new opportunities to future atomically precise graphene based electronics and valleytronics ^{61 62}. For instance new multichannel nanowires could be built by contacting the opposite sides of a graphene flake with two different border-like edges. These atomically precise nano-leads will excite respectively each one of the two graphene sublattices, allowing two-ways atomically controlled transport via these independent electronic states (see **Figure 2 24** for a schematic speculative proposition of a multichannel graphene nanowire).



Figure 2 24: Sketch showing a speculative two-channel conductor using a G nanoribbon and atomically precise G-Pt contacts.

2.7. Strain relief mechanisms: 0D,1D and 2D/3D defects.

In the present section we change the topic from the metal-graphene heterostructures to the structures appearing inside the C layer. The second law of thermodynamics dictates the presence of a certain amount of disorder in crystalline materials. Moreover the production methods normally lead to some impurities and defects in the crystals ⁶³. Here we will try to shed some light on the defective atomic mechanisms we have found on the G/Pt(111) surface leading to strain relief. The difference in the lattice constants between the graphene –or Moiré periodicities- and the substrate makes graphene accumulate a relatively high quantity of strain. The layer will try to release these unbalanced forces through the formation of a variety of atomic scale defects – atomic vacancies, line defects...- or nanoscale defects – such as graphene-graphene grain boundaries, twisting of the moirés, carbide structures or nanobubbles.

Figure 2 25 shows two independent defects coexisting on the same sheet of graphene. This figure intends to show that the atomic scale defects can adopt more than one atomic configuration depending on how many C atoms are missing or where is/are this/these missing atom/s inside the Moiré unit cell.

The present chapter is not intended to be a rigorous study of all the possible defective structures that might appear on graphene, as this might be an enormous experimental task but rather a *"bestiary"* of all the structures observed during our STM experiments. We divide the graphene defects into three different subgroups depending on its dimensionality. Therefore we have, 0D defects, 1D defects, and 2D defects. However, this must be taken with caution, as it is an artificial separation and there are structures that can be assigned to more than one of these subgroups.

The **OD defects** can be divided in four groups according to previous work ⁶³:

1-Point defects: such as the so called Stone-Wales defect consisting in the restructuration of 4 hexagons inside the graphene layer into 2 pentagons and 2 heptagons without adding or removing any atom.



Figure 2 25: STM images showing two OD defects on graphene on Pt(111). These structures are present in small patches of graphene with high strains.12x12nm, 100mV, 1nA.

2- Single vacancies: One missing atom induces the appearance of the characteristic Jahn-Teller distortion which leads to the formation of a fivemembered and a nine-membered ring. This defect has been experimentally observed by means of STM on HOPG⁴⁶ (whose topmost layer posses mechanical properties similar to free-standing graphene). Analogous experiments on G/Pt(111)⁶⁰ -a supposed weakly interacting metallic substrate- induces a severe modification on the configuration of the defects through chemical bonding between the unsaturated C atoms and the substrate

3- Multiple vacancies: The simplest of them are the divacancies. These structures have been studied theoretically in detail ⁶⁴ and experimentally studied by means of TEM ⁶⁵. Higher order vacancies involving more than two missing C atoms are likely to induce curvatures in the graphene layer and therefore forming domes and other sort of topological defects.

4- Foreign adatoms: The saturation of one π bond in graphene by an impinging atom has been observed on G/Ir(111) exposed to atomic H. In this particular case it seems that H adatoms tend to organize forming clusters on the positions of the Moiré superlattice ⁶⁶. Another possibility is

that the foreign adatom substitutes a C inside the graphene lattice. This possibility is very interesting in order to dope graphene ^{67 68}.

In Figure 2 26 we show three different point defects found in our STM sessions of the G/Pt(111) system. We have to point out that obtaining atomic resolution of these defects at room temperature it is not an easy task and the results must be taken with caution. Moreover, the absence of theoretical calculations for comparing with the experimental data makes the present morphological analysis a preliminary approach to the understanding of these structures. However the quality of the images is good enough to try the interpretation of these structures through comparison with other studies. Figure 2 26 a shows a single atom defect, we believe this defect consists of an heteroatom -most likely a N atom coming from the residual gas in the chamber- incorporated into the graphene layer. We believe this is a foreign adatom because in case it was a C vacancy a relaxation would be expected. Figure 2 26.b shows a multiatomic vacancy which induced a reconstruction of a region of 1-2nm. Although a dome-like local configuration can be expected one must take with caution the fact that this region appears brighter -- and thus higher- in the STM images as electronic effects are normally occurring in the defective regions of graphene. Figure 2 26.c shows a strain-induced lattice dislocation involving at least two unit cells of graphene. It is not clear to us whether or not this structure has C vacancies or graphene-metal bonds. Further studies including theoretical calculations would be desirable in order to fully determine the atomic configuration of this structure.



Figure 2 26: Three 5x5nm² images showing 0D graphene defects on Pt(111). **a**.10 mV, 3.9nA . **b**. 10 mV, 2nA. **c**. 10 mV, 3.9nA

The possible **1D defects** on metals can also be grouped in three categories:

1-Graphene edges: Either they are *step-like* or *border-like* the ending of a graphene sheet is considered as a defect. We already described how *step-like* edges are related to Moiré stability. On the other side the *border-like* edges try to minimize the total energy of the system by chemical functionalization. The two most likely functionalization mechanisms are through H passivation ⁶⁹ or through covalent bonding with the metallic substrate ⁷⁰ of the external C atoms.

2-Graphene grain boundaries: These are the junction structures appearing between two rotational domains of graphene. They can be crystalline, as the one found on the surface of Ni(111)¹², pseudoperiodic or amorphous⁷¹. These structures have attracted an important attention since theoretical works⁴⁷ predict exotic transport properties, such as the possibility of being used as valley filters⁶¹ or metallic wires.

3- Graphene folds and wrinkles: Graphene might relax its strain through out of plane deformations. These deformations might be caused by surface defects, such as an atomic step ⁷², or by thermodynamic effects, such as a chemical attacks ⁷³ or local carbon accumulation due to the difference between the thermal expansion coefficients between the substrate and the overlayer ^{74 75}.

In **Figure 2 27** we see a pseudo-periodic graphene grain boundary. The structure involves several, unresolved, vacancies and lattice deformations. Interestingly it seems that the grain boundary is periodic, adopting the periodicity of the larger of the two Moirés that separates.



Figure 2 27: Pseudo periodic G-G edge, the grain boundary follows the periodicity of the lower moiré. 18.4 x 9 nm², 2nA, 10mV.

In Figure 2 28 we see two 1D defects on the G/Pt(111) system. This figure tries to show that graphene adjusts itself to the conformation which minimizes its energy. Thus in Figure 2 28 a we see two domains of graphene that lie in the same Pt(111) terrace but are separated by an amorphous grain boundary. The strain accumulated between the two domains induces the appearance of this defective structure. On the other hand, in Figure 2 28b we see that graphene can in some cases run across an atomic step without forming a grain boundary, the only defective structure appearing is an out-of-plane bending on the layer. The slope of the fall will depend on the strain accumulated inside the domain, but this strain is not big enough to form any "more defective" (such as vacancies) configuration.



Figure 2 28: Examples of 1D defective . G-G edge vs. graphene running through a Pt step. **a** . $10x10 \text{ nm}^2 1.9nA$, 10mV. **b** . $7.5x7.5 \text{ nm}^2$, 8nA, 2mV.

2D/3D defects. At last, the remaining possible defective structures are 2 and 3-dimensional. These structures are not normally discussed in the literature as graphene itself is 2D. We can talk of 2D defects correctly when talking about the two structures that are going to be discussed below.

1-Surface carbides: Surface metal carbides are well known as impurities in surface science. However it has been recently discovered that some 2D surface carbides become graphene under low temperature annealing ⁷⁶ following complex intermediate phases and forming interesting graphene-carbide interfaces. In the case of Pt the carbide structures consist normally of 3D protrusions that grow forming *stone*-like clusters on the clean Pt(111) regions. However we can also find these *stones* embedded inside graphene regions, see **Figure 2 29 a**.

2-Graphene Nanobubbles: Graphene relaxes through formation of domelike structures. These so-called nanobubbles have attracted an important theoretical attention since the discovery of gauge-related electronic effects in strained graphene ⁷⁷. Under this theoretical approach the electrons within three-fold strained graphene feel gauge field analogous to a magnetic field (and therefore called pseudo-magnetic fields ⁷⁸). Thus, zerofield landau levels are observed in strained graphene. In particular Pt(111) is a good substrate to form these nanobubbles and pseudomagnetic fields greater than 200T have been observed in G/Pt(111) nanobubbles ⁴².



Figure 2 29: Examples of 2D defective structures. **a**. Surface carbide,10x10 nm², 8nA, 2mV. **b**. Graphene nanobubble, 20x20 nm², 0.6nA, 310 mV.

During our STM experiments we have observed both kinds of structures. We have found carbides forming 3D structures and embedded carbides. We also observed nanobubbles and, although our RT-STM is not the best tool to study the narrow resonances in the DOS, we have measured strange electronic effects around these nanobubbles. For instance in **Figure 2 29 b** we show a nanobubble inside a $(\sqrt{7}x\sqrt{7})R19^\circ$ domain; looking carefully we observe that its contour looks deeper than the bare $(\sqrt{7}x\sqrt{7})R19^\circ$ terrace. We believe this is an electronic effect or STM artifact rather than a real topographic hole caused by strain-induced electronic effects.

In conclusion in the present section we have explained a selection of defective structures that are normally related to strain relief mechanisms of G/Pt(111). We have also shown STM images of several of these mechanisms. The high accumulation of strain due to the apparition of a large number of rotational domains in G/Pt(111) makes this system an ideal testbed to study these graphene defective structures that might be important for future graphene based electronics.

2.8. Conclusions

The aim of this chapter is to characterize epitaxial graphene grown on weakly interacting metallic substrates. For this purpose we have efficiently grown graphene on Pt(111) by means of different carbon containing molecular precursors, from large aromatic molecules, such as C_{60} , to small hydrocarbons, such as propane C_3H_8 .

Graphene grows forming rotational domains, i.e. domains with different angles between the G and Pt high symmetry axis. Every possible crystallographic angle leads to the formation of a Moiré superstructure. These structures have been extensively studied by means of STM and an original geometrical model.

The model that we developed is based on the search of best matching pairs of surface crystal vectors for every angle between graphene and Pt(111). With these inputs our model predicts the appearance of 22 possible superstructures or Moirés for the case of G/Pt(111). Our model can be exported to other metallic crystalline substrates reproducing the Moirés reported in the literature for these substrates.

Thus, our model minimizes the strain and periodicity occurring between graphene and substrate arising from the difference between the surface lattice parameters. It does predict the periodicity and apparent angle of every Moiré unit cell suggesting the possibility of metal-overlayer pinning regions within the Moiré unit cell. The most commonly observed Moirés are the ones holding less strain.

Among the possible structures the one holding a biggest strain is the $(\sqrt{3}X\sqrt{3})R30^\circ$, or $\alpha G/Pt(111)$ superstructure, which is observed, mainly for low temperatures, occupying large portions of the total areas. We have developed a combined theoretical-experimental approach that determines that this structure consist of an ordered vacancy network in the topmost Pt(111) layer and a graphene layer covalently bound to it.

In order to understand the physical origin of our phenomenological theoretical model we have studied the atomic structure of the bonding regions between graphene and metal steps. These edges follow the crystallographic order of the Moiré and involve graphene normally finishing in a zig-zag configuration.

We have studied at the atomic scale the edge occurring between a Pt step and ($\sqrt{7}$ X $\sqrt{7}$)R19°, or β G/Pt(111) superstructure. Our combined theoretical and experimental approach shows that the step edge reconstructs exclusively in the Pt side and predicts the presence of an exotic 1D state in one of the two graphene sublattices. This prediction is confirmed experimentally as we observe a 1D structure in the unoccupied states of graphene when inspected with the STM.

Lastly we have presented the defective structures formed upon strain relaxation mechanisms. The formation of some of defective structures can be directly related to strain accumulation between the substrate and the overlayer.

In conclusion, we have performed a wide structural study of the G/Pt(111) systems and the possible crystalline and defective structures appearing within it.

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Chapter 3. Epitaxial growth of graphene on SiC(0001)

In order to use the already existing semiconductor based industry for microfabrication of new integrated circuits based on 2D materials, a non-metallic substrate is necessary to decouple the intrinsic semimetallic transport properties of the ad-layer from those –normally dominating- of the substrate. In a moment where Si-based technology is reaching its fundamental limits, the high mobility of electrons in graphene, even under high electric fields ¹, together with the fact that its electronic properties are very robust, even at ambient conditions ², makes graphene a possible solution to keep increasing the speed and quantity of transistors per chip. For instance ballistic transport at room temperature in the submicron length-scale can be achieved on this material and therefore a graphene-based ballistic transistor can be, in principle, fabricated ³.

Graphene microelectronics has its intrinsic drawbacks. For instance the absence of a bandgap complicates the design of such transistors. Moreover the production methodologies implemented up to now have several limitations. HOPG mechanical exfoliation ⁴ is well suitable for producing small -up to several µm- high purity flakes, but terribly expensive. Graphene oxide reduction produces high quantities of low quality chemically modified graphene sheets ⁵. Graphene on polycrystalline copper is nowadays the most promising production method of freestanding graphene ⁶ but the resulting product is more suitable for being used as transparent conducting electrodes in touch-screen devices than in microelectronics. Graphene grown on single crystal metals produces high quality large area sheets that can be transferred to dielectric surfaces but the price of the substrate makes this method only suitable for academic studies. In order to be scalable for a future graphene-based electronics, cheap and stable substrates are desirable. Among the current main production methods there is only one that fulfills the requirements -large production scale, low price, high domain area, high crystalline quality, and ease to handle- necessary for a potential graphene-based microelectronics: epitaxial graphene on single crystal silicon carbide (SiC).

It was in 2004, short after graphene was isolated for first time in Manchester, when C. Berger *et al.* noticed that the graphitic layers that had been previously observed epitaxially growing on SiC(0001) (see for example a 1997 review in ⁷) behave as graphene ⁸. In its pioneering work C. Berger *et al.* showed that the electrons in G/SiC(0001) behave as in a 2D electron gas with high electron mobility over large scales, and that the system could be successfully patterned by conventional lithography in order to create devices. After this finding, further developments have been achieved and

transistors up to 100GHz have been patterned onto wafer-scale epitaxial graphene $^{9\ 10}$ and integrated circuits have been successfully developed onto SiC wafers 11 .

However, in the present section we will not focus on the possible devices and applications of this system but rather on the structural modification of the G/SiC(0001) upon molecular deposition. For this purpose we have characterized all the possible surface reconstructions appearing on this material under UHV conditions and we have chosen two different characteristic molecular species to deposit onto it: one belonging to the group of very weakly interacting adsorbates – C_{60} - and the other belonging to the group of highly reactive and highly interacting adsorbates – atomic hydrogen (H). We have performed a combined theoretical-experimental atomistic characterization of the $C_{60}/G/SiC(0001)$ system and H/G/SiC(0001) and compared the main interactions between them as well as with other similar systems.

SiC is present in the nature in the form of the mineral form of moissanite. This mineral is extremely rare on earth but extraordinary abundant in space where it is synthesized in the vicinities of carbon-rich asymptotic giant branch stars (see Appendix IV). It can crystallize in a zinkblende structure-cubic SiC, historically called β -SiC- or a wurtzite structure –hexagonal symmetry, also known as α -SiC. There are more than 170 identified polytypes of SiC depending on the stacking of the layers ¹². The most common ones according to the current production techniques are the 3C-SiC, 2H-SiC, 4H-SiC and 6H-SiC. In **Figure 3 1** we show the crystallographic unit cell of two different polytypes. One can see that the 6H-SiC unit cell includes 6 Si-C layers. We have used both 3C and 6H polytypes during the studies of this thesis, however only results from 6H-SiC(0001) samples are presented.



Figure 3 1: Crystal unit cells of the two most common polytypes of SiC. a. 3C-SiC. b. 6H-SiC.

There are some good reviews about SiC surfaces. Every one of these works is focused on different aspects of this material. The information therein has been very helpful during the realization of this thesis and it is referred all along this chapter. The reader is therefore kindly invited to read the following references for further understanding of SiC ^{12 7 13 14 15 16 17 18 19 20}.

3.1. 6H-SiC(0001): high temperature surface reconstructions

The as-received samples are not suitable for performing atomic scale studies because they are covered by a native SiO₂ layer on the polished side that prevents the surface for experimentation. A process for removing this protective layer is necessary. The cleaning protocol used during this thesis is as follows: Prior to all, the SiC platelets need to be cut apart from the wafer with the help of a diamond tip and mounted onto the specific sample holders. Then the sample needs to be slowly annealed, ramping up the temperature while keeping the pressure in the 10⁻¹⁰ mbar range. This induces a sample, and annealing-stage, degasification that results necessary in order to obtain low pressures during the high temperature flashes that are forthcoming. After this degassing procedure we turn on the -already degassed- Si evaporator. The most important step of the process consists in evaporating while SiC annealing; this is shown in Figure 1 22 where a picture of the interior of the UHV chamber during the process is presented. The sample is mounted in a refractory metal sample holder, in this case Ta, and is annealed at 1100K while a Si evaporator, placed 15 cm in front of the sample, is kept at 1500K. This Si evaporation temperature at the abovementioned distance yields an approximate evaporating rate of 1ML/s. The flux, however, has not been precisely calibrated (for example with the help of a quartz balance) as the exact value is not important. The Si deposition is only necessary in order to maintain the Si stoichiometry of the SiC sample during the SiO₂ removal. Several combined cycles of Si evaporation and annealing are normally needed in order to obtain large terraces of high-quality reconstruction. Every Si evaporation cycle, while SiC is annealed is typically 10-15 min long. Normally one need to perform 3 to 6 cycles in order to clean the surface, although if the base pressure is high $(>5x10^{-9}mbar)$ one may need more of them.

The usual way to check the atomic order of the surface is with the help of LEED instrumentation. The sample, when introduced in the UHV chamber exhibits a faint (1x1) LEED pattern. After several cycles of Si evaporation while annealing a sharp (3x3) pattern arises. Interestingly, this pattern appears much before the sample is well suited for performing scanning probe microscopy studies, and only when the pattern is very sharp and the background very faint the terraces are well developed. Once the sample has this well developed (3x3) pattern, further annealing increasing the temperature yield to the different reconstructions-($\sqrt{3}x\sqrt{3}$)R30°, ($6\sqrt{3}x6\sqrt{3}$)R30°, and graphene- without the need of any Si surplus or any other UHV additional process.

For a complete view of the G/SiC(0001) system we must briefly introduce another main preparation methods. Several groups instead of UHV treatment use *ex-situ* Argon (Ar) assisted graphitization of the SiC(0001) samples. The method was described by K.V. Emtsev *et al.*²¹ and consist in H-etching followed by an 1950K annealing of the sample into 900 mb of Ar. The samples prepared following this protocol normally present very large graphene terraces and morphologically superior graphene. The explanation to this improvement in the quality is explained because higher temperatures are achievable under Ar atmosphere prior to Si depletion. No Si depletion is observed in near-atmospheric pressures of Ar until 1800K as it exists a non negligible probability that an outgoing Si atom gets back to the surface by collision with Ar atoms. We must underline that we have not used these ex-situ samples in any of our experiments, but the more conventional- and still high quality resulting- UHV method was used in our experimental sessions.

In Figure 3 2 we see the mesoscopic characterization of the 6H-SiC(0001) sample. The as-received sample was investigated with SEM and AFM. It is not surprising to find that the polished side appears smoother than the unpolished side of the wafer. In the Figure 3 2 a the only visible item are small spots, probably dust grains, in the limit of the resolution of the microscope. The scratches of the polishing process are not resolved with the SEM. In the **Figure 3 2 b** we see that the unpolished side appears rough, even under a smaller amplification, indicating that the cut of the wafers is a relatively harsh process that leaves the surface in a very disordered configuration. In the AFM images of the polished side we see that the asreceived sample is full of scratches in all directions. These groves arise as the grains of the polishing powder attack the surface, mainly covered of SiO₂ and probably amorphous carbides. We show on Figure 3 2 d an AFM image of the same surface (same scanning area size) after UHV graphitization. We observe the atomic steps of the terraces in the treated sample (while on the as-received only the polishing scratches are visible) forming intricate shapes and flat terraces of about 500 nm width.



Figure 3 2: a. SEM image of the polished side of an as-received 6H-SiC(0001) wafer, the scale bar is underneath the image. **b**. SEM image of the unpolished side of an as-received 6H-SiC(0001) wafer, the scale bar is underneath the image. **c**. AFM image of the polished side of an as-received 6H-SiC(0001) 10x10 μ m². **d**. AFM image of the 6H-SiC(0001) sample (polished side) after UHV treatment. The atomic terraces are resolved, $10x10 \mu$ m².

In the following sub-section we will introduce, when possible, the LEED, LEEM, XPS and STM characterization of the different C-rich SiC(0001) reconstructions induced upon temperature. We have characterized these structures as a reference for subsequent molecular depositions or treatments. The relatively Si-rich reconstructions,(3x3) and (V3xV3)R30°, are described in similar detail in the Appendix II.
a. (6v3x6v3)R30°/SiC(0001) or buffer layer.

If the temperature of the annealing is higher than 1450K, Si depletion from the crystal surface increases. Eventually the surface changes its reconstruction and a $(6\sqrt{3}\times6\sqrt{3})R30^{\circ}$ LEED pattern develops. This change corresponds to the appearance of quasi-periodic (6×6) reconstruction in some regions of the surface. This surface structure was reported in 1975 through LEED observations ²² and first STM images were performed in 1996 ^{23 24} by two independent groups. They reported a mixture of three reconstructions, the $(\sqrt{3}\times\sqrt{3})R30^{\circ}$ and two psuedoperiodic reconstructions with approximate periodicities of (6x6) and (5x5) respectively, from Fourier analysis of experimental STM images.

(6v3x6v3)R30°, guasi-(6x6), buffer layer or zero layer graphene (ZLG) are different names for the same structure. The precise atomic structure of this surface reconstruction is hard to determine because its pseudo-periodic behavior. From a theoretical point of view it is hard to handle because the large amount of atoms involved in the surface unit cell, and some groups use artificially smaller unit cells to perform their simulation of the (6v3×6v3)R30° structure ²⁵ ²⁶. Nevertheless, experimental and theoretical groups have proposed some atomic configurations involving the presence of C in sp^2 (graphene) configuration covalently bound to the uppermost SiC layer. Some of these proposed atomic models have been suggested by Chen et al.²⁷. Rutter et al.²⁸ and Riedl et al.²⁹. From an experimental point of view, the commensurability of graphene with the SiC substrate and the resulting periodicity of the atomic termination of the surface posses a doubly interesting behavior. When inspected with local techniques, such as STM or nc-AFM, we observe a set of atomic protrusions with (V3×V3)R30° periodicity but these protrusions, most likely dangling bonds, present different heights and slight positional distortions ordered in an overall (6×6) guasi-periodicity, while when studied with diffraction tools a (6V3×6V3)R30° pattern emerges, but the structure is not well ordered and vacancies and defects occupy a significant fraction of the surface.. These ambiguous observations have been put together by the atomic model of Kim et al.³⁰. They proposed that this layer consist of a mesh of C atoms arranged in a honeycomb lattice, analogously to graphene, but contrary to it, some of the resulting semi-filled π -orbitals being covalently bound to the atoms of the next layer buried underneath and preventing the formation of a developed π band. A similar model proposed by Varchon et al. ³¹ show that the covalently bonded graphene sheet in the buffer layer is highly corrugated. However one must notice that the simulated STM images for these models

are in modest agreement with the STM images obtained experimentally, and dangling bonds do not appear in the simulated images. More recently, another theoretical-experimental work proposed the presence of hexagon-pentagon-heptagon defects breaking the honeycomb symmetry of this structure and thus opening a gap, in good agreement with the ARPES results ³². To the best of our knowledge there is not a clear consensus on the atomic structure of this reconstruction although there exist several works claiming "solving the long-standing problem of the interfacial structure of epitaxial graphene on SiC(0001)". Just as an example we would like to bring the attention to the works performed during the present year about this topic, as they present clear contradictions with the previous literature ^{33 34}.

In Figure 3 3 we show three STM images of different scales of this reconstruction. In the large scale image we see features spaced following the (6x6) pseudoperiodicity; it has an approximate unit cell length of 19 Å and grows in terraces of 10-100 nm. When inspected with atomic resolution (see Figure 3 3 c) we find atomic-scale structures that are normally attributed to dangling bonds. Every one of these atomic protrusions arise from an electronically empty extended orbital of an atom spaced according to the $(\sqrt{3}x\sqrt{3})R30^{\circ}$ periodicity. The height variation of these dangling bonds is what produces the superperiodicity of 19 Å. The surface looks very defective at both scales -atomic and superperiodicity- and there are missing atomic dangling bonds as well as missing trimers all over the surface when inspected with STM. The atomic structure of this reconstruction is formed by three nonequivalent sublattices of (V3xV3)R30° coexisting on the surface. Every of these sublattices is shifted with respect to the other two, and forms a complex network of nonequivalent positions. The trimers arise when three atoms, one atom belonging to each sublattice, appear together, in the vertex of the trimers.

On $(6\sqrt{3}x6\sqrt{3})R30^\circ$, no graphene atomic resolution can be achieved despite the honeycomb carbon lattice covering the structure. When scanning with a bias voltage near the Fermi level the STM images gets unstable and most of the times the tip crashes. Out of this voltage range, the main features are the dangling bonds and the quasi-(6x6). On the other hand, on SLG the conditions for resolving graphene corrugation, normally imply using bias close to the Fermi level, at higher bias voltages the main attributes are very similar to those of the underlying $(6\sqrt{3}x6\sqrt{3})R30^\circ$. When scanning on SLG, the STM images at high bias are very similar to STM images of the buffer layer itself. Graphene and buffer layer both exhibit a quasi-(6x6) superperiodicity and to distinguish between them can be difficult, as tip artifacts might induce confusion and the strong bias dependence of the G/SiC surface makes the identification of the surface structures not trivial in some cases.



Figure 3 3: STM images of the (6V3x6V3)R30° reconstruction. **a**. 50x50 nm², -1200mV. **b**. 25x25 nm², -2400mV. **c**.10x10 nm², 1000mV.

The XPS spectra of this structure are presented in **Figure 3 4**. In the overview we can check that the C1s peak has bigger intensity than the Sirelated peaks, thus indicating that the surface has become richer in carbon due to the Si depletion. The C1s/Si2p ratio is about 1.15 for this photon energy and the C and Si core level peaks seem to be single component centered at 283.5 eV (these experiments were performed with an X-Ray Alanode , so the resolution is not as good as the synchrotron spectra and the Si doublet is not resolved). Asymmetry in the C1s peak indicates the existence of a developing second component at higher energies; let us remember that the C1s component related to sp² bonding hybridization appears at 284.8 eV ³⁵. Therefore this second component most likely comes from graphitic carbon that is starting to form on the outermost surface. On the other hand the maximum of the Si2p peak is slightly shifted towards higher energies up to 101.4 eV and a single component is resolved. This spectrum corresponds to a surface with a very low degree of graphitization.



Figure 3 4: XPS spectra of (6√3x6√3)R30° surface using an Al Kα anode (1486.6 eV) as X-ray source. a. Overview for comparing the relative intensity of the C1s and Si2p and Si2s peaks. b. detail of the C1s peak, only one component appears at an energy corresponding to carbide, although a small component at higher energies starts to be noticeable. c. Si2p peak.

The LEED pattern of this reconstruction is very instructive. The experimental pattern is shown in **Figure 3 5** together with an explanation of the observed dots. The complexity of the spot arrangement has fostered several interpretations. However, most of them involve the presence of more than one atomic reconstruction on the sample's surface. The sketch remarks the origin of each of the observed dots, highlighting the coexistence of SiC (1x1), faint graphene dots, (V3xV3)R30°, (6V3x6V3)R30°, (6x6) and quasi-(5x5) on the same surface preparation. It is interesting to comment that most of the nominal (6V3x6V3)R30° spots are not normally visible, but only a small amount of them are clearly resolved. An interesting LEED I(V) analysis of this pattern is presented in ³⁶.

Another point that shall be commented on the LEED pattern is the evolution of the inner points of the characteristic diamonds appearing around the ($\sqrt{3}x\sqrt{3}$)R30° spots. The $\sqrt{3}$ spots are dominating in intensity until the quasi-(5x5) spot appears. They coexist during a small range of temperatures, and thus C/Si ratio (an experimental pattern of this coexistence can be seen in **Figure 3 6 b**). If we continue annealing only the quasi-(5x5) remains (**Figure 3 6 c**) and eventually where several layers of graphene are developed none of them can be observed.



Figure 3 5: LEED pattern of the $(6\sqrt{3}x6\sqrt{3})R30^{\circ}$ structure at 140eV. The theoretical explanation of the pattern is adapted from ref.²⁰



Figure 3 6: Evolution of the inner diamond with temperature (and/ or time) as the (V3xV3)R30° spot- the one inside the diamond in the lower halfdisappears and the quasi-(5x5) spot – the one inside the diamond in the upper half- appears. In b. we see an intermediate step where both structures coexist in the LEED pattern. The images correspond to different samples and electron energies.

b. <u>Quasi-(5x5)/SiC(0001)</u>

The quasi-(5x5) superstructure is intimately related to the $(6\sqrt{3}x6\sqrt{3})R30^{\circ}$ reconstruction. Both reconstructions appear under the same preparation methodology, but quasi-(5x5) appears occupying small regions of the surface. This reconstruction is scarcely appearing in STM sessions and therefore most people have considered it as a defective surface structure. It is difficult to quantify its partial coverage as it frequently appears in small patches inside the dominant (6V3x6V3)R30°. Anyway, it can also extend several tenths of nm. The quasi-(5x5) internal structure consist in set of atoms forming flower-like structures of 2-7 dangling bonds. As we have introduced before, the (6V3x6V3)R30° surface can be seen in terms of the sum of three (V3xV3)R30° nonequivalent lattices. According to this perspective, the quasi-(5x5) appears as islands of dangling bonds belonging to the same sublattice. The average distance between the protrusions is 5 lattice unit cells. In Figure 3 7 we show a representation of this. One of the (V3xV3)R30° lattices is represented in Figure 3 7 b as an array of white dots. We can notice that the maxima of the dangling bonds coincide with the marked dots for some of the flowers, we have marked these dots with blue circles in Figure 3 7 c. The rest of the flowers maxima appear respectively in the positions of the other nonequivalent (V3xV3)R30 lattices, that are depicted in Figure 3 7 c as green and red circles shifted hexagonal lattices. All the dangling bonds within a single rosette belong to the same (V3xV3)R30° sublattice and

surrounded by a region appearing lower in the STM images. The fist neighbor flowers from a green island are red and blue flowers, and the same occurs for the other combinations.



Figure 3 7: Explanation model of the quasi-(5x5) superstructure .a. The STM image as recorder (filtered for ease the visualization). Inset: scheme of the three nonequivalent (v3xv3)R30° lattices, blue (1, white in the b and c images), green (2), and red (3). b. One of the three sublattices is represented with white dots, the other two sublattices correspond to the middle of the triangles, on a when the triangles are looking upwards, and the other when the triangle are looking downwards. Every sublattice is represented with a different color: blue, green, and red.c. The tree lattices are represented.

In **Figure 3 8** we show STM images of this superstructure. In **Figure 3 8 b** and **c** we show for the first time, up to our knowledge, the existence of the graphene intercalation between the quasi-(5x5) structure. The graphene mesh is visible in the STM images in the dark regions between the rosettes as a small regular corrugation with 2.4Å periodicity. One explanation is a graphene sheet on top of the quasi-(5x5) reconstruction, but other options shall be taken in consideration, such as graphene intercalated between the quasi-(5x5) structures or even graphene under the quasi-(5x5) structure. We believe that proving the existence of graphene between some islands of quasi-(5x5)/SiC(0001) is a demonstration that a rich pull of surface structures are possible on the SiC hexagonal surface and that most of them are not understood, despite the large amount of scientific literature devoted to the topic. Further atomic-scale studies are necessary in order to fully understand the SiC high-temperature reconstructions.



Figure 3 8: STM images of the quasi-(5x5)/SiC(0001) reconstruction and the G/quasi-(5x5)/SiC(0001). **a**. 20x16 nm², -3400mV. **b**. In this image the reconstruction is covered by a graphene overlayer, the white square marks the region highlighted in c, 14x14 nm², -400mV.**c**. Detail of the b image corresponding to the white square in b, where the graphene lattice is visualized as a small corrugation, 5x5 nm², -400mV.

c. <u>SLG/SiC(0001)</u>

Graphite has been described on top of SiC(0001) surface by means of STM measurements as soon as 1991 by C.S. Chang *et al.* ³⁷ and it was described before in 1975 by means of LEED and AES experiments ²². In the work of Chang, the authors present atomically resolved images of a (6x6) structure with a smaller periodicity of 2.5Å on top of it. They correctly described the structure as a graphite monolayer incommensurately grown on the Siterminated surface of the SiC sample. This finding was presented soon after the invention of the STM. However, despite its brilliant origins, a full characterization of the SLG on the buffer layer structure is still missing, most likely due to the absence of a true crystalline order ³⁴.

In **Figure 3 9** we present large scale STM images of a graphene covered terrace bigger than 100nm long. In these zoom-in series we observe that the collision of two nonequivalent domains of the underlying $(6\sqrt{3}x6\sqrt{3})R30^{\circ}$ structure induces a defective structure. Detailed inspection of the image shows that bellow the defective structure is a region where there is no underlying SiC buffer layer substrate, and thus the graphene layer is somehow suspended. The absence of subsurface artifacts that obscure the imaging of the pure graphene sheet makes the honeycomb structure to be nicely resolved. The line defect appearing o the **Figure 3 9 c** results from the coalescence of two shifted domains of the quasi-(6x6) structure.



Figure 3 9: STM images of single layer graphene on SiC(0001). The white square marks the region magnified in the contiguous image. a. 100x100 nm²,-1100mV. b. 40x40nm²,-1100V. c. 15x15 nm²,-1100V. In this image a defective zone is shown where there are missing subsurface atoms of the buffer layer, most likely due to the conjunction of two nonequivalent domains of the substrate.

Epitaxial graphene on SiC present very interesting electronic characteristics. The first thing an STM experimentalist note when measuring this surface is that it exist a strong bias dependence on the STM images. Depending on the bias voltage graphene change from being almost invisible to becoming the most notable feature observed on the surface ³⁸. The subsurface dangling bonds, on the other hand, pass from being the most distinguishable feature to become severely screened by the graphitic layer which is on top. In **Figure 3 10** we present a series of STM images of the same region at different tunneling bias. We observe how graphene becomes transparent at energies well above or below E_F ²⁸. Local spectroscopic measurements show a gap of ~100meV ³⁸ centered in the E_F ; this gap is most likely originated from the SiC substrate-.

Another interesting electronic effect is the defect-induced (V3xV3)R30° pattern on graphene due to intervalley scattering. This (V3xV3)R30° pattern shall not be confused with the (V3xV3)R30° SiC surface reconstruction. This purely electronic effect arises in the proximities of defects and vacancies as well as zig-zag and arm-chair edges ³⁹. This structure is very easily spotted on the G/SiC surface, while the interaction with other substrates, typically metallic, makes this purely electronic effect more difficult to find in G/metals than on G/SiC. This effect is explained in terms of quantum interferences between electrons belonging to each of the two nonequivalent sublattices in the k-space, i.e. each of the two nonequivalent Dirac-cones and is considered to be a fingerprint of π -like states close to the Fermi level ⁴⁰. The valley degeneracy is being related to the apparition of a conserved number analogous to the spin called the pseudo-spin. Under this formalism the (V3xV3)R30° pattern can be studied in terms of intervalley scattering or pseudospin rotation ³⁹. In **Figure 3 11** we present STM images of an arm-chair edge a zig-zag edge as well as point defects presenting scattering effect.

Figure 3 10: (right page) Series of STM images of the same region showing the bias dependence of the SLG/SiC(0001). When scanned at bias near the Fermi edge (100mV) the main feature is the graphene lattice, while scanned at higher bias (400mV) the subsurface buffer layer structure is revealed. 7x7 nm^2





Figure 3 11: STM images of the (V3xV3)R30° electronic interference pattern of: **a**. arm chair edge 8.4x8.4nm² V=100mV. **b**. Zig-Zag edge, 8.4x8.4nm² V=-100mV. c. Punctual defective region, 8.4x8.4nm² V=400mV, and a fast Fourier transform of the c image where the graphene dots and the (V3xV3)R30° dots are clearly spotted.

In **Figure 3 12** we present a high resolution image of a small region of graphene. This image is performed during a lapse where our tip presented an exceptional characteristic that is normally called "giant corrugation" ⁴¹. With this resolution, apparent heights within a single graphene unit cell can exceed the 2Å, for a lateral distance of 2.46 Å. This effect is poorly understood and several hypotheses have been proposed. However, we believe that it most likely involves the presence of some sort of small molecule or adsorbate, for example an H₂ molecule, attached to the apex of the scanning tip. This supposition is based in the recent results on CO (carbon monoxide) functionalized tips where an exceptional resolution of adsorbed organic molecules is achieved ⁴² and some experimental-theoretical evidences pointing towards hydrogen attached to the scanning tip as the source of the improved resolution ⁴³. Our supposition is that a

single unknown molecule from the residual gas in the UHV chamber is confined between the tip and the surface. This involuntary functionalization do not usually last very long as any surface impurity, such as for example an atomic step, is normally enough for losing the giant corrugation resolution.



Figure 3 12: 3D representation of a high resolution image of graphene scanned under giant corrugation conditions. 2x2 nm², 1 nA, -100mV.

In order to identify the chemical nature of our samples we have combined our STM results with syncrchrotron radiation photoelectron spectroscopy experiments measured in SuperESCA beamline in ELETTRA syncrotrone (Trieste, Italy) ⁴⁴. In **Figure 3 13** we present the overview spectrum of the sample annealed at 1400K recorded with a photon energy of 600eV. It is obvious that the C1s peak dominates the spectra. However, the photon energy is not the same than the one used for the previosly shown spectra (where a X-ray gun with an Al-Mg anode was used) and the comparision

between the spectra of the different reconstructions can not be performed directly.

It is important to notice that the resolution in XPS spectra that can be obtained in a synchrotron facility is much better than the one obtained in the laboratory. Therefore much more chemical information can be extracted from these spectra.



Figure 3 13: Synchrotron radiation XPS overview spectra of the SiC sample annealed at 1400K recorded with a photon energy of 600 eV

Synchrotron-based high resolution spectroscopy permits us to decompose the peaks into its basic curve-components. Every component reflects a particular electronic environment (i.e. bonding configuration) and results from the convolution of a purely quantum Lorentzian energy distribution (FWHM 0.12-0.2 eV) with a Gaussian distribution (FWHM 0.4-0.7 eV). However, the carbon chemistry is very rich and the interpretation of the C1s spectra is not straightforward. The components corresponding to sp^2 and sp^3 bonding configurations measured for pure graphite and pure diamond respectively appear at very similar binding energies.

We have decomposed the C1s XPS peak of the as-grown G/SiC sample in 5 different basic components without using any asymmetry parameter. SiC is a wide gap semiconductor and therefore we use symmetrical peaks for the fitting. In **Figure 3 14** we show the C1s and Si2p photoelectron peaks decomposed in its basic components. The component appearing at 284.83 eV can be directly assigned to the graphene contribution (or C atoms in sp^2 configuration)²⁰, and is the biggest contribution to the C1s core level peak,

with its 58.2% of the total area. This component is also important for calibration of the energy width, since it is narrow enough to test the Lorentzian and Gaussian widths with a high precision. The components located at lower binding energies than the main peak (in our case 283.98 eV) are attributed normally to carbides, and we assign them to the C in the SiC bulk crystal. There are three other components at higher binding energies, which can in principle be assigned to different configurations of C atoms in the superficial rearrangement that takes place upon surface reconstruction. We assign these XPS components to surface related peaks ^{45 46 21} and name them with an S. in the way that follows: S.C-Si 1 at 285.26 eV, S. C-Si 2 at 285.73 and S. C-Si 3 at 286.4 respectively.

The Si2p peak presents interesting information as well. The Si2p peak can be decomposed in 5 components, every of them consisting of a Si doublet. The binding energies of these components are 101.45 eV, 101.85 eV, 100.9 eV. 100.4 eV and 102.4 eV. The Si bonding configuration of every of these components is not straightforward, but we will try to elucidate the origin of every component of the Si2p curve. In the literature each group assigns components differently, Riedl et al.²⁰ describe the component resulting from Si-C bonds is located at 100.6 eV and the component arising from Si bonded to H atom is at 100.9 eV, they also assign a single component for the buffer layer located at higher energy. Johansson et al. in its seminal work about photoelectron spectroscopy of SiC surfaces were able to decompose their Si2p peak of the (6V3×6V3)R30° surface in four different components. They assign two of them, 101.4 eV and 100.7 eV to silicon in bulk configuration and the other two located at lower energies, -1.16 eV and -0.39 eV respectively, to surface components. In our analysis we have a better agreement with the work of Johansson et al., as we also find two bulk components at similar energies, 100.9 eV and 102.4 eV. However we find components at higher energies that we assign to surface-related silicon. We must emphasize, again, that to the best of our knowledge there is not a standard assignment of XPS components for the Si2p peak of G/SiC(0001) due to the complexity of the system and due to the difference in resolution between the different experimental setups used by the different authors.



Figure 3 14: **a.** XPS spectrum of the C1s peak of G/SiC sample annealed at 1400K recorded at a photon energy of 400eV. **b**. XPS Spectrum of the Si2p peak of G/SiC sample annealed at 1400K recorded with a photon energy of 150eV.

It is important to notice that the surface stoichiometry changes very fast at these high temperatures. In a very narrow gap of temperatures the surface reconstruction changes very much and, as far as we know, there is not a clear consensus on the role of the duration of the annealing. As an example of this fast changes in the SiC in this temperature range we present the consecutive μ -LEED patterns of one sample annealed at different temperatures. As we see in **Figure 3 15** the LEED pattern of the electron-illuminated region changes critically in a temperature range of only 50K. For this high temperature annealing it seems that the partial pressure just on the vicinities of the surface results very important.



Figure 3 15: μ -LEED pattern of the surface annealed at slightly different temperatures, showing great variation in a small temperature range.

We have also characterized the clean SLG/SiC(0001) surface by means of LEEM measurements. This instrument is extremely useful in order to characterize graphenic systems as it can easily measure the precise number of graphene layers appearing onto the SiC surface or, in the case of graphene on metal systems, it results and appropriate tool for measuring the crystallographic angle between graphene and substrate ⁴⁷. For graphene grown on SiC it was found that the electron reflectivity curve shows a nice oscillation behavior with the kinetic energy of the impinging electrons and as a function of the number of graphene layers ⁴⁵. In Figure 3 **16 c** we present curves corresponding to three different domains appearing on the sample after annealing at 1525K. An image serving as an example of the typical LEEM measurements is presented in Figure 3 16 a. Three different contrasts can be distinguished at this energy and at some energies two of the contrasts might look very similar. It is important to notice that the system reflectivity is severely dependent on the electron energy. To ease the visualization of the figure we have marked every of these contrasts by enclosing them in colored polygons. Thus, we have three regions: the red, the blue, and the grey ones. In order to know to which structures we can correlate these domains we need to perform a LEEM I(V) measurement and measure the reflectivity (brightness) of every domain depending on the electron energy. This is what is shown in Figure 3 16 c where three different reflectivity trends are clearly resolved. It is possible to relate the number of minima with the number of graphene layers and thus the blue domains would correspond to bilayer graphene, the red domains to (6v3x6v3)R30° and the white dominating background can be correlated with single layer graphene, with partial coverage for 1525K in good agreement with the previous literature ⁴⁸. Thus we can conclude that after annealing at1525K around 60% of the sample is SLG, 20% BLG and 20% buffer layer.



Figure 3 16: a & b. LEEM image of a sample annealed at 1525K where three different contrasts are visible when using 5eV electrons for imaging. The right side presents the same image where the different contrasts have been highlighted for ease the visualization. c. Reflectivity curves for the colored regions in the images showing a correlation between the number of minima and the number of stacked graphene layers. 2x2μm².

At last, we have also performed theoretical calculations of the substrate in order to fully characterize to the atomic scale the system. However the full determination of the exact atomic positions by means of DFT results very difficult to determine due to the high number of atoms involved in the unit cell. Up to the date there have been several attempts to perform this

calculation and several strategies have been explored ^{49 31}. Some works in order to reduce the number computational efforts have modeled the system through a smaller unit cell (for example (5x5) ²⁸ or (3x3) ²⁵) or by including atomic-scale defects ³². Up to our knowledge most theoretical approaches realized up to now lack of full reliability when confronted with experimental results – although the most important features are correctly described. Only very recently, some convincing results related to the growth process have been performed concluding that SiC(0001) act as a template for graphene growth ²⁶. Moreover the full energy landscape of the different reconstructions up to the trilayer was calculated ⁵⁰.

In our calculations we have relaxed a full (6V3x6V3)R30° unit cell by two independent methods. First though the use of the efficient localized basis set FIREBALL code, second using a clever approach in order not to obtain spurious solutions of local energy minima. The main results are presented in Figure 3 17 where the three projections of the relaxed unit cell together with a simulated STM image are presented. The relaxed structure corresponds to a graphene-like layer covalently bound to the topmost Si layer acting as a buffer layer. This layer is highly corrugated with a buckling of 1.2 Å and its electronic properties are far from those of freestanding graphene. On top of this we have a completely flat graphene layer which is the SLG. The STM simulations do not reproduce the underlying dangling bonds, but they correctly reproduce the (6x6) periodicity. The mean distance between buffer layer and SLG is 3.3 Å and the corrugation of the graphene layer is negligible. However, these results should be treated with caution, evermore when they include a large number of atoms. We can see them as a starting point for the understanding of the material and future more precise calculations.



Figure 3 17: Theoretical schematically presented model of SLG/SiC(0001). a. Lateral side of the unit cell. b. Lateral side of the unit cell. c. Top view of the unit cell. The periodicity corresponds with the one of (6v3x6v3)R30° reconstruction. d. Preliminary results on the simulation of the STM image of the unit cell depicted c. e. Perspective view of the unit cell of the SLG/SiC(0001). Due to time-economy considerations in the DFT calculations only four SiC slabs have been introduced. The lower part of the slab is saturated with atomic H.

This structure can be seen as the basis for multilayer graphene. The second –and subsequent- layers of graphene are going to stay on top of the previous at a mean distance of around $3,4\text{\AA}^{50}$.

d. <u>BLG/SiC(0001)</u>

It was as soon as 1998 when people noticed that heteroepitaxial graphite could be successfully grown on 6H-SiC(0001)⁵¹. However, it was not until the characterization of the products resulting from the mechanical exfoliation of HOPG samples in 2004 that multilayer graphenic system on SiC focused the attention of the surface science community. Since that, the multilayer graphene on SiC system has been characterized through means of different techniques such as ARPES.STM.LEED I(V).LEEM...²⁰ (see for instance the cross-sectional high-resolution transmission electron microscopy observations of Norimatsu and Kusunoki ⁵²). Usual experiments. involving samples annealed at temperatures in the range 1400-1800K, present coexistence of stacking with different number of layers. Atomic scale microscopy investigations reveal that it is very difficult -if not impossible- to obtain samples where only SLG or BLG exists. Some advances have been performed in the quality of the number of layers by annealing the samples in furnaces with atmospheric Ar atmospheres, but even thought, the most usual result is coexistence of different stacking, as an example of this the surface of **Figure 3 16** where SLG and BLG coexist. Because the intrinsic difficulties in measuring the temperatures in this range it is not a clear consensus on the exact temperature needed for every superstructure. However, there is a clear correlation between the higher annealing temperatures and the coverage of more than one graphene laver. For instance Huang et al. describe monolayer to occur at 1475K, bilayer at 1525K and trilayer at 1575K⁵³.

We have also noticed the coexistence of several reconstructions on a single sample. In **Figure 3 18** we present LEEM images of a sample annealed at 1525K showing the same region under illumination with different electron energies. As we have already discussed in the previous section bilayer graphene has a double minima reflectivity curve and it corresponds to the dark regions in the images at 2eV and 5eV or the bright regions in the 3.5 eV image (see **Figure 3 16**). It is important to notice that at energies above 7eV it results very difficult to distinguish bilayer from monolayer domains.



Figure 3 18: Selected frames of the LEEM I(V) video where islands of bilayer graphene are clearly spotted in 2 eV and 5eV as dark regions and at 3.5 as bright regions. $1.5 \times 1.5 \mu m^2$.

We have also characterized BLG by means of STM. Its appearance when scanned with STM conserves the quasi-(6x6) periodicity and the honeycomb atomic scale lattice. The main difference is the absence of underlying protrusions from the buffer layer. The typical dangling bonds that dominate when scanning at bias far from the Fermi level are not longer observed in BLG. This effect is most likely due to electronic screening of these states by two graphene layers above them. In Figure 3 19 we present atomically resolved STM images of bilayer and trilayer graphene. In the bilayer image we see an atomic-scale defect which promotes the apparition of the typical (V3xV3)R30° intervalley interference pattern in good agreement with previous literature ⁴⁰. The trilayer graphene, on the other hand, can be easily distinguished because it no longer conserves the quasi-(6x6) superperiodicity. Its electron density appears puzzled and amorphous. It has been described that the atomic honeycomb structure is no longer appearing and that instead the hexagonal atomic symmetry is observed, as for HOPG ⁵⁴. We actually observe this hexagonal behavior in our atomically

resolved images, however we remark that these observations are very dependent on the tip termination, and thus can be an artifact. For instance BLG theoretically should express the hexagonal symmetry, and some experimental works confirmed it, but the actual consensus states that BLG can express both atomic symmetries –hexagonal and honeycomb.



Figure 3 19: STM images of multilayer graphene on SiC(0001). **a.** Bilayer graphene where subsurface buffer layer structure is not visible but the Moiré-like long range pseudoperiodicity is still conserved. An atomic scale defect- probably involving two pentagons- is spotted in the center-left of the image. 10x10 nm², -1100mV. **b**. A region with small corrugation of graphene is clearly visible and probably consisting of 3 -or more- layers of stacked graphene, 10x10 nm², -100mV.

3.2. H/G/6H-SiC(0001) deposited at 300K

Atomic hydrogen is the simplest possible adsorbate that one can imagine. We have studied its adsorption on the graphene surface. The usual experiment involves the graphitization of the SiC sample, its characterization by means of LEED and XPS prior to deposition, the atomic hydrogen dose -typically 1×10^{-8} mbar during 10 min- by using an H-cracker and keeping the sample at room temperature and after all this processes the H/G/SiC characterization.

In 2006 it was experimentally discovered that atomic hydrogen attaches to graphite (HOPG) in the form of dimers and small clusters ^{55 56 57}, some years later researchers also noticed that a similar behavior appears when hydrogen is adsorbed on single layer graphene on SiC ⁵⁸ ⁵⁹. Theoretical calculations concluded that the most estable adsorption site of an individual H atom on the graphene network is covalently bound on top. However, it appears forming small adsorbate structures with defined geometry. The most common structure, according to these works, are small dimers predominantly appearing on the high areas of the quasi-(6x6) reconstruction. This behavior can be contrasted with that of H adsorbates on G/Ir(111) or G/Pt(100) where the hydrogen tends to form higher order clusters following the graphene Moiré as a template ⁶⁰ ⁶¹. Moreover it has also been described intercalation processes with hydrogen passivating the Si dangling bonds within the (6v3x6v3)R30° reconstruction beneath graphene and yielding to buffer layer elimination ¹⁸ ²⁹ ⁶². Under this mechanism the buffer laver becomes SLG and the BLG reconverts to BLG. Yet, there is not a clear understanding on the factors that influence the competition between the hydrogen adsorption and the hydrogen intercalation.

From a theoretical point of view the H/G system has been widely studied. From this perspective H chemisorbs on top of a carbon atom within the mesh and breaks the sp² original hibridization towards a sp³ orbital arrangement. Several aspects of the system have been theoretically investigated ⁶³ ⁶⁴ ⁶⁵ ⁶⁶ ⁶⁷ ⁶⁸, as full hydrogenation (graphane: a 2D hydrocarbon ⁶⁹), the combination with nitrogen adsorbates ⁷⁰ and the colossal enhancement of spin-orbit coupling ⁷¹. Even though the theoretical attempts to understand the interplay between hydrogen adsorption and hydrogen intercalation on 6H-SiC(0001) ²⁵, the role of hydrogen on G/SiC is still an open question.

In Figure 3 20 we show large area STM images of atomic hydrogen adsorbates on graphene. In these images we observe two different coexisting substrates, at the right part of both images we observe a rougher substrate where the graphene lattice is visible but the underlying structure is still distinguishable and the underlying protrusions are spotted in the graphene region (see Figure 3 20 b). We conclude that the surface on the right part of the images correspond to SLG. On the other hand, the left side of both images has a smoother surface, which still conserves the quasi-(6x6) periodicity. The graphene lattice can also be resolved and therefore we estimate this structure to be BLG. Interestingly the hydrogen adsorbates are spotted on both surfaces. This is an expected result as small adsorbates (also referred in the literature as hydrogen clusters) were first reported onto HOPG ^{55 56}, and therefore nothing could make us to foresee that they would not be observed in BLG. Still, it can be seen that the number of Hinduced protrusions on BLG are less than on SLG indicating that the sticking coefficient changes as the number of layers increase. Unfortunately, we do not have sufficient experimental results to quantify the sticking coefficients on every layer.



Figure 3 20: STM images of the H/G/SiC system in a region where bilayer(top-left) and single layer(bottom-right) graphene coexist. H binds to both reconstructions with a similar sticking factor. a. V=-0.6V, I=1nA, 40x40nm² .b. V=-0.2V, I=1nA, 20x18nm². A double color scale is used for this image where both terraces (upper and lower) correspond to different color scales. This image treatment was performed to ease the visualization of the atomic resolution in both surfaces.

These clusters are chemisorbed structures and thus the bonding between the hydrogen and the carbon atom underneath is very strong. However this interaction is not as strong as one should expect for a purely chemisorbed system, as the structures can be easily removed under STM scanning. Mild tunneling conditions -voltages near the Fermi level and small currents- are required to preserve the adsorbates during the scanning. This effect can also be used on purpose, as it was noticed by P. Sessi et al. 72, and nanopatterning can be achieved by using controlled voltage pulses of bias higher/lower than 3V/-3V (although this values strongly depend on the tip). In Figure 3 21 we present two consecutive images of the same region before (a) and after (b) a controlled voltage pulse. The upper left region of the presented graphene region was previously pulsed at high voltages and that is the reason why it looks clean of hydrogen adsorbates. We realized a 4V pulse on the position marked with a white arrow in the Figure 3 21 a image and we can see in the Figure 3 21 b a region of ≈25nm diameter where the adsorbates are no longer present. The diameter of the inducedevaporation area is directly proportional to the voltage used for the pulse, in good agreement with the previous bibliography 72 .

This experiment promotes the question of where are these adsorbates going. There is not a clear answer, up to our knowledge, about this point, but some hypothesis can be presented. The most direct one could be that hydrogen gets trapped by the tip as it has been described for many other adsorbates that disappear during STM imaging. Functionalizing tips, by attaching different molecular, and atomic, species to its apex, is a well known process that has been described for many systems. Due to the volatile nature of atomic hydrogen and upon comparison with some previous experimental ⁵⁵ and theoretical results ⁶⁶, a possible scenario could be the tip-induced molecular formation of H₂.



Figure 3 21: Consecutive STM images of a region of H/G/SiC. **a**. The white arrow marked with a V indicates the place where a voltage pulse of 4 V was performed, V=2.2V, I=1nA, 80x80nm². **b**. In this image we obseve that the voltage pulse has generated a region clean of atomic adsorbates on the surface V=2.2V, I=1nA, 80x80nm².

Medium scale images, as the one presented in **Figure 3 22**, reveal some intrinsic characteristics of the hydrogen adsorbates. The size and shape of most of them, although is not homogeneous, reveal that only a limited number of atomic scale structures are present in the surface. The graphene regions near these structures exhibit the characteristic electronic ($\sqrt{3}x\sqrt{3}$)R30° periodicity of intervalley scattering. The mean height of the adsorbates is around 1.7Å, as extracted from a histogram analysis. The clusters seem randomly distributed, either isolated or forming higher order 2D-structures, without any clear indication of what drives the clustering process. In **Figure 3 22** there are no less than 350 clusters occupying around 15% of the total area.



Figure 3 22: STM image of hydrogen adsorbates on SLG where some identifiable structures seems to be repeated. More than 350 clusters are shown occupying 15% of the total area. V=-0.1V, I=1nA, 40x26nm²

In order to determine the most stable adsorption geometries we have recrded high resolution STM images (see Figure 3 23 a). We observe that only a limited number of atomic scale structures are present, more precisely we can divide the configurations into: small dimers, large dimers, ovaloids, trimers and monomers. In Figure 3 23 b we have marked all these structures by enclosing them within colored geometrical lines. Thus the small dimers are marked with green rectangles, large dimers with red rectangles, ovaloids with white ellipses, trimers with yellow triangles and monomers are marked with purple circles. It is very interesting to note that we have atomic resolution on the graphene lattice and the main crystallographic directions are easily distinguished. The $[11\overline{2}0]$ is along the vertical direction of the image. Using this direction as a basis we observe that the three equivalent possible orientations for the small dimers (0°, 60° and 120°) are observed into the same image. Similar argument applies for trimers and large dimers. This analysis is not so easy to perform on ovaloids, as the structures seem somehow affected by the scanning direction (horizontal) and they appear distorted in the images.



Figure 3 23: High resolution STM images of hydrogen adsorbates on SLG forming small clusters. **a**. V=-0.3V, I=1nA, 12x12nm².**b**. Image where the atomic graphene grid has been superimposed and the clusters have been classified by a color code.

The resolution in **Figure 3 23** is so nice that we have tried to determine the exact atomic position of all the atoms in the graphene substrate lattice. This is shown in **Figure 3 23 b** as a small overprinted white honeycomb lattice. The exact positioning of this lattice is a very difficult task as drift effects, as well as other image deformations, leads to a situation where the distances are non-homogeneously distorted in the different directions of the surface and in the different parts of the image. This has been done by identifying the hollow position of every ring and by distorting the three different directions of the honeycomb lattice with different correction parameters. We shall remark that we have placed manually many atoms, in order to fully determine the adsorption geometries of the hydrogen clusters with unprecedented resolution.

In **Figure 3 24** we present a smaller STM image where only two of the small dimers are present and the graphene lattice is clearly resolved. Again in the contiguous image we have placed the graphene atomic grid and an ansatz of where the hydrogen atoms might be atomically positioned –provided that we assume chemisorption on top of C atoms. In the following we will constrain our analysis to the determination of the exact atomic structure of these small dimers. There are three main reasons for this decision: First, because this structure is the most commonly observed during our experiments. Second, because the full determination through comparison with theoretical calculations of all the other structures would demand very computational-costly efforts, and we just focused on one of them to study the basic concepts of hydrogen chemisorption. And third, because among all the clusters, small dimers are the simplest ones (i.e. smallest structures with internal structure).

The small dimers present two asymmetrical lobes with a mean apparent height of 1.4Å. The distance between the maxima of both lobes is 3.2Å. At a first sight, they consist of two hydrogen atoms adsorbed on top of opposed C atoms of a particular ring, but this interpretation could be very naïve, and further DFT investigations are needed to understand the experimental data.



Figure 3 24: High resolution STM images of hydrogen small dimers on SLG.
a. V=-0.3V, I=1nA, 3.8x3.8nm².b. Image where the atomic graphene grid has been superimposed and a simple interpretation of where the hydrogen atoms might be chemisorbed have been superimposed

To fully understand the system we have performed DFT calculations of the different possible theoretical absorption geometries. These configurations are presented in **Figure 3 25** where three different pairs are schematically represented and named according to the usual nomenclature. Thus, the first neighbor pairs are usually called ortho-dimers (marked in white), the third neighbor pairs are called para-dimers (marked in green), and the, less described fifth neighbors, we named the short-duo (marked in blue). The crystallographic interatomic distances are: ortho 1.42Å, para 2.84Å, short duo 4.26Å, to be compared with our experimental value of 3.2 Å. Obviously we have disregarded other options –such as meta-dimers, or second neighbor configuration- which do not present an orientation according to the experimental observations.



Figure 3 25: Ball-and-stick model of the discussed dimer configurations: ortho-dimers (marked in white), para-dimers (marked in green), and short-duo (marked in blue). The theoretical distances are: ortho 1.42Å, para 2.84Å, short duo 4.26Å, to be compared with our experimental value of 3.2 Å between lobes maxima.

In Figure 3 26 we present simulated STM images of the three described configurations. To ease the comparison we have also presented an experimental image and a modified experimental image with the substrate atomic grid overprinted. These simulations are performed using simple SLG as a substrate and with no buffer layer. This decision was taken in order to speed the calculations and because the role of the underlying buffer layer is not fully understood but believed to be secondary (the distance is about 3.3Å, see Figure 3 17). As we can see the in the simulated images, the paradimer looks very different from the other two. This structure does not present a deep in between the two hydrogen positions and only one single lobe is resolved. This is true for most theoretical scanning conditions (placing the tip closer to the surface and different bias voltages). On the other hand the short-duo and the ortho configurations do present a minimum and an asymmetrical configuration, which is in good agreement with the experimental input. The difference between them is indeed very small and comparison with the experimental data is convincing for any of the two configurations. The energy values for these configurations are -1.4 eV for ortho and -1.1 eV for short duo, indicating an energetic preference towards the ortho configuration.



Figure 3 26: Simulated STM images for the different proposed theoretical configurations of the hydrogen dimers together with experimental images (with and without grid) for comparison.

Simple optical comparison between experimental and simulated STM images does not clarify the atomic nature of the hydrogen dimers. We have performed a profile analysis. The main results are presented in **Figure 3 27** where the theoretical profiles are presented together with the experimental results. Upon this analysis the short duo configuration looks closer to the experimental result than the para-dimer, but this comparison must be taken with caution as both, the height and the x-y positioning, have absolute errors bigger than the difference between both structures.

Importantly, the experimental result appears broader than any of the proposed configurations and this yields us to the question of whether is a tip effect or a intrinsic property of the hydrogen adsorbates on graphene. For this purpose we have separated the contribution to the density of states (DOS) of every of the C atoms of the substrate. These results are presented in **Figure 3 28**.On the left panel we show a comparison of DOS for the chemisorbed H, its first neighbor carbon, C₁, and its three equivalent second neighbor carbon, C₂. It comes as a surprise that, at the voltages used in the experiment, the main contribution to the STM image comes in fact from C₂ followed by C₁ and only marginally from H. Therefore the

chemisorption of a single hydrogen produces in experimental STM images intrinsically extended features of several Å of diameter, difficulting the determination of the precise position of the H atoms.



Figure 3 27: Profile analysis of the different theoretical structures together with the experimental value.



Figure 3 28: Local density of states projected on a single chemisorbed H and its first and second carbon neighbors (C₁ and C₂)
In conclusion we present STM images with unprecedented resolution of the hydrogen adsorbed structures that appear onto SLG upon atomic hydrogen exposition. We combined the experimental results with theoretical calculations to fully determine the exact adsorption geometries of the most often found short dimers. However, calculations show that the STM images present important electronic effects, extended to the vicinity of the adsorbed adatom. This system is intrinsically complex to be described through STM simulations and energy calculations, and it is difficult to discriminate between theoretical structures.

The high resolution XPS spectrum of the C1s peak of a highly graphitized sample gives some insights into the chemical modification of the system upon hydrogen deposition. In **Figure 3 29** we present the C1s peak of the same surface before and after hydrogen exposition (2 min, $4x10^{-7}$ mbar). We observe that the chemical configuration is altered as the maxima of the peak slightly decreases in intensity and get shifted towards lower binding energies. The small energy shift ($\approx 0,1 \text{ eV}$) can be correlated to a small charge transfer process, the graphene layer gets slightly reduced by the H adsorption. On the other hand we also observe the shoulder located around 290 eV to decrease. This region corresponds to the components assigned to the Si-C bonds in surface coordination (see **Figure 3 14**). Upon H adsorption and intercalation the surface components are modified and hence the intensity in this energy region decreases.



Figure 3 29: Synchrotron based XPS spectra of a sample prior and after hydrogen deposition.

3.3. C₆₀/G/6H-SiC(0001)

Mechanical stability, friction, or adhesion are among the physical properties that strongly depend on the strength of van der Waals (vdW) interactions. This is also true for the nanoscale. The nucleation and growth of molecular surface structures involve dynamic processes such as diffusion, molecular rotations, or conformational changes, which rely also on vdW intermolecular interactions ⁷³ ⁷⁴. Moreover, self-assembly and adsorption studies focus on determining the preferred adsorption site and configuration, the adsorbate-adsorbate interaction, and the distance between the adsorbate and substrate (e.g., Ref. ⁷⁵). There is an increasing interest in the role of vdW interactions of organic molecules on graphite and other surfaces ⁷⁶.

Generally, long-distance forces as vdW are not described by the most widely used DFT functional. Thus, in many of the works performed until now they are simply not included. However, when planar systems of carbon-based materials are in question, they require a different approach to the interplay between intermolecular (lateral) and adsorbate-substrate (vertical) interactions in determining the properties of ordered molecular structures. To evidence the important role of the vdW interactions in adsorption processes we have chosen a system of a very weakly interacting substrate and adsorbate, single-layer graphene (SLG) and fullerenes (C_{60})⁷⁷. The fact that both materials consist exclusively of carbon atoms arranged in an atomically thin planar mesh without H or any other atoms inside the atomic structure that could lead to long-range H-bond interactions makes this system a good prototype for a demonstration of the effect of these forces at a molecular level.

Thus, we consider the C₆₀ on SLG grown on 6H-SiC(0001)^{78 7 53} as a model system to test the strength of the vdW forces and mutual interactions that occur between neutral inert nanostructures. C₆₀ adsorbed on surfaces generally tend to form hexagonal close-packed arrangements⁷⁹ in order to optimize their lateral interactions. In very recent studies of C₆₀ molecules deposited on SLG epitaxially grown on metal ^{80 81}, it has been shown that the interaction between the molecules and the substrate, and consequently the molecular arrangement, is ruled by the Moiré unit cell. The C₆₀ coming to the surface are trapped in potential wells of the Moiré valleys where the substrate SLG is more reactive, thus forming pinning centers for the other molecules that arrange in between. In contrast to these studies, we found a much weaker interaction of the C₆₀ with the SLG grown on 6H-SiC(0001),

which lead us to a workbench to discuss the bonding mechanism in weakly interacting systems. Very recently a study of a very similar system appeared ⁸², which characterizes the basic behavior of the C_{60} on a graphene layer at 6H-SiC(0001) near to one monolayer coverage and studies its electronic properties based on scanning tunneling spectroscopy.

We employed a variable temperature scanning tunneling microscope (VT-STM) and DFT-vdW calculations ^{83 84 85} to prove that this system is solely governed by vdW forces. We determined the adsorption geometry of the molecules and we observed their collective motion. We also show that including vdW contribution in the calculations is necessary in order to fully describe theoretically the interaction between the sp^2 systems. To compare *in-situ* the interactions of fullerenes (C₆₀) with SLG and with the (6x6) we intentionally kept the SLG coverage below 1 ML, which resulted in a coexistence of SLG with the quasi-(6x6) and quasi-(5x5) reconstructions.

Behavior of C_{60} molecules deposited on the surface at room temperature has some noteworthy aspects. Absence of C_{60} on the SLG layers at room temperature is a clear indication that the molecules on the quasi-(6x6) are in a lower energy configuration than on SLG. The **Figure 3 30 a** shows C_{60} molecules that literally escaped from SLG to the quasi-(6x6) at room temperature. Consequently these C_{60} remained trapped in a form of stable planar dendritic islands with the highest concentration of the molecules around the step edges, similarly to other studies ^{86 87}. On the other hand, the depositions performed at 40K permit the perfectly ordered islands of C_{60} form on the SLG (**Figure 3 30 b**), most likely because the C_{60} are unable to cross the diffusion barrier at the SLG boundaries.

On the contrary, when we evaporate C_{60} on the sample kept at a low temperature of 40 K (LT), STM images show the formation of C_{60} epitaxial structures on SLG in the form of well-ordered planar islands with a twofold symmetry. **Figure 3 31 a** and **b** show the STM topography of islands on both types of surfaces and adsorbed molecules in detail.



Figure 3 30: STM topography images of C_{60} deposited on a mixture of SiC(0001) phases at a) room temperature, with the C_{60} islands exclusively on the quasi-(6x6) phase and b) at 40 K with C_{60} islands forming also on SLG. The molecules adopt higher order on the SLG compared to the molecules on (6x6). Both images have 30x30 nm² and were taken at 1.5V bias voltage and 100 pA tunnelling current

At first glance the properties of the C₆₀ islands on quasi-(6x6) (**Figure 3 31 b**) are very similar to the ones reported before at RT ⁸⁶ ⁸⁷. The molecules inside the island are present in various orientations. Different molecular orbitals (MO) are exposed to the probe during scanning. The internal electronic structure appearing in the STM images of C₆₀ has been extensively studied and it relates the aspect of the fullerene with the orientation. Normally the bright lobes within the molecule appear on the pentagons of the C₆₀ molecule. In the C₆₀ islands on quasi-(6x6) the molecules seem randomly orientated (see **Figure 3 31 b**, and **Figure 3 32**). Their corrugation is 0.45 Å rms and the base apparent height is 7.2(±0.5) Å. On larger scales, two quasiperiodic arrangements could be found corresponding to a pair of twin domains appearing at ±20° (with 1° error) with respect to (6x6). The measured orientation matrix respect the substrate is: $\begin{pmatrix} 12 & 2 \\ -2 & 10 \end{pmatrix}$

On the other hand, the C_{60} islands on SLG in **Figure 3 31 a** show lower corrugation (0.28 Å rms), a considerably denser packing, and an almost perfect intramolecular order. According to the FFT power spectrum of the STM image in the inset of **Figure 3 31 a**, the C_{60} molecules arrange in a (4x4) commensurate superstructure with respect to the SLG lattice. As a rule, the

islands are hexagonally shaped with edge angles of 120°, which is an expected kind of behavior, since it has been already observed in the first layer of C_{60} on highly oriented pyrolitic graphite ⁸⁸. The profile analysis of the islands gives an apparent height of 8.8(±0.3) Å and interestingly does not show medium-scale corrugation that could be expected due to the underlying quasi-(6x6) corrugation of the SLG.



Figure 3 31: Three-dimensional (3D) representation of 20x20 nm² empty states STM topography on C₆₀ islands and their corresponding profiles.
a.SLG at 600mV, 100pA, with a 5x5 nm² detail and FFT power spectrum of the entire area showing a clear 4x4 pattern of the close-packed arrangement of the molecules on SLG. b.(6x6)-SiC(0001) recorded at 1000mV, 100pA and a 5x5 nm² detail and FFT power spectrum of the entire area. Both images were obtained at 40K.

The detail in the inset of **Figure 3 31 a** shows submolecular resolution, which suggests the adsorbed molecules on SLG are all equally oriented. The intramolecular structure of each C_{60} consists of two bright lobes that shall correspond to their MO, which may be considered as a fingerprint for their orientation ^{79 89 90}. However, in our case, the MO contrast is slightly varying between subsequent STM images. **Figure 3 32** evidences changes of the probe itself and prevents us from directly relating the observed contrast to

any expected MO of C₆₀ molecules previously reported ^{79 89 90}. To unambiguously determine the correct orientation of the molecules on the surface based on these data, we have to assume a C₆₀ being picked up by the reactive metallic tip apex before the acquisition of the images, since this process is commonplace, especially in LT STM sessions—e.g. Refs. ⁹¹ and ⁹². Therefore, the observed STM contrast on the MO is most likely influenced by imaging of a C₆₀ by another C₆₀ adsorbed on the tip apex.



Figure 3 32: Consecutive STM images where different contrasts are obtained for the same molecular layer. a. Metallic tip. b. Probably a C_{60} tip. The white circle marks a reference to ease the visualization.

Consequently, the most important questions that arise from the experiment are about (i) the detailed role of the vdW in the well-ordered 4 \times 4 C₆₀/SLG system and (ii) the orientation of the C₆₀ with respect to the SLG lattice.

We performed extensive DFT-vdW calculations in order to understand the role of the vdW in stabilizing this structure. Several groups have developed DFT-based calculations including the vdW interaction ⁸³ ⁹³ ⁹⁴ ⁹⁵. Here we use the LCAO- S^2 previously applied to SLG and graphene-like materials ⁸⁴ ⁸³. In this formalism, we consider two contributions. The first arises from the small overlaps between the electronic wave functions of the C₆₀ and the SLG, leading to an electronic repulsion, and the second, which is the vdW interaction itself, is due to oscillating dipoles in both interacting systems. These two contributions are treated in perturbation theory from a DFT calculation using the FIREBALL code ⁸⁵. This method takes into account particularly the π - π interactions since the corresponding overlaps are the

dominant effect in this weakly interacting system. The underlying SiC buffer layer was neglected, since the expected energy contribution to the C_{60} total energy due to the vdW interaction is at least an order of magnitude lower than the contribution due to the presence of SLG, considering the large separation of SLG and the buffer layer ⁹⁶.

In the calculations we considered more than 20 different adsorption geometries of C_{60} /SLG in a 4x4 periodicity. These calculations have confirmed that the energetically most favorable structures are indeed those with a high symmetry. To discriminate the contribution of the vdW forces in the global structure, we made DFT calculations with and without incorporation of the vdW forces. The most stable structures among all the probed adsorption sites and molecular orientations are presented in **Table 3 1**.

C ₆₀ orientation	6:6/30°	6:6/0°	Hex/0°	Hex/30°
SLG adsorption site	Hollow	Hollow	Adatom	Dimer
d _{DFT} (Å)	3.4	3.3	3.5	3.6
E _{DFT} (eV)	-0.006	-0.006	-0.004	-0.004
d _{vdW} (Å)	2.7	2.7	2.9	2.9
E _{c60-c60} (eV)	-0.880	-0.871	-0.680	-0.645
E _{c60-SLG} (eV)	-1.007	-1.010	-1.019	-1.016
E _{vdW} (eV)	-1.887	-1.881	-1.696	-1.659
ΔE_{vdW} (eV)	0.000	+0.006	+0.189	+0.226

Table 3 1: Total energy values per C_{60} for the various orientations in a 4x4 SLG supercell, with and without considering vdW interactions (E_{vdW} and E_{DFT}) and the associated equilibrium distances d_{vdW} and d_{DFT} . E_{vdW} is the sum of two contributions: the cohesion energy between the C_{60} molecules, $E_{C60-C60}$, and the interaction energy between a C_{60} and the SLG substrate, $E_{C60-SLG}$. The structure with the lowest energy value is taken as a reference for calculation of the relative total energy.

The molecular orientations are labeled by a C_{60} feature exposed to the surface and the angle of rotation around the *z* axis (perpendicular to the surface plane) with respect to the diagonal of a (1x1) unit cell of SLG (see **Figure 3 33**). Thus, the 6:6/0° orientation corresponds to an adsorption of a C_{60} by a dimer shared between two adjacent hexagons parallel to a C-C

bond in SLG; the 6:6/30° is identical to the 6:6/0° rotated by 30° around the z axis; hex/0° is a hexagon aligned with the SLG hexagons, etc. There are three possible adsorption sites of high symmetry on the SLG: on top of a C atom (adatom), in the center of a hexagon (hollow), and above the center of a C-C bond (dimer). The same nomenclature is used here for both the orientation of C₆₀ on SLG as for the orientation of the C₆₀ on the metallic tip used for the STM simulation (see **Figure 3 35**).

In **Table 3 1** we see that the lowest total energy (E_{vdw}) structure calculated including the vdW interaction is the 6:6/30° in a hollow site of SLG, which is used as the reference value for the relative energy of adsorption (E_{vdW}). The closest structure in terms of energy is the $6:6/0^{\circ}$, also in a hollow site, with a total energy higher by 6.44 meV/ C_{60} . Taking into account that the experiments were performed at 40 K, the thermal energy is about 3 meV, which is approximately half of the difference between the two most favorable structures. Consequently, the system at 40 K should prefer the hollow6:6/30° adsorption geometry over the hollow 6:6/0°. The rest of the structures present values of the total energy that are much larger, indicating the strong influence of the C₆₀ orientation with respect to each other in the value on the vdW interaction. Remarkably, the main difference in the total energy comes from the molecule-molecule interactions ($E_{C60-C60}$) rather than from the interaction with the surface ($E_{C60-SLG}$), which is only slightly modified when the molecule is placed with a different orientation. As the $E_{C60-C60}$ differs for each adsorption orientation, it has the ultimate role in the final value of the E_{vdW} . Charge transfer from the surface to a C₆₀ is negligible, amounting to ≈ 0.03 electrons/C₆₀, which has been suggested recently⁸².

Interestingly, when we perform the total energy calculations without the vdW interactions (E_{DFT}), all four structures present about the same energy (with differences less than 3 meV/C₆₀) and therefore the orientation of the molecules in the islands on the surface would not have any particular preference under our experimental conditions. The introduction of the vdW interaction results in a considerable reduction of the C₆₀-SLG distance (d_{vdW} compared to d_{DFT}). That is a clear indication that the vdW interactions cannot be neglected in any similar system.



Figure 3 33: Set of the most energetically favorable model structures for C_{60} adsorptionon graphene. Black: Hex/0° Adatom. Green: 6:6/0° Hollow. Red: Hex/0° Dimer. Blue: 6:6/30° Hollow

Aware that the total energy difference between $6:6/30^{\circ}$ and $6:6:/0^{\circ}$ is very small, we performed STM simulations for these adsorption geometries to elucidate which is the structure observed experimentally ⁹⁷. A set of 60 tips consisting of a pyramid of 35 metal atoms and a C₆₀ molecule attached to the apex in various geometries has been used as a probe over both candidates. The calculated images were carefully compared to the experimental images with varying contrast. We found the agreement only for the structures based on the 6:6/30° orientation, as in the example in Figure 3 35, where the best agreement is obtained for the 6:6/30° imaged with appropriate orientations of the C_{60} on the tip apex. The couples of bright lobes in the images systematically correspond to a pair of pentagons linked by a dimer between two hexagons, which is crucial to decide the mutual orientation of the molecules in the 4x4 structure. The calculated images are all similar to an image produced by a simple metallic tip, somewhat modified by the effect of the MO of a rotated C_{60} on the tip. Considering the high probability of having a C_{60} on the tip apex leads us to inevitably conclude that any spectroscopic information obtained by scanning tunneling spectroscopy on this system can be significantly distorted. In particular, the width of the gap between the highest occupied and lowest unoccupied states of a C_{60} is likely to be overestimated ⁸².

The resulting images were carefully compared with the experimental data for various types of submolecular contrasts over the most stable structure for the surface - the $6:6/30^{\circ}$. The corresponding tip models presented in our work are: $6:5/90^{\circ}$, $6:5/30^{\circ}$, atom/0°. From the identified positions of the C₆₀ it is possible to deduce that the movements of the C₆₀ on the apex have

rather a character of rolling around the axes perpendicular to the substrate. The bias of the STM simulation that reproduced the detailed features of the real STM topography was 1.0V. A purely metallic tip was also tried to simulate the images but it could not reproduce the variety of the observed features. The theoretical simulation is schematically represented in **Figure 3 34**. The comparison between simulated STM images and the experimentally obtained ones is presented in **Figure 3 35**.



Figure 3 34: Schematically representation of the best agreement model according to the experimental observations. The C_{60} molecules form a 4x4 ordered close-packed superstructure on top of SLG. A C_{60} molecule is attached to the scanning tip.



Figure 3 35: a. A reference molecule used for the generation of C_{60} orientations. The rotations around the axes x and z define the nomenclature of the orientation, respectively, e.g. 70-30. **b**. Simulation of STM images on the model structure (top part) using a C_{60} tip in various orientations compared and matched with the experimentally observed contrasts obtained on one C_{60} island on SLG.

So far, we have pointed out the dominance of vdW intermolecular attraction between the C_{60} molecules on SLG. Due to a distinct decay and strength of this force one can expect a qualitatively different dynamical behavior of the molecules in this system. Movement of a single molecule away from the islands is highly unfavorable, because it has to overcome the energy barrier created by the vdW interactions with the nearest neighbors, but it will likely occur along the edge of an island. We observed such a process and it was enhanced by interactions with the scanning tip. We successfully attempted to observe C₆₀ diffusion in an experiment by means of fast and reiterate scanning of the same region. We observed that the islands not pinned by defects (step edge, impurity, etc.) reveale a much faster mode of mass transport. Figure 3 36 shows a sequence of tipinduced changes undergone by an island consisting of 50 C₆₀ molecules. The observed area contains two pinned and thus rather stable islands A and C, plus a free and a very mobile island B which is apparently directed by the sense of the scanning, i.e., alternating upwards and downwards.

Importantly, the shape of A and C does not change strongly from one image to the next. That means the C_{60} migration along the island edges is slow and not many events are missed. A consequent interpretation of the movement of B is only possible by collective motion, as seen in the images between the time stamps 2:48 and 8:24, where both the shape of the island and the number of its molecules remain preserved. Island A serves only as a pivot point as B is changing its orientation with the substrate by 30° . By such rotation of the island, the unit cell is temporarily changed to $(V3xV3)R30^{\circ}$ C_{60} coincident with a 7 × 7 SLG. A diffusion barrier of a C_{60} /SLG is inherently very low and the attractive force between the C_{60} caused by the vdW interactions can reach over distances of several SLG unit cells. Consequently, in the absence of a strong site-specific bonding mechanism, the cohesion force between C_{60} molecules is the crucial factor in the stability of the islands.



Figure 3 36: Sequence of STM topographic images taken at 1500mV and 100pA on SLG with three islands of C_{60} . Islands A and C are pinned by a step edge and a surface defect respectively. The whole island B is undergoing

movements (marked by curved arrows) that apparently conserve the overall shape between 2:48 and 8:24. The movements of the island are apparently correlated with the direction of scanning (denoted by vertical arrows with horizontal bars).

In the sequence in the **Figure 3 37 a-c** we present some evidence of single C_{60} diffusion along the island step edges. Most likely the molecules are migrating along the island boundaries as it was imaged in the **Figure 3 37 d**. The image shows only one half of a fullerene, repeatedly appearing above the edge of an island. The most likely interpretation of this effect is a movement of the C_{60} caused by the scanning probe, since the position and movements of the mobile molecule are correlated with the position and scanning direction of the probe. Logically a molecule in the corner position is less bound to the island and is more prone to movement. This mechanism leads to a gradual change of the island shape during the imaging, but may also occur spontaneously.



Figure 3 37: a-c. $12x12 \text{ nm}^2$ STM topography sequence showing transport of C_{60} molecules one-by-one. **d**. Movement of one C_{60} along the island boundary (white arrow) caught in one $11x7nm^2$ image scanned from the bottom to the top (black arrow). All data taken at 600mV bias voltage and 100pA tunnelling current.

In conclusion, the C₆₀/SLG behaves as a prototype of a decoupled adsorbate system governed by vdW forces. Our results show that the orientation of the molecule within the structure plays a major role in the total energy evaluation. The collective movement of small molecular islands demonstrates the dominant role of the vdW interactions in this system and the decoupling of the C₆₀ from the substrate. The agreement of the experimental observation with the total energy and STM image calculations indicates the need for including vdW to account for the weak interactions in sp^2 compounds.

3.4. Conclusions

In this chapter we have studied by means of surface science techniques the different structures that appear onto the 6H-SiC(0001) surface. Form the silicon-rich (3x3) reconstruction and $(\sqrt{3}x\sqrt{3})R30^{\circ}$ structures to the carbon-rich (6 $\sqrt{3}x6\sqrt{3})R30^{\circ}$, graphene, and multilayer graphitic structures. For this purpose we have made use of high resolution STM images, XPS spectra, LEED and LEEM analysis, AFM, and theoretical calculations.

Graphene grows on top of a buffer layer in large terraces and in coexistence with $(6\sqrt{3}x6\sqrt{3})R30^\circ$ regions and BLG terraces. The graphene produced by this method conserves its electronic properties very close to that of freestanding graphene. We have taken profit of this situation to investigate the adsorption mechanisms of two different adsorbates on quasi free standing graphene – as opposed of G/metals where the underlying substrate normally plays a role.

In order to rationalize the substrate-adsorbate interaction we have chosen the two extreme and simple cases: a strongly interacting adsorbate ,atomic hydrogen, and a weakly interacting adsorbate, fullerenes.

Atomic hydrogen on graphene forms small clusters of a reduced number of atoms chemisorbed on top of carbon atoms of the graphene lattice. This chemisorption breaks the hybridization of the graphene carbon atoms from the original sp^2 towards sp^3 , inducing electronic states in the first and second neighbors of the hydrogenated carbon atom.

The atomic clusters, although chemisorbed, are very weakly bounded to the graphene surface and can be very easily evaporated under tip-induced desorption by highly interacting scanning conditions or voltage pulses.

On the other hand, the carbon pure C_{60} molecules deposited onto graphene at room temperature tend to escape from the graphene terraces and diffuse towards the, more reactive, $(6\sqrt{3}x6\sqrt{3})R30^{\circ}$ regions, where they get anchored forming a structure with translational order but with molecular disorder. When C_{60} is deposited at 40K close-packed molecular islands are observed onto graphene in a 4x4 superstructure. DFT calculations show that the molecules are adsorbed on a hollow site by dimer separating two hexagons. Observation of collective movements of fullerene islands and single molecules around the island edges points out the weak coupling to the substrate. DFT calculations indicate that the main energetic terms are due to van der Waals interactions.

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General conclusions

This thesis aims to unravel the atomic scale structures appearing on epitaxial graphene systems and to understand the stable atomic-scale configurations of sp² carbon structures appearing on the surface on single crystal samples. For this purpose we have made use of two independent substrates, the silicon carbide (SiC) hexagonal surface and the Pt(111) surface. Both of them are suitable for growing epitaxial graphene, but the growth methodology differs for each surface. Epitaxial growth on SiC(0001) surface is successfully achieved by annealing the samples at temperatures around 1550K. Annealing above this temperature results in multilayer growth. This material contains a significant amount of carbon and no external precursors are needed for graphene nucleation or growth. On the other hand Pt(111) surface needs temperatures around 1100K and an external source of carbon in order to catalyze the growth of graphene. This can be done either by using carbon containing molecular precursors or by surface segregation of embedded carbon in the bulk. In the present thesis only the molecular precursor methodology was studied. Under this methodology the total graphene coverage can be controlled by regulating the amount of precursors deposited on the surface.

Graphene on Pt(111) grows forming islands with several orientations and sizes. Every of these orientations forms a different superstructure known as Moiré pattern. We have investigated from an experimental point of view the stable Moiré superstructures on Pt(111) and analyzed all the possible Moiré superstructures in the G/Pt(111) system with the help of a geometrical model. The model predicts the existence of 22 preferred graphene orientations forming 15 different Moiré superstructures. The model predictions are in good agreement with the experimental observations and the existing scientific literature. Among all the possible Moirés we have performed a combined theoretical-experimental exhaustive characterization of the two smallest reconstructions, this is $(\sqrt{3}x\sqrt{3})R30^{\circ}$ and $(\sqrt{7}x\sqrt{7})R19^{\circ}$, and found that the former can be explained in terms of an ordered vacancy network in the outermost Pt layer and graphene relatively strongly bound to it, while the latter is described as a van der Waals mediated flat sheath on top of the Pt(111) surface.

Covalently bound graphene-Pt(111) edges have an important role in the determination of stable orientations. The bonding region between carbon and Pt normally forms crystalline one-dimensional heterostructures that are the nucleation seed for graphene growth. We have found that graphene tends to end in a zig-zag configuration. On the $(\sqrt{7}x\sqrt{7})R19^{\circ}$ -Pt the larger part of strain relaxation takes place on the Pt side of the heterostructure,

which forms a 1-D reconstruction. This atomic rearrangement induce the appearance of a 1D electronic state, which is exclusively confined in one of the two graphene sublattices.

OD,1D and 2D graphene defects are the preferred relaxing mechanism for the strain raised from mismatch accumulation in the Moiré superstructures on G/Pt(111). The OD defects include missing C atoms and inclusion of foreign atomic species into the graphene lattice as well as multiatomic rearrangements. The 1D defects include graphene-graphene pollycristalline borders and graphene-metal heterostructures. Finaly, the 2D defects are the formation of surface carbide clusters, graphene folds and nanobubbles.

Graphene on SiC(0001). We have grow and characterized quasi freestanding graphene on the buffer layer formed on SiC(0001). This surface presents exotic electronic behavior such as intervalley scattering near defects and tunneling transparency under bias voltages far from the Fermi level. We have made use of the G/SiC(0001) to test the reactivity of graphene upon deposition of adsorbates.

Hydrogen on G/SiC(0001) covalently bounds on top of carbon atoms belonging to the graphene lattice and break the hybridization of these surface atoms from the original sp² towards an sp³ orbital rearrangement. It chemisorbs on graphene forming dimers, trimers and small 2D clusters with geometrical configurations confined by the honeycomb lattice of the substrate. These adsorbates can be easily removed from the surface by annealing at relatively low temperatures (800K) or by simple STM or voltage pulses. Upon H adsorption the first and second carbon neighbors get electronically modified inducing the apparition of intrinsically extended features, making very difficult the exact determination of the atomic position of the chemisorbed H atoms. This system is a prototype of strong interacting graphene adsorbate.

 $C_{60}/G/SiC(0001)$ is a prototype of a weakly interacting adsorbates. The molecules deposited at 300K tend to escape from the graphene regions and end immobilized on the $(6\sqrt{3}x6\sqrt{3})R30^{\circ}$ terraces. When C_{60} is deposited at 40K hexagonal close-packed (4x4) fullerene islands are observed onto graphene. These molecules are very weakly bounded and are very mobile under STM experiments. DFT calculations show that the molecular islands are mainly bound by van der Waals interactions and reproduce the most stable adsorption site to be the molecules sitting on a hollow position of

graphene by a dimer separating two hexagons (of the C_{60} molecule) rotated 30° with respect to the crystallographic direction of graphene.

Conclusiones generales

Esta tesis tiene como objetivo estudiar las estructuras a escala atómica que aparecen en los sistemas de grafeno epitaxial asi como comprender las configuraciones estables de carbono sp² ocurrentes en superficies monocristalinas. Para ello se ha hecho uso de dos sustratos independientes. el carburo de silicio (SiC) y la superficie hexagonal Pt(111). Ambos son adecuados para el desarrollo de grafeno epitaxial, pero la metodología de crecimiento difiere para cada una de las superficies. El crecimiento epitaxial sobre carburo de silicio en la superficie (0001) se logra con éxito por el calentamiento de las muestras a temperaturas alrededor de 1550K . El calentamiento por encima de esta temperatura da como resultado el crecimiento de múltiples capas de grafeno. Este material contiene una cantidad significativa de carbono y no es necesario el uso de precursores externos para la nucleación o el crecimiento de grafeno. Por otro lado, Pt(111) necesita temperaturas de alrededor de 1100K y una fuente externa de carbono con el fin de catalizar el crecimiento de grafeno en su superficie. Esto se puede hacer ya sea mediante el uso del carbono contenido en precursores moleculares o por la segregación hacia la superficie del carbono embebido en el volumen del metal. En la presente tesis sólo se estudió la metodología que utiliza precursores moleculares. En esta metodología la cobertura total de grafeno puede ser controlada mediante la regulación de la cantidad de precursores depositados sobre la superficie.

El grafeno sobre Pt (111) crece formando islas con varias orientaciones. Cada una de estas orientaciones forma una superestructura diferente conocidas como Moiré. Estas estructuras aparecen por la interferencia electrónica entre el sustrato y la sobrecapa, y la corrugación observada combina efectos electrónicos y topográficos. Desde un punto de vista experimental, el número total de superestructuras Moiré sobre Pt(111) es difícil de determinar por lo que se ha hecho uso de un modelo original para predecir y analizar todas las posibles superestructuras Moiré que aparecen en el sistema G/Pt(111). El modelo se basa en la búsqueda de las posiciones de red con mejor coincidencia entre una hoja de grafeno girada en cualquier ángulo sobre la parte superior de una superficie de Pt(111). El modelo predice la existencia de 22 orientaciones preferentes de grafeno que forman 15 superestructuras Moiré distintas, esto se debe a que algunas simetrías internas hacen aparecer el mismo Moiré para dos ángulos diferentes. Las predicciones del modelo se encuentran en buen acuerdo con las observaciones experimentales y de la literatura científica existente. Entre todos los Moirés posibles hemos realizado una caracterización exhaustiva teórico-experimental de las dos reconstrucciones más pequeñas, que son (V3xV3) R30° y (V7xV7) R19°. La (V3xV3) R30° puede ser explicada en términos de una red de vacantes ordenadas en la capa más externa de la superficie de Pt y una capa de grafeno fuertemente unida a ella, mientras que (V7xV7) R19° se describe como una de red de grafeno plana en la parte superior de la superficie de Pt con una interacción mayormente mediada por fuerzas van der Waals.

Los bordes grafeno-Pt(111) covalentemente unidos tienen un papel importante en la determinación de las orientaciones estables . La región de enlace entre el carbono y Pt forma normalmente heteroestructuras unidimensionales cristalinas que representan las zonas de nucleación para el crecimiento de grafeno. Estos bordes también se pueden determinar a partir de nuestro modelo. Hemos encontrado que el grafeno tiende a terminar en zig-zag, esto también es cierto para la región de unión del grafeno con el Pt y, por lo tanto, la mayor parte de la relajación se lleva a cabo en el lado del Pt de la heteroestructura. Hemos llevado a cabo una caracterización completa de la heteroestructura ($\sqrt{7}$, $\sqrt{7}$) R19°-Pt mediante la comparación de imágenes de STM de alta resolución con cálculos DFT. Los resultados muestran que para esta interfaz en particular, la relajación tienen lugar en el lado del Pt mediante el reajuste de las posiciones de red del Pt y mediante la recolocación de los átomos de Pt exteriores del escalón muy lejos de sus posiciones originales. La caracterización electrónica trae un resultado inesperado: la aparición de un estado electrónico 1D en una de las dos subredes de grafeno.

Los defectos en grafeno de OD , 1D y 2D son el mecanismo de relajación preferido para la capa. Este estrés es debido a la acumulación de falta de coincidencia en las superestructuras Moiré de G/Pt(111). Los defectos OD pueden ser, entre otros, vacantes atómicas de carbono o la inclusión de especies atómicas extrañas en la red de grafeno, así como el reordenamientos de muchos átomos en una zona reducida de la red. Los defectos 1D incluyen bordes policristalinos grafeno-grafeno y heteroestructuras grafeno-metal. Y los defectos 2D incluyen carburos de superficie o los pliegues de grafeno como las nanoburbujas.

El grafeno sobre SiC(0001) se comporta como grafeno cuasi-libre y presenta un comportamiento electrónico muy exótico con efectos electrónicos tales como la dispersión entre valles cerca de defectos o la transparencia túnel bajo voltajes lejos del nivel de Fermi. Esta estructura normalmente coexiste con regiones con la reconstrucción (6V3x6V3)R30° y regiones de bicapa de grafeno en forma de terrazas con tamaños entre 10 y 100nm. La superestructura (6V3x6V3)R30° consiste en una capa de carbono

con hibridación sp² en panal de abeja con algunos de sus átomos unidos covalentemente a la fila superior de átomos de Si subyacentes. Esta estructura presenta una periodicidad cuasi-(6x6) si se investiga con STM y siempre está por debajo de las regiones de grafeno. Hemos hecho uso de la superficies G/SiC(0001) para probar la reactividad del grafeno con respecto a la deposición de adsorbatos sencillos.

El Hidrógeno sobre G/SiC(0001) se enlaza covalentemente sobre la parte superior de los átomos de carbono pertenecientes a la red de grafeno rompiendo su hibridación desde la sp² original hacia un reordenamiento orbital en configuración sp³. El hidrógeno se quimisorbe formando dímeros trímeros y pequeños clústeres bidimensionales sobre el grafeno cuyas configuraciones geométricas están confinados por el sustrato. Estos adsorbatos se pueden eliminar fácilmente de la superficie calentando a temperaturas relativamente bajas (800K) y mediante el uso de STM con pulsos de voltaje. Hemos estudiado desde una perspectiva teórica las geometrías de adsorción más estables para la menor de todas estas estructuras, el dímero, y hemos encontrado algunas dificultades intrínsecas para confrontar las imágenes de STM simuladas con las experimentales. La adsorción de hidrógeno modifica electrónicamente la estructura de los primeros y segundos vecinos, lo que difículta la determinación exacta de la posición atómica de los átomos sobre los cuales el hidrógeno está quimisorbido Este es un sistema prototipo de una interacción fuerte adsorbato-grafeno.

El C₆₀/**G**/**SiC(0001)** es un prototipo de sistema de adsorbatos débilmente interactuantes. Las moléculas depositadas a 300K tienden a escapar de las regiones de grafeno y acaban ancladas sobre las terrazas de(6V3x6V3)R30°. Cuando los C₆₀ se depositan a 40K se observan islas de fulerenos hexagonales sobre el grafeno. Estas moléculas están muy débiles unidas al substrato y resultan muy fáciles de mover con la punta del STM. Los cálculos DFT muestran que las islas moleculares están unidas exclusivamente por interacciones van der Waals. La geometría de adsorción de las moléculas se confirma computacionalmente sólo si las correcciones van der Waals se incluyen en el formalismo de cálculo. La interacción intermolecular y la orientación relativa de los fullerenos resulta ser un factor determinante en la determinación de la energía total del sistema.
Appendix

A.I- Graphene on TM(111)

Our studies about the stability of the graphene Moiré superstructures appearing on Pt(111) triggered our interest to know whether it is valid for other transition metal (TM) substrate. We have run calculations of our phenomenological model for all hexagonal surfaces of TMs for which epitaxial graphene has been reported. First we shall distinguish between the TM surfaces where multiphase graphene is formed from those who are supposed to hold just one Moiré structure. Pt(111), Pd(111), Ir(111), and Cu(111) are among the multiphase surfaces whereas Co(0001), Rh(111), and Ru(0001) are supposed to accommodate mainly one graphene superstructure ^{1 2}. Our model enables us to describe all the published Moiré patterns as coincidence structures between the graphene and the substrate lattices. We will discuss here only three of the multiphase examples (Pd, Ir and Ni). The rest are omitted for simplicity, although we have also calculated their stability plots and confirmed the validity of our model.

A.1.1. Pd(111)

Murata et al. ³ reported the existence of six Moirés for G/Pd(111) by means of LEEM measurements. The agreement between their measurements with our theoretical predictions is very good and, additionally, we foresee the existence of unreported phases. For reproducing them we used a Pd(111) first neighbour distance of 2.75Å and a cutoff of 23Å to obtain the following figures. Our model describes accurately all the superstructures reported on this work. There is just one exception: the ($\sqrt{21x}\sqrt{21}$)R11°, whose periodicity, crystallographic and apparent angle are 12 Å, 10° and 11°, respectively. However, we found a superstructure very similar to it, with a periodicity of 13.697 Å and Φ =8.95° (γ phase). The larger difference comes from the Ω value, which in our model is 0.002°.



Figure A 1: Figure caption. Stability plots for G/Pd(111). The structures marked with solid squares are found experimentally in ³.

A.1.2. Ir(111)

The paper of Loginova *et al.* ⁴ describes four superstructures at Φ 's 0°, 14°, 18.5°, 30°. The periodicities of the structures are 24Å, 7.4Å, 9,9Å and 5Å. We can identify those structures as τ G/Ir(111), γ G/Ir(111), β G/Ir(111), and α G/Ir(111). The last superstructure, the one at Φ =30°, exhibits in the STM an interesting phenomena. It presents a double Moiré contrast with a fine scale corrugation of 5Å at Ω =30° (α G/Ir(111), in our model) and a long scale corrugation of around 25Å forming a Moiré with an apparent angle Ω =10°. The long range periodicity is not described by our method at first

approximation. This double Moiré effect, which has only been observed for that particular reconstruction on Ir(111), shall be studied deeper as a particular case of higher order coincidence superstructures. We used as surface lattice parameter 2.75Å, and a cutoff of 23Å.



Figure A 2: Figure caption. Stability plots for G/Ir(111). The structures marked with solid squares are found experimentally in ref.⁴

A.1.3. Ni(111)

We compare our model with two different works. The one of Lahiri et al. ⁵ describes the G/Ni(111) system as multiphase graphene. They analyze a particular structure which is between two $(1x1)_G$ domains aligned with the Ni $[1\overline{10}]$ direction (note that $(1x1)_G$ is in our notation L=2.4Å, $\Phi=0^\circ$, $\Omega=0^\circ$).

Our model for G/Ni(111) with a first neighbour distance 2.49Å and a cutoff 23Å describes the existence of this structure as α G/Ni(111). In addition, the work of Murata et al.⁶ describes two Moiré superstructures with Φ 's 6.4° and 23°. The first Moiré has a periodicity of 22Å, whereas for the second one this value is not explicitly given (inspection of their STM images seems that it presents a larger periodicity). They could be assigned to ρ /Ni(111) and ρ /Ni(111), respectively



Figure A 3: Stability plots for G/Ni(111). The structures marked with solid squares are found experimentally in refs. ^{5 6}.

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A.II- SiC(0001) Si-rich structures

A.2.1. (3x3)/SiC(0001)

The first ordered reconstruction appearing on most hexagonal faces of SiC, and particularly on 6H-SiC(0001) surface, is the (3x3) reconstruction. This structure presents a Si-rich stoichiometry, and it is not always observed when preparation methodologies without Si evaporation are used. This superstructure was very early reported on 6H-SiC by Tanaka *et al.* in 1994¹ and first resolved by Kulakov *et al.* in 1996 in its pioneering STM work², where they successfully developed a recipe for its growth similar to the one used in this thesis. They determined the crystallographic surface unit cell by using a multitechnique approach³ (including holographic reconstruction from electron diffraction⁴). This model was later upgraded by Starke *et al.* and consists in a *chiral* surface, although this is not revealed under normal STM images. However this hererochirality is revealed under adsorption of some adsorbates –such as phthalocyanines-⁵.

Following the literature we have been able to successfully prepare and characterize this surface reconstruction by STM, LEED and XPS. Figure A 4 shows atomically resolved STM images of (3x3)/SiC(0001) surface. The morphology of the sample consist of small terraces divided by canyons 2 running through the sample. In the sequence of images surface shown in **Figure A 4** we were able to image sequentially smaller regions (every image corresponds to the zone marked with a white square on the image of its left) of the same part of the sample. In Figure A 4 c a hexagonal array of spherical protrusions of around 1nm width is resolved. Every of this protrusion corresponds to an atomic orbital (dangling bond) of a single Si atom. Checking the image carefully we see that there are a large number of defects in the form of darker protrusions or absence of them. These defective structures are due to local reduced electron density, possibly corresponding to missing Si adatoms or atomically (i.e. H or O_2) passivated dangling bonds ⁶(most likely from residual gas in the UHV chamber). Local spectroscopic studies of this surface reveal a bulk-related bandgap of 3.0 eV width and three electronic surface states located into it 7 .



Figure A 4: STM images showing the terrace morphology and atomically resolved images of the (3x3)/SiC(0001) reconstruction. The white square in a (b) corresponds to the region shown in b (c). a. 50x50 nm², 0.2nA, -3000mV. b. 25x25 nm², 0.2nA, -3000mV. c.10x10 nm², 0.2nA, -3000mV.

Figure A 5 shows the typical XPS spectra of the (3x3)/SiC(0001) surfaces. In the overview scan of the sample we exclusively observe C and Si signal after the cleaning process. This is important as the as-received sample contains a significant amount of oxygen that can be tracked by the presence of the O1s peak situated at 531 eV⁸. The three peaks correspond, from left to right, to C1s (283 eV), Si2s (152 eV) and Si2p (101 eV) respectively. The relative intensity between the C1s peak and Si2p (i.e C1s/Si2p) is 1.09 for this specific photon energy. In the C1s region spectra we observe that the peak is symmetric and centered in 283.1 eV in good agreement with the existing literature ⁸ ⁹. This means that only one kind of carbon appear on the sample and its energy corresponds to C in a carbide configuration, as the peak is shifted towards lower binding energy. We can attribute this component to a surface C-Si bond. The Si2p peak presents at least two components which can be assigned to Si in bulk configuration (101.0 eV) and surface shifted components (99.6 eV)⁶. It is also important to notice the absence of Si in SiO₂ bonding configuration whose spectroscopic fingerprint appears at a binding energy of 103.3 eV¹⁰.





The LEED pattern consists of a (1x1) diffraction pattern with 2 inner points per diagonal, indicating a (3x3) surface crystallography. It is strongly energy dependent but there are some electron energies where the fractional spots are strongly visible. In **Figure A 6** we show one of these patterns. The outer (1x1) points of the reconstruction have an intensity minimum while the pairs of diffractions spots appearing between these are in its maxima. An overall characteristic "circle-like" pattern appearing at electron energies around 80eV is a simple reference to know if the surface is well prepared or not.



Figure A 6: µLEED pattern of the (3x3) taken at electron energy of 80eV .The (1x1) dots are the faint and more external ones.

A.2.2. (V3xV3)R30°/SiC(0001)

Once the sample is cleaned and prepared with the (3x3) reconstruction higher annealing temperature induces Si depletion. This depletion changes the stoichiometry of the sample, and more precisely the C/Si ratio of the surface. Annealing the sample at 1400K (this temperature is strongly dependent on the measurement method) provoke the apparition of the ($\sqrt{3}x\sqrt{3}$)R30°/SiC(0001) surface reconstruction. This reconstruction was reported by Kaplan *et al.* from LEED observations ¹¹ although the first STM imaging experiments were performed by Owman *et al.* in 1995 ¹². Short after, an atomic model was proposed based on Si adatoms over T₄ sites of the surface lattice ¹³.

The STM images of this surface appear as a regular hexagonal lattice of protrusions with an unit cell of 5Å, in good agreement with the expected value of 5.3Å for the $(\sqrt{3}x\sqrt{3})R30^{\circ}$ reconstruction ¹². The surface appears more defective than the (3x3) one, and defects present more possible configurations and more irregularities than the single-atom defects of the (3x3) surface. In Figure A 7 a we show a large area image of the surface. Several holes and defective bumps are spotted in the scanned area. If we focus on the 10x10 nm² image in **Figure A 7 b** the individual protrusions can be easily distinguished but with an imaging effect that makes them appear as holes rather than bumps. This artifact is most likely due to some tip efect, such as an atomic or molecular adsorbate attached to the apex, although some authors have assigned it to a polarity effect ¹⁴. With this *inverted* contrast the atomic defects appear as holes in the hexagonal array. These defects form six-pointed star when single defect and eight-pointed ellipsoidal stars when two contiguous defects are spotted. The bright defective bumps do not show any regular conformation that may help to distinguish its atomic origin. A Mott-Hubbard state has been found with an energy inside the bulk gap after the STS studies of this surface reconstruction ¹⁵.



Figure A 7: STM image showing the (V3xV3)R30° reconstruction of the SiC(0001) surface. Several defects are visible in both images, indicating that the surface stoichiometry is lower in [Si] than the nominal value. a. Overview image with "normal" contrast, 25x25 nm², -3500mV. b. Detail image with inversed contrast, probably due to a tip effect, 10x10 nm², -3500mV.

The XPS spectrum of such surface is presented in **Figure A 8**. The C1s/Si2p ratio is 0.95, this is smaller than the ratio for the (3x3) reconstruction indicating a lower C concentration in the surface region. However we believe this is a naïve interpretation; if we compare the Si2p -appearing here at 101.3 eV- peaks of both reconstructions we can observe that the shoulder appearing at 99.6 eV has disappear in the ($\sqrt{3}x\sqrt{3}$)R30° spectrum indicating that there are no Si atoms in this configuration on the surface. These extra atoms are the Si depletion that we would expect from a higher temperature annealing. However this analysis has to be made with caution as the energy resolution obtained with the laboratory XPS using an Al K α anode is relatively poor and the 2 components of the Si 2p doublet are not resolved. Synchrotron-based photoelectron studies reveal a richer chemistry of the surface components of this reconstruction ¹⁶. Nevertheless our results are in good agreement with the previous literature ^{17 18 19}.





The picture of the LEED pattern of the $(\sqrt{3}x\sqrt{3})R30^{\circ}/SiC(0001)$ system is shown in **Figure A 9.**



Figure A 9: *LEED pattern of the* $(\sqrt{3}x\sqrt{3})R30^{\circ}/SiC(0001)$ *surface.*

The $(\sqrt{3}x\sqrt{3})R30^{\circ}$ is difficult to found isolated. Our experience shows that it exists a small range of temperatures. Therefore, very easily, when inspecting with LEED, we found that we annealed higher than expected and the $(6\sqrt{3}x6\sqrt{3})R30^{\circ}/SiC(0001)$ pattern appears. When these surfaces are inspected with STM we observe a panorama where both reconstructions are imaged at the same time. In **Figure A 10** we show one of these images where three atomically resolved different SiC reconstruction coexist after the same preparation. In this image we observe a dominating $(\sqrt{3}x\sqrt{3})R30^{\circ}$ structure coexisting with a $(6\sqrt{3}x6\sqrt{3})R30^{\circ}$ domain at the lower part. The borders of these domains are smooth and round-shaped. A small part of a quasi-(5x5) island appears in the top-left corner of the image. The fact that all the three reconstructions appear under the same preparation experimental conditions indicates that all the three are thermodynamically stable under this temperature annealing and must have similar formation energies.



Figure A 10: STM image where different reconstructions of the SiC(0001) coexist. In the upper-left corner an island of quasi-(5x5) reconstruction is found. In the middle region the (v3xv3)R30° reconstruction dominates, although lots of defects are spotted. On the lower part of the image an area with the (6v3x6v3)R30° reconstruction is found.50x50 nm², 2500mV.

In the main text we have already introduced the two reconstructions appearing in the **Figure A 10**: $(6\sqrt{3}x6\sqrt{3})R30^{\circ}$ and quasi-(5x5). These two surfaces have some characteristics in common and might even appear mixed between them

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A.III- C₆₀/(3x3)/SiC(0001)

This vdW governed behavior of $C_{60}/G/SiC$ results opposed to that of hydrogen adsorbates on SLG that we have discussed in a previous section, which is governed by the chemical bonding between H and C. Moreover, it also qualitatively differs with that of C_{60} molecules deposited on the Si-rich reconstructions of the 6H-SiC(0001). We have performed experiments to test the interaction between fullerenes and Si dangling bonds. For that purpose we have grown a (3x3)-SiC(0001) surface and deposited C_{60} onto it. This system was explored long time ago by Li *et al.* ¹ and more recently by Ovramenko *et al.* ². The first study focused on the monolayer regime while the latter restricted to the determination of the atomic configurations of the single C_{60} adsorbed onto a single dangling bond.

In Figure A 11 we present large scale STM images of C_{60} on (3x3)/SiC(0001). In these images we have obtained atomic resolution of the surface reconstruction presenting the characteristic hexagonal symmetry and on top of it spherical structures with an apparent diameter of 2.1nm and an apparent height of 9Å. These adsorbates can be directly correlated to single fullerene molecules. The adsorbates are scattered through the surface in a random configuration and normally being isolated, although small amorphous clusters of <10 molecules are also found. This behavior clearly reveals a strong substrate-adsorbate interaction driving the adsorption configuration of the C_{60} molecules and that the intermolecular cohesion energy becomes negligible. It is very probably that single C_{60} molecules are covalently bound to some of the dangling bonds of the surface adatoms. Our results are in good agreement with the experimental results, and more importantly, the DFT calculation of Ovramenko et al. However our observations reveal a preferential absorption on the step edges and defective regions which is not discussed in detail in the referenced work.



Figure A 11: STM images showing C₆₀ molecules adsorbed onto the Si-rich (3x3)/SiC surface. **a**. V=-3V, I=0.1nA, 75x75nm². **b**. V=-3V, I=0.2nA, 35x35nm².

We have also performed high resolution STM images. At first sight our submolecular resolution of a single C_{60} molecule – see Figure A 12- is surprising. As we have commented before, protrusions within fullerene molecules are normally attributed to electronic states excess due to pentagonal rings within the molecule, and thus the most common orientations yield to single protrusion (a pentagon upwards) double protrusions (6:6 bond looking upwards) or three-fold symmetry (an hexagon on top) structures. However the submolecular contrast obtained for $C_{60}/(3x3)/SiC(0001)$ is completely different to these results obtained for fullerenes deposited on metals. In Figure A 12 we see a single molecule where many protrusions are resolved within it. This contrast normally appears when depositing C₆₀ onto semiconductor surfaces, such as 7x7-Si(111)³, and more precisely when depositing these molecules on dangling bond covered reconstructions. We believe that charge transfer processes from the C_{60} molecule towards the surface –in order to passivate the highly reactive dangling bond- might be occurring on these C₆₀/semiconductor systems and resulting in MO reorganization and rehybridization within the adsorbates, and thus to the, rather rare, submolecular contrast.



Figure A 12: High resolution STM image of a single fullerene adsorbed onto (3x3)/SiC(0001) surface. V=-3V, I=0.1nA, 4x4nm².

In conclusion, $C_{60}/(3x3)/SiC(0001)$ experiments reveal that the dangling bonds are very reactive and tend to form covalent bonds with adsorbates. The pseudo-graphene layer covering the $(6\sqrt{3}x6\sqrt{3})R30^\circ$ structure prevents these bonds but still affect the adsorption geometry of the C_{60} molecules when they are deposited onto this surface. On the other hand, once we have SLG , the C_{60} molecules form a molecular 2D gas that can only be crystallized and experimentally observed by means of STM at low temperatures.

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A.IV- SiC in astrochemistry

Graphene etching on SiC grains as a path to interstellar polycyclic aromatic hydrocarbons formation

A.4.1.Abstract

Polycyclic-aromatic-hydrocarbons as well as other organic molecules appear among the most abundant observed species in interstellar space and are key molecules to understanding the prebiotic roots of life. However, their existence and abundance in space remain a puzzle. Here we present a new top-down route to form polycyclic-aromatichydrocarbons in large quantities in space. We show that aromatic species can be efficiently formed on the graphitized surface of the abundant silicon carbide stardust upon exposure to atomic hydrogen under pressure and temperature conditions analogous to those of the interstellar medium. To this aim, we mimic the circumstellar environment using ultrahigh vacuum chambers and investigated the SiC surface by in-situ advanced characterization techniques combined with first-principles molecular dynamics calculations. These results suggest that top-down routes are crucial to astrochemistry in order to explain the abundance of organic species and to uncover the origin of unidentified infrared emission features from advanced observations.

A.4.2.Introduction

The great advances experienced by radioastronomy during recent years have depicted the interstellar medium (ISM) and circumstellar envelopes (CSE) as supporting an active and rich chemistry ¹. In these cosmic regions, both simple molecules, such as H₂ or CO, and complex ones, such as C₆₀ and PAHs, are routinely detected by their characteristic IR spectrum ² ³. Advances in infrared spectroscopy, powered by space missions such as *ISO* and *Spitzer*, have revealed the existence of dust grains composed of silicates, SiC or oxides, among other substances, in such regions ^{4 5 6}. All this chemical complexity present in the ISM and in CSEs plays a major role in the evolution of galaxies, comets, the formation of planets and, ultimately, in the abiotic organic chemistry that preceded the origin of life on Earth ⁷.

PAHs contain up to 20% of the carbon in the Photodissociation Regions (PDRs)⁸, and are present in any region subjected to UV radiation⁹. However, despite being so ubiquitous and playing such a crucial role in several astrophysical processes and environments, their formation in the interstellar and circumstellar media remains poorly understood. Proposed chemical routes leading to the formation of complex polyaromatic molecules, and particularly to large PAHs, in space cannot account for their abundance and thus, efficient mechanisms for their formation are still an open issue. The main current theories invoke either combustion-like¹⁰ ¹¹ ¹².or UV-driven - acetylenic - polymerization and evaporation processes in most evolved objects^{13 14 15 16 17}. However, the efficiency of such processes is still unknown^{8 9 18} and during the last 30 years an important amount of work has been performed to determine PAHs origin and physicochemical properties.

Unfortunately, a complete carbon inventory is difficult to determine, as many other important molecules—such as carbon clusters (C_2 , C_3 , C_n), CH_4 and C_2H_4 , which could also be abundant in the inner regions of circumstellar envelopes—have not yet been quantitatively observed with sufficient detail. Within this context of chemical complexity in the ISM, new bottom-up assembling mechanisms based on concepts from nanotechnology have recently come into play. The catalytic role of interstellar dust grains in certain reactions has long been proposed; in their seminal work, Watson et al. ¹⁹ and later Hornekaer et al. ²⁰ studied the dust grains as the preferred sites for the formation of the most abundant molecule, H_2 .

In this article, we propose—and experimentally reproduce—an alternative and efficient mechanism based on a top-down approach for producing PAHs through the hydrogen processing of SiC dust grains, which is

schematically shown in Figure A 13. Such SiC grains are formed in the inner regions (1–5 R*, R* stellar Radius) of evolved stars by means of gas-phase condensation ¹⁴ ¹⁸. We show that in space, SiC crystallites possess a significant amount of segregated carbon on their surfaces, primarily organized as graphitic overlayers. These grains travel through the CSE due to the radiation pressure induced by the infrared photons of the central star, until they reach the cold external layers of the envelope. At this point (>5 R*) they are exposed to UV radiation. PAH emission has been observed to be prominent in PDR regions where most molecules are photodissociated and dust grains are processed ²⁸. Here, UV photons and H atoms produced by H₂ photodissociation further process the grain surfaces. We show experimentally that atomic H interaction at elevated temperature (1000-1300 K) on a graphene-terminated SiC surface, where graphene denotes a single layer of carbon atoms arranged in a honeycomb structure, triggers significant surface erosion even at low atomic H exposures. Thus, the graphene layer at the SiC crystallite surface is etched, leading to the formation of broken graphene flakes with sizes ranging from a few carbon rings to large graphene areas. This provides a method to inject PAHs and other PAH-related species into the gas phase.

The potential of surface science methodology to mimic and characterize the essential characteristics of complex problems concerning molecules on surfaces has been previously demonstrated by explaining, among others, the fundamentals of catalysis²¹ or the formation of H₂ on the stardust grains ²⁰. We simulate the conditions of interstellar space using UHV chambers equipped with *in-situ* atom-resolved Scanning Tunnelling Microscopy (STM) and 3rd generation synchrotron radiation-based X-ray photoemission-spectroscopy (XPS), among others. The experimental results are confirmed by *ab-initio* calculations. This theory-experiment combination provides a state-of-the-art morphological, structural and spectroscopic description about molecular interactions on SiC crystallites under CSE conditions. In addition, SiC has also been widely studied in condensed matter research and nowadays it is well accepted that all SiC crystalline structures are covered with graphene after annealing in vacuum^{22 23}.



Figure A 13: Qualitative sketch of the proposed model for a novel approach to the formation of interstellar PAHs and related molecules in the envelope of an evolved star. The process can be divided into four different stages. (1) Formation of SiC in the gas phase and condensation into micrometer and nanometer sized grains (T=2000K; 1-5 R*). (2) Annealing of the SiC dust grains due to the proximity of the star and the consequent promotion of surface C-rich phases and graphene (T=2000-1500K, 1-5 R*). (3) Exposure of the surface to atomic hydrogen, promoting graphitization of the C-rich surface and H passivation of the underlying buffer layer (T=1500-1200K; 5-20 R*). (4) Etching of the graphene by atomic hydrogen and thermally assisted desorption of PAHs (T=1200-1000K, 5-20 R*). Temperature values are taken from ref. 38. Lower row: typical temperature in laboratory experiments.

A.4.3. Results

Dust grains produced in Carbon-rich asymptotic giant branch stars are abundant in SiC crystallites ¹⁸. Their size can range from few nm in the proximities to the star to some μ m. Extra-solar particles of SiC as big as 5 μ m have been found in the interior of chondritic meteorites ^{24 25}. The most

common circumstellar SiC polytypes, as found in the Murchison meteorite are 3C-SiC (80%) and 2H-SiC (16%). The size of the SiC grains in the ISM is sufficiently large to present atomically reconstructed facets and their main chemical aspects can therefore be confidently simulated by the use of SiC single-crystals. We have used as an analogue to the dust grains a 6H-SiC(0001) single crystal, and the data were taken with a base pressure in the range of 10^{-11} mbar, similar to the conditions occurring in the densest regions of the ISM ²⁶ (see Supplementary Information).

Due to temperature-induced Si-sublimation and subsequent C-segregation, the surface of SiC crystallites is always graphitized after annealing at typical temperatures of the ISM depletion zone (**Figure A 13**). In the case of SiC(0001), the surface after annealing at 1500 K consists of a combination of atomically flat terraces partially covered with single layer graphene (SLG) (**Figure A 14 a**) and other areas with a carbonaceous termination consisting of a mixture of Si and C atoms in sp^2/sp^3 configuration ^{23 27} The graphene termination of different SiC specimens after being submitted to high temperature has been observed in different previous studies ^{22 23}.Therefore, we conclude that the ISM SiC grains also end with a graphene cover.

As the surface-graphitized SiC grains travel outward into the ISM they cool (1500–1000 K). During this trip, they are exposed to UV-photodissociated atomic H with an approximate impinging rate of $\approx 1 \times 10^{14}$ particles/cm² s. These are the conditions we use to simulate the process: a temperature of about 1200 K while exposing the surface to an approximate dose of 4 Langmuir (1 L= 10^{-6} mbar sec $\approx 10^{15}$ particles/cm² s) of atomic H. Figure A 14 b, d and e show STM images at different length scales with atomic resolution demonstrating that the graphene covered SiC surface has been strongly modified. The upper part of the image in Figure A 14 b still contains graphene whereas the lower region has been completely etched and roughens. In the etched part some remaining carbonaceous pieces can be observed (features in Figure A 14 d). To emphasize the erosion process, we show in Figure A 14 c a height profile of an etched surface after dosing the crystallite with atomic H and for comparison a height profile of an as grown surface. The peak to valley difference is about 3 Å, which is the size of an atomic step in the SiC surface, suggesting that a whole layer has been disrupted. It is clear that the corrugation of the profiles strongly increases after H dosing at high temperature, indicating a strong erosion of the carbon termination.

In general, upon H exposure at elevated temperature the surface tends to reorganize from sp^3 to sp^2 configuration ²⁷, leading to a cracked and

decoupled graphene layer from the SiC surface. **Figure A 14 d** shows some formed carbonaceous structures of different sizes remaining weakly bound to the surface. High-resolution images reveal some features that can be assigned to large PAHs (see **Figure A 14 e, f**). These features show a molecular orbital-like electronic density and a periodicity of about 2.4 Å between bright lobes ²⁸. This distance corresponds to the lattice constant of graphene, indicating that these structures consist of a concatenation of benzene rings. This situation leaves small patches of graphene weakly bound to a H-saturated substrate, ready to be ejected by thermal or photoexcitation processes. These molecules could be the origin of the recently proposed top-down interstellar carbon chemistry ²⁹ and the reason why SiC is abundant in evolved stars but normally gone in the ISM ³⁰.



Figure A 14: The surface of stardust SiC is strongly graphitized after formation at temperatures about 1500K and exposure to atomic H produces a strong erosion of this layer. a. 5×5 nm² STM image showing a graphene region V=100mV. The small mesh corresponds to the atomic honeycomb atomic lattice of graphene. b. The image shows at the upper side a graphene plane whereas at lower part the surface has strongly roughen. 40x40 nm² V=-100mV. c. Profile on STM images recorded before (blue) and

after (black) being exposed to atomic H with the surface kept at 1200K, taken along the dotted line indicated in. The total roughness (rms) of the surface increases from 0.22 to 0.69 Å. **b**, **d-f**. Series of STM images showing the graphene surface eroded after atomic H exposure at high temperature. **d**. 10×10 nm² STM image recorded on the most eroded part that shows the formation on the surface of small molecules and nanostructures. V=-200mV **e**, **f**. 2.2×4 nm² STM image zooming in on a detail of the surface showing protrusions corresponding to localized molecular orbitals of a PAH-like molecule. **e**. Overlaid optimized DFT model of a proposed PAH formed.

Figure A 15 a and b show some regions of the surface that have been heavily etched. Figure A 15 a displays the edge between the graphene part and the eroded one. The H erosion takes place through edges and defects of the graphene layer, leading to a highly modified edge. In other places of the sample we see that the graphene-cover is strongly shrunk to small patches, as seen in Figure A 15 a. Only graphene islands remains in the center of the image. The most likely scenario is that the original flake covered the whole upper terrace (left side of Figure A 15 a) and continued over another graphene layer into the lower terrace (right side of Figure A **15** a). The etching process has attacked the graphene in contact with the Hpassivated substrate, and the process has stopped at the step edge, where the overlayer becomes bilayer graphene (BLG). The flakes exhibit rounded smooth contours, and high-resolution images show heavily distorted electronic states at the edges, which could originate from passivation through hydrogenation of the edge atoms ³¹. The etching process has stopped at the step edge, where the overlayer becomes bilayer graphene (BLG) and it takes place mostly on the SLG. Thus, the presence of BLG can be considered as a protective film with respect to H attack ^{32 33}. This could be the reason why this process does not disrupt the whole SiC grain and the origin of the complex graphitic structures and PAH agglomerates also found in ISM dust ³⁴. These data picture a whole atomistic mechanism of the attack-process of epitaxial graphene SiC surfaces by atomic hydrogen.



Figure A 15: STM images after H dosing at 1100 K of G/SiC and computer simulation of the proposed etching process. **a**. $100x100 \text{ nm}^2$, -1100 mV. Wide view of a region where the graphene has been reduced to a stripe with rounded edges on the center of the image. On the right part of the image a region of bilayer graphene seems unaltered. The upper inset shows a highresolution image of a kink where SLG, BLG and the modified etched substrate coexist. **b**.STM image of a hole in the middle of a graphene terrace. These holes are observed after H treatment at high temperatures and they evidence etching through edges and defects. 70x70nm², -1.1V. c. Atomically resolved STM image of a subsurface trimer 2.5x2.5 nm², -400mV . d. Initial and final frames of the graphene surface extracted from a movie of DFT molecular dynamics calculations of the G/H/SiC system. The distance between graphene layers expand from 7% at room temperature to about 62% at 1000K, and finally, after 250 fs (MD time), the topmost layer disrupt in the form of small carbonaceous species. In this case benzene rings (blue oval), acetylene molecule (black oval), methylene radical (orange oval), or PAHs (red oval) can be identified.

The erosion mechanism can be understood and reproduced by firstprinciple calculations. Figure A 15 c shows 3 bumps identified by their apparent height as H atoms adsorbed on the lower basal plane of graphene, i.e., intercalated between the graphene and the SiC buffer layer. We have used this information to launch DFT based Molecular-Dynamics (MD) calculations at 1000K. Figure A 15 d shows that the graphene surface gets completely disrupted at this temperature exclusively if intercalated H is included, and we observe, as outcome, the formation of PAHs among other carbonaceous species. The hydrogen adsorbed on the basal plane induces sp^3 C hybridization, and decouples structurally the graphene from the surface. Thus, due to both H intercalation (the distance between graphene layers expand from 7% at room temperature to about 62% at 1000K) and temperature-induced anisotropic vibrations, the layer finally disrupts after 250 fs (MD time). Moreover, our calculations reproduce also the lower etching efficiency on the BLG, because the mobility of the SLG underneath. These disorganized PAH-related molecular structures, such as aliphatic, radicals, hydrogenated PAHs and PAH agglomerates, could account for unidentified infrared emission features 4 35 36.



Figure A 16: Synchrotron-based XPS spectra of C1s before (black curve) and after (red curve) H treatment (550L) at 1200K. Beneath the experimental data we show their decomposition into separate components. A decrease in the C peak of about 28% in the surface-related components indicates that those C-species have been etched away through H processing. The component appearing at 284.8 eV can be assigned to the graphene sp² configuration. The components located at lower binding energies (about 284.0 eV) are attributed to bulk carbides and the components at the lefthand side of the spectra to the buffer layer (between graphene and SiC). Photon energy: 400eV.

The above-proposed mechanism is based on topographical information obtained from high-resolution STM images and DFT calculations. In order to confirm them, and to acquire quantitative information, we explore the relevant chemistry by analyzing high-resolution synchrotron radiation XPS spectra before and after H exposures. The C1s core level peak gives an indication of the atomic density of C at the surface region of a sample and the particular electronic environment (i.e. bonding configuration)³⁷. Figure A 16 shows the C1s spectrum of the SiC before and after exposure to 550 L of atomic H at 1250 K. This peak can be decomposed into different components in good agreement with the scientific literature. The component appearing at 284.8 eV can be assigned to the graphene sp^2 configuration and is the biggest contribution to the C spectra (58.2% of the total), consistent with the area estimation from the STM topography. The components located at lower binding energies (about 284.0 eV) are attributed to bulk carbides and the components at the left-hand side of the spectra to the buffer layer ³⁷. Figure A 16 shows that the whole intensity of the C1s peak decreases upon H exposure treatment, indicating that there is about a 30% of carbon desorption, which left the surface with lower density than the original one. Although this number cannot be directly extrapolated to the CSE, the high efficiency of the presented erosion process makes these events highly probable to occur at the CSE regions.

A.4.4. Discussion

Surface science aims at studying highly controlled systems and tracing the influence of particular parameters in the final product. This approach has produced outstanding results in different fields, such as solid-state chemistry or catalysis ²¹. The environmental parameters in our simulation chambers, such as temperature, vacuum and gas composition, were as close as possible to the conditions occurring in the CSE. Of course, real CSEs have a much complex chemistry than the one gathered in our experimental ideal simulation chambers. Molecules such as H₂, CO, or C₂H₂ are present in the proximities of evolved carbon rich stars ³⁸ and electromagnetic radiations, covering large regions of the spectrum, have non-negligible intensities in the vicinities of the stars. These parameters might play a role in the formation of PAHs. However, in the case of the mechanism that we are proposing the role of radiation and small molecules is not so important. First, because graphene absorbs electromagnetic radiation through excitation of vibrational phonon modes, which later decay through radiation emission. This process does not alter the intrinsic properties of graphene ³⁹. Second because graphene is inert to most of the molecules present in the CSE, such as H_2 , CO, C_2H_2 , etc. We have performed exactly the same experiment using H_2 instead of atomic H and no etching (not even molecular hydrogen adsorption) has taken place. We have obtained exactly the same STM images as for the clean SiC surface (**Figure A 14 a**).

This accurate methodology allows us to test the influence of many parameters in the processes. Our simulation experiments and calculations indicate that the size of the resulting PAHs strongly depends on the hydrogen concentration and the formation temperature. If atomic hydrogen is included in the system and temperature is much lower than 900K, we just have adsorption of H on the surface. If the temperature exceeds 1500K we have new graphene formation at the surface as it is etched away. To have efficient graphene erosion a temperature in the 900-1200 K range and high doses of atomic hydrogen are required. Thus, in our experiment performed in UHV chambers we have been able to mimic the most important conditions for SiC dust grains in the CSE, and this kind of research opens the door to use UHV-model systems to understand the precise role of co-absorption of molecules, other than hydrogen, and radiation in dust processing mechanisms.

SiC is produced close to the evolved star as small sized nanoparticles (few nm) and it has been proven that the crystallization rates of SiC grains can be very fast ($\approx \mu$ m/h) at high temperatures ¹⁸. In our experiment we have used single-crystal surfaces to simulate the process, and one could think that the surface chemical properties of large extended crystals and nanoparticles are completely different. However this is not the case. Just a few crystallographic unit-cells (about 5 nm) are required for recovering the bulk electronic structure of SiC. There are several high-resolution TEM studies using SiC nanoparticles revealing that the graphitization process takes place efficiently upon high temperature annealing ⁴⁰ ⁴¹ all around the SiC nanoparticle ²². Therefore our single crystal approach can be seen as a suitable atomic scale description of the astrochemical processes taking place on the surface of both, micrometer and nanometer sized, SiC grains populating the CSE.

The usual size of PAHs in the ISM is estimated to be in the range of hundreds of C atoms, in good agreement with the one that we have indentified in **Figure A 14 d**, which has around 180 C atoms. Although, **Figure A 15 d** might give the erroneous impression that only small PAHs can be produced, we would like to remark that the PAH formed by our proposed mechanism can be quite large. This misleading idea is due to the

reduced number of atoms that can be handled into the complex ab-initio MD calculations we have performed. Moreover, one might think that the etching process will last forever, cracking the formed PAHs into smaller and smaller pieces as time goes on. This is not the case because of three reasons: i) The efficiency of the process is strongly dependent on the underlying interface, as it is shown in the DFT calculated movies. In other words the graphene etching takes place efficiently because it is supported on a SiC grain . ii) The hydrogen concentration and the temperature decrease as the PAH travel outwards in the CSE, and then the etching becomes less and less efficient, as we have mentioned above .iii) The smaller PAHs have less probability of interacting with the atomic hydrogen, and a higher hydrogen adsorption energy. This means that the smaller the PAH, the bigger is the hydrogen absorption energy in the ISM (see DFT calculations. Therefore graphene etching in the CSE is a self-limiting process yielding to significantly large PAHs.

Finally, based on these experiments, we should not expect ISM PAHs to have the classic/identifiable structures previously considered. Mixtures of PAHs, aromatic-aliphatic molecules and hyperhydrogenated PAHs molecules have been proposed to account for the astronomical IR observations. All these aromatic chemical species can be produced out of the above-presented processing mechanism of the SiC dust ⁴². We are aware that in our experiments we observe the surface of the SiC grains instead of the produced PAHs. However, the latter is difficult as *a priori* our mechanism does not favor a particular size of the produced species and a global increase in mass detection experiments can just be expected.

In conclusion we propose an alternative PAH top-down formation mechanism through graphene etching on the surface of SiC dust grains at ISM. This model is supported by a combination of different state-of-the-art experimental techniques with advanced computational methods. The good match between the available astrochemical information and the advanced surface science experimental methodology suggests that the problems of the former can be successfully understood through the techniques of the latter, and opens the door to the investigation and modelization of other processes related to dust particles in ISM.
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